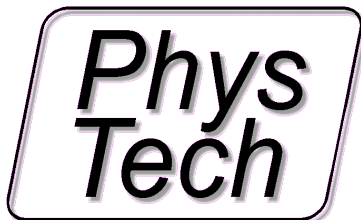


High Energy Resolution Analysis

Deep Level Transient Spectroscopy

FT 1230 HERA DLTS System

Dr. Ludwig Cohausz
Phystech GmbH
Moosburg
Germany



What is DLTS

What is needed for DLTS measurements

How to analyse the measurement results

DLTS evaluations of the FT1230 DLTS system

Correlation DLTS

Fourier DLTS

Laplace DLTS

Deconvolution DLTS

Special measurement possibilities

Isothermal timeconstant scan

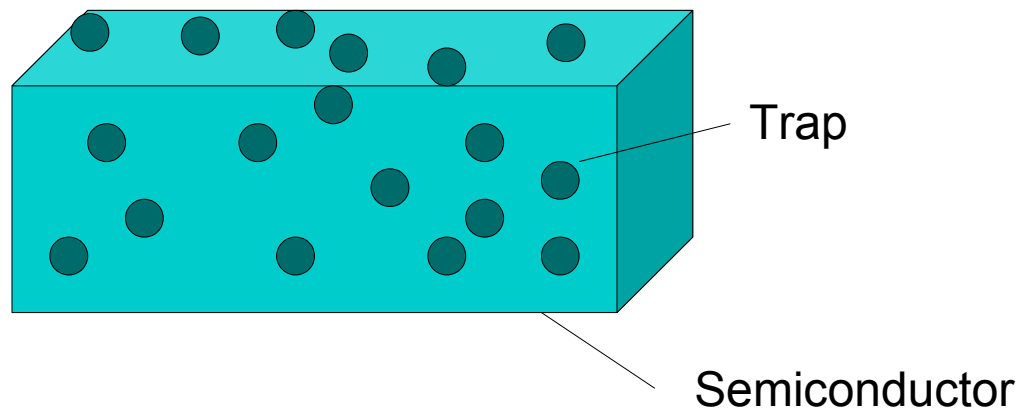
Direct capture measurements

We are looking at a semiconductor crystal with electric active atoms so called traps.

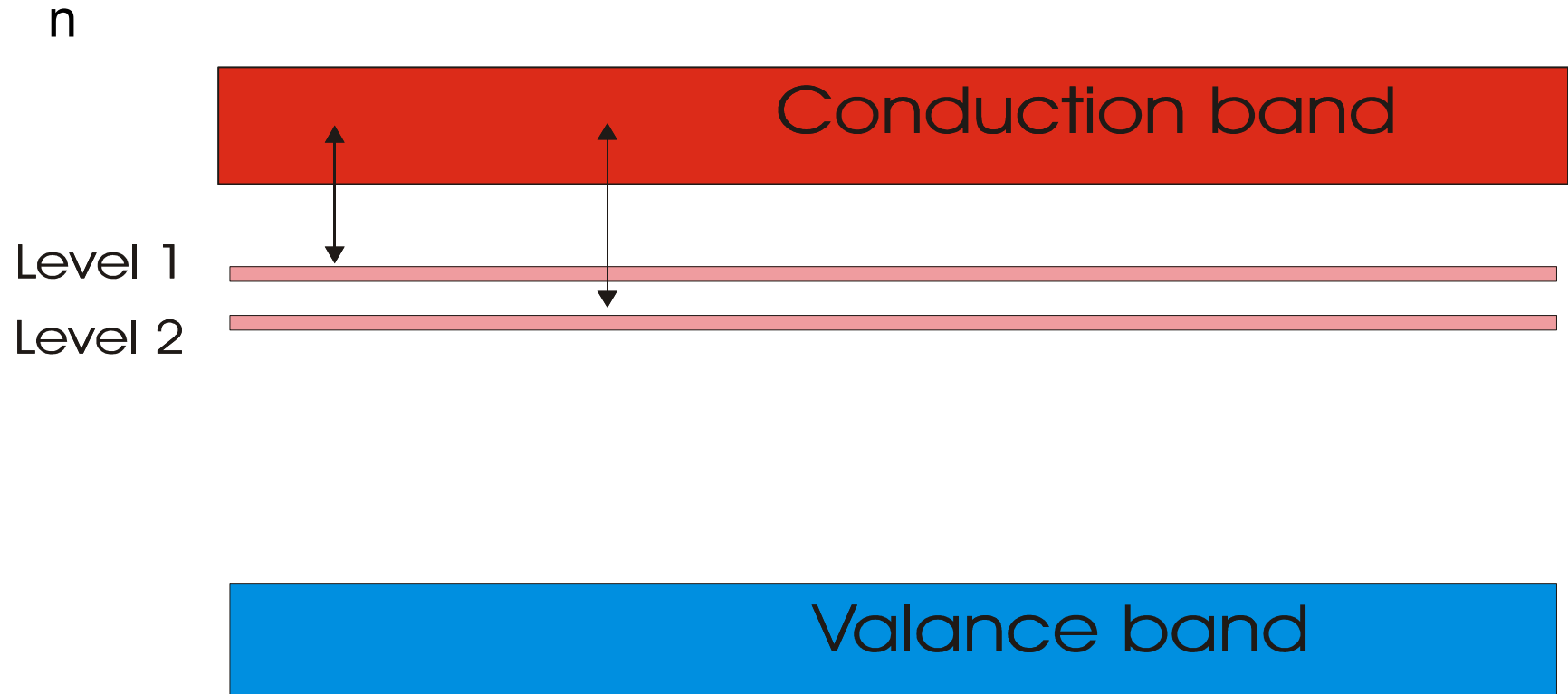
These are what we want to analyse

We want to know:

1. The total no. Traps, the trap concentration
2. The kind of the trap material,
3. The trap distribution



Band structure



1 level ; $n \gg p$; $n \gg N$

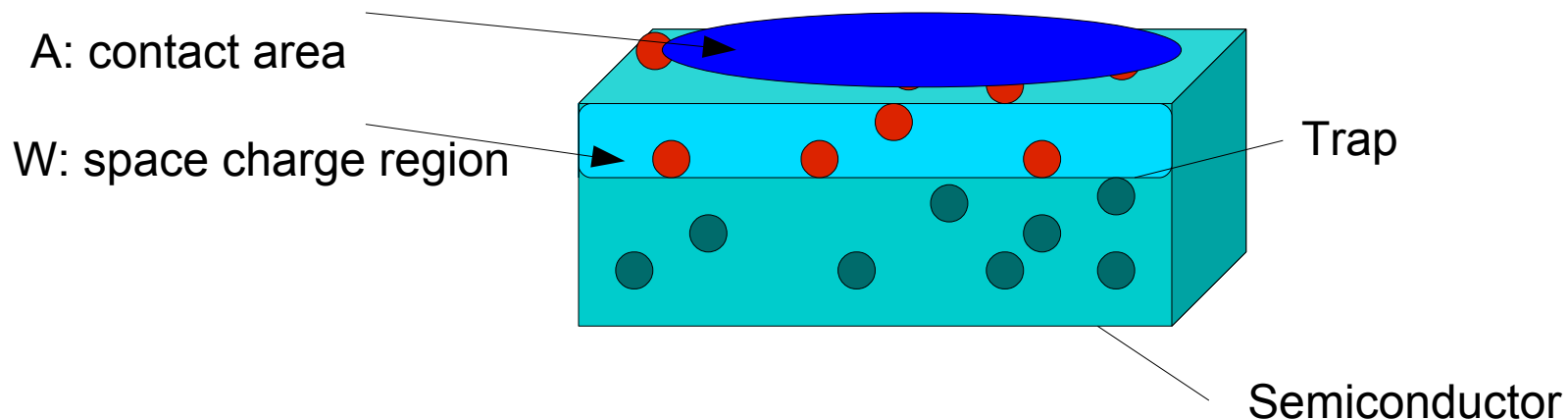
$$n_1 = N_T \exp(-t/\tau) \quad \tau = \sigma_T X_T \exp(-\Delta H_T / kT),$$

$$\ln(\tau) = \ln(\sigma_T X_T) - \Delta H_T / kT,$$

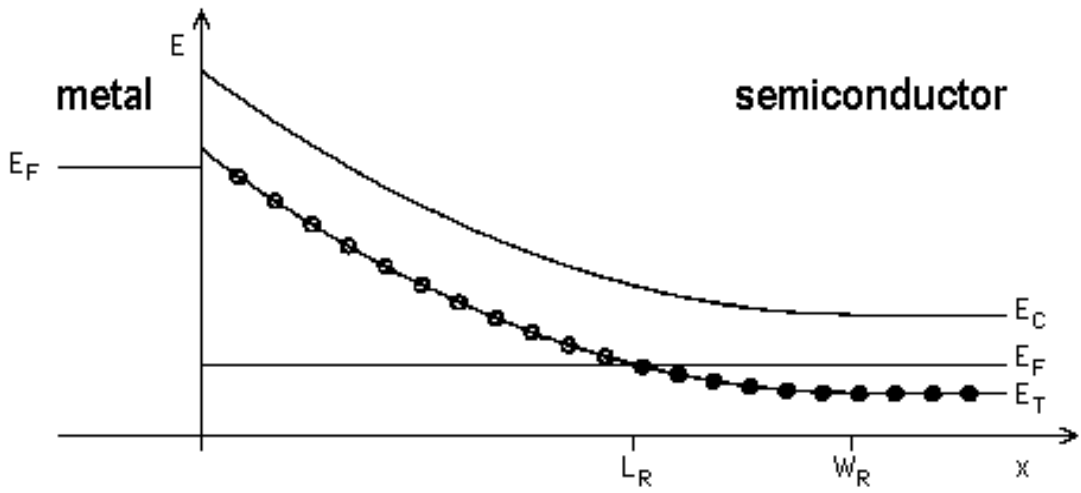
Arrhenius Plot: $\ln(\tau)$ vers. $1/T$, slope: ΔH_T , intercept: $\sigma_T X_T$

1. n has to be detected. Possibly the capacitance of a diode or by the leakage current of a diode
2. The change of the free electron concentration with time has to be detected to get the trap electron emission concentration and timeconstant
3. $DC(t)$ has to be measured as a function of the temperature to get the Material parameters Energy and capture cross section.

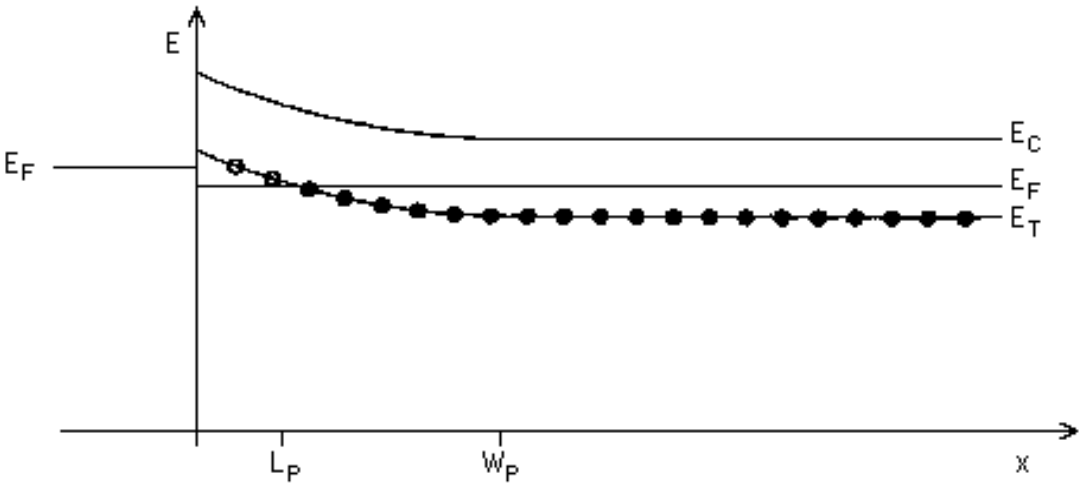
$$C = \epsilon A / W$$



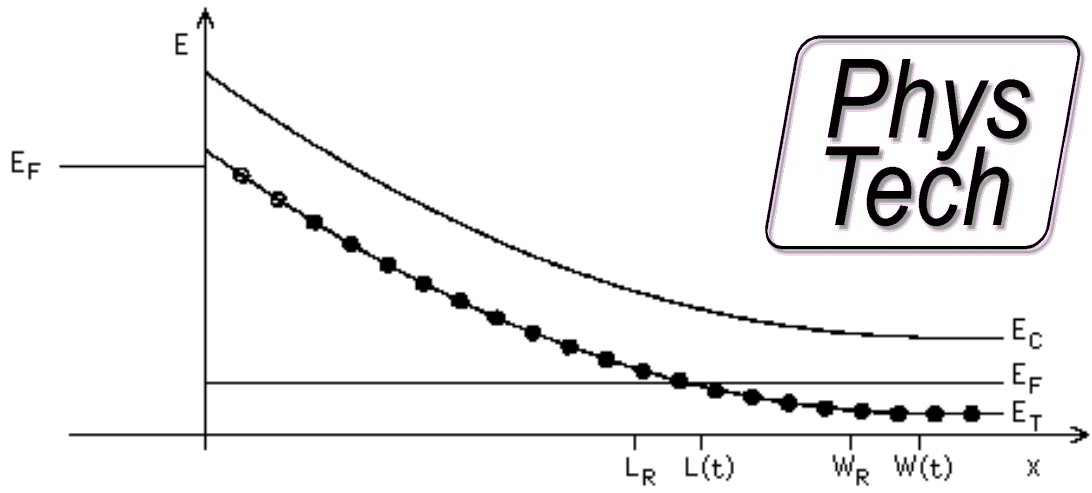
A Schottky diode (Metall-Semiconductor Contact) with a large reverse bias voltage



This diode with a small (nearly 0V) Reverse bias voltage



This diode back to the large reverse bias voltage



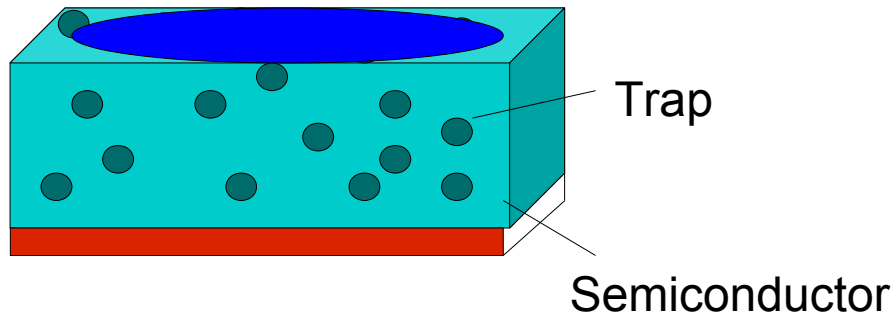
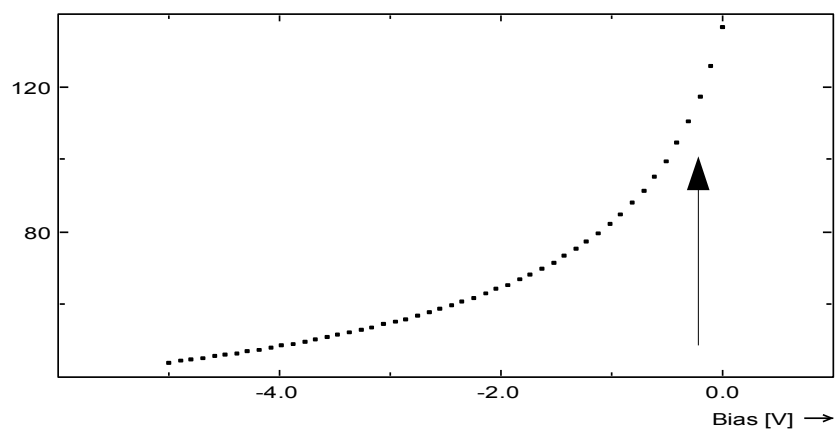
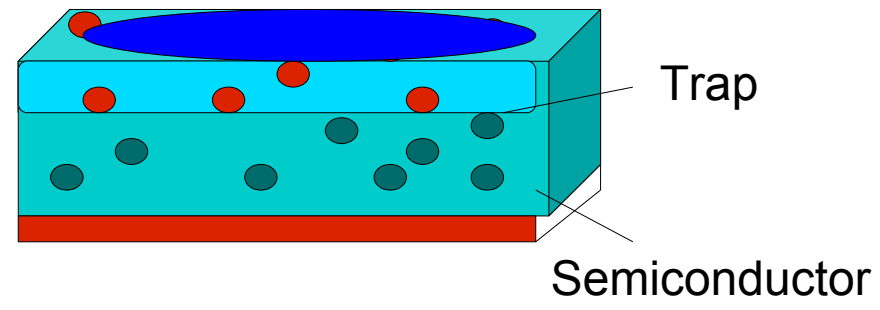
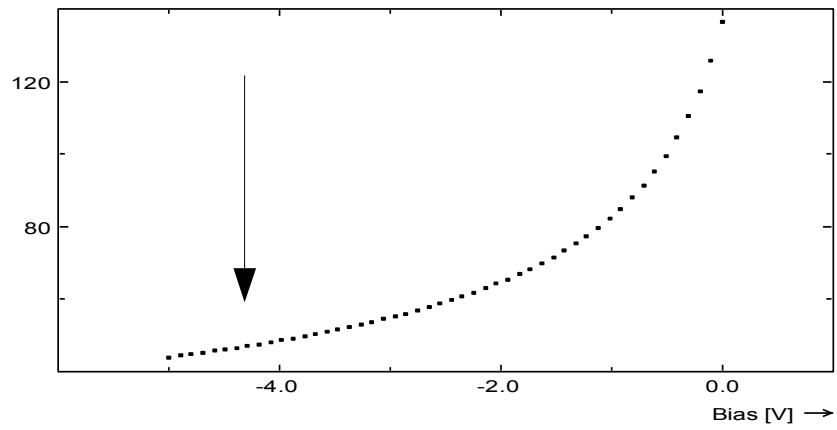
W, Lp,Lr, needed for calculation the volume

$$\frac{C_0 - C(t)}{C_0} = \frac{N_T}{2 * N_S} * \frac{L_R^2 - L_P^2}{W_R^2} * \exp\left(-\frac{t}{\tau_{ae}}\right)$$

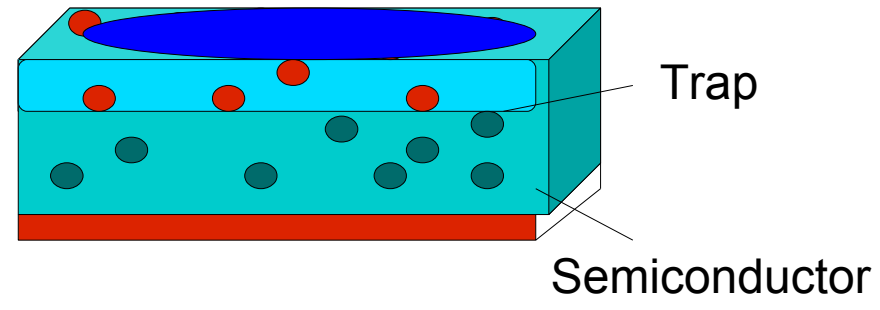
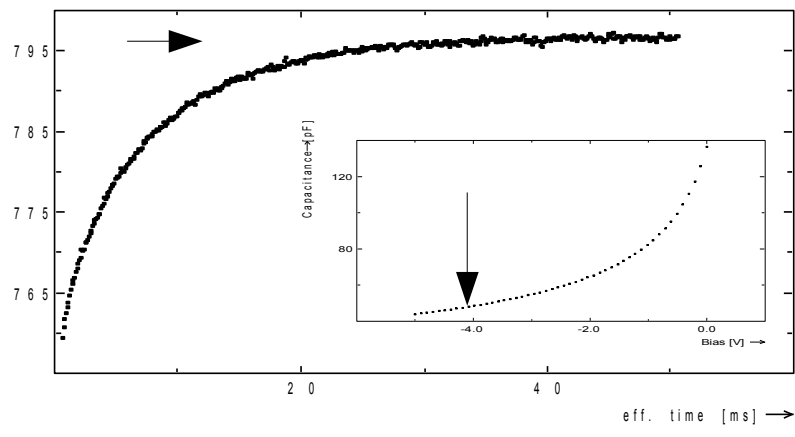
Approximation:
 LP --> 0 | Pulse --> 0 V
 LR --> WR | high Bias
 --->

$$\frac{C_0 - C(t)}{C_0} = \frac{N_T}{2 * N_S} * \exp\left(-\frac{t}{\tau_{ae}}\right)$$

$$C_0 = \frac{\epsilon_{ps} * A}{W_R}$$



**Phys
Tech**



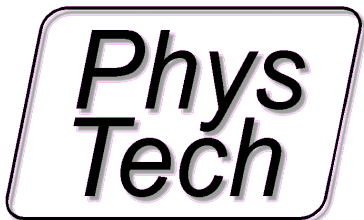
Needs

Sensitive capacitance meter (compensation mode)

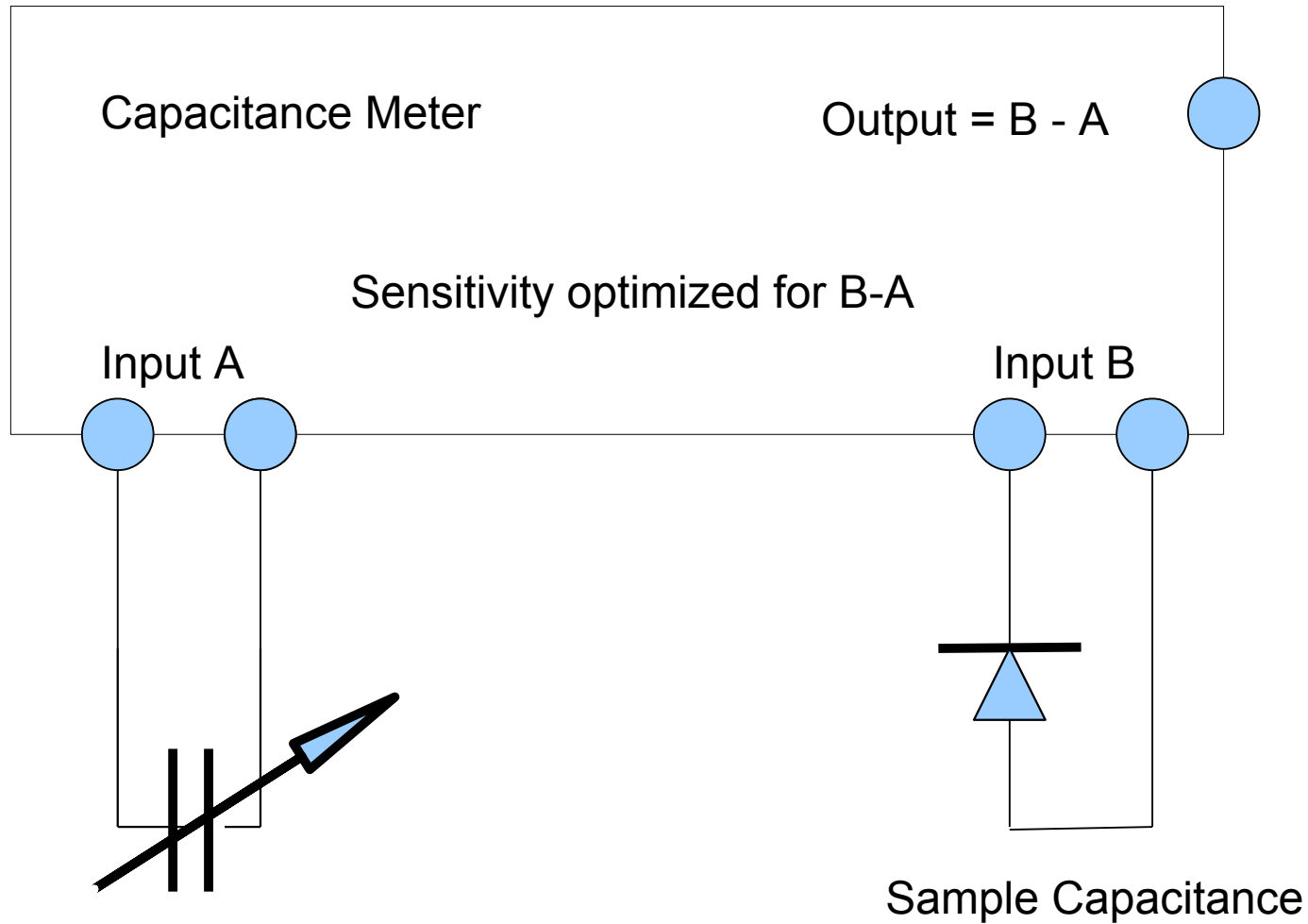
Time dependant data acquisition

Variable sample temperature

Time constant evaluation software



Phystech Sensitive capacitance meter (compensation mode)



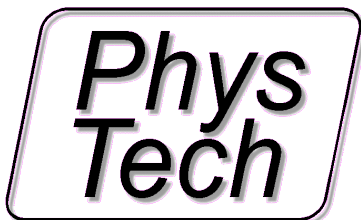
Specifications:

Phystech Capacitancemeter

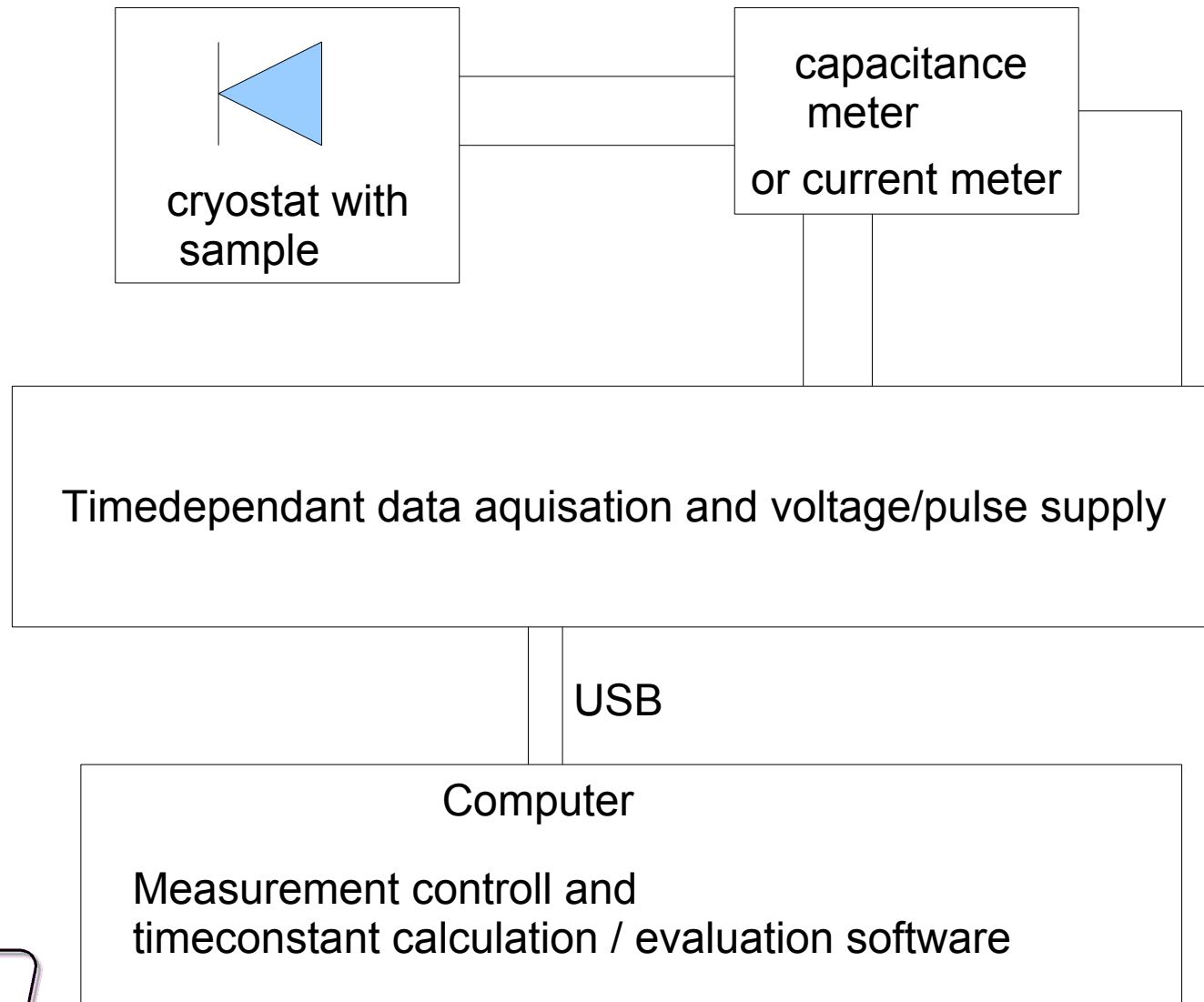
with automatic reverse bias capacitance compensation and automatic range setting

Compensation range : **1 pF - 3300 pF**
HF - frequency : 1 MHz
HF signal : **20mV, 100mV**
ranges : **5 pF - 2000 pF (4) (100mV)**
(5000 pF)

Current measurement amplifier with automatic range setting
max. measurement current : 15 mA



HERA DLTS FT1230



Specifications:

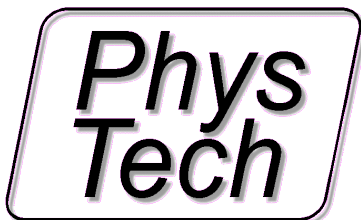
Bias-/Puls voltage source

voltage range : -/+ 20V (optional +/- 100V)
voltage setting resolution : 0.3 mV (1.5mV with 100V option)

internal shortest Pulswidth : 10 micro second (1V/micros)
external fast pulse generator : 20 ns (+/- 10V)
longest Pulswidth : > 100h

**optical pulse trigger available at the option port for TTL modulation
inputs of Laser power supplies**

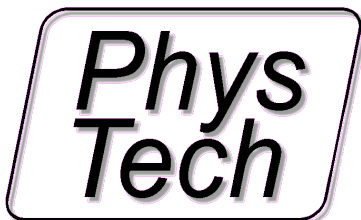
Computer controlled Amplifier with automatic gain setting
gain range : **1 - 100 000**



Specifications:

Digital transient recorder
with variable oversampling technic

max. samplings per transient : **2E6 (buffered), 2E9 (streaming)**
fastest sampling intervall : **850 nano seconds**
shortest period width : **27 micro seconds**
longest periodwidth : **110 h**



Timedependant measurement



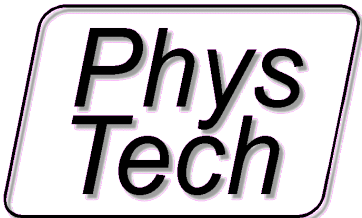
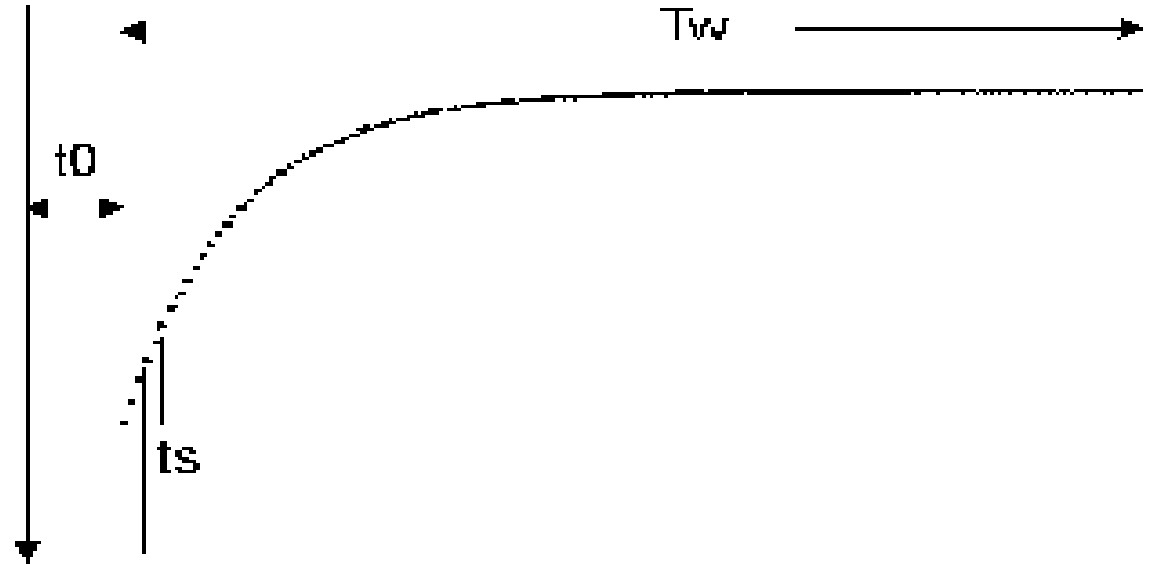
Compensation: $C_0 = 0$ time \longrightarrow

Capacitance \uparrow

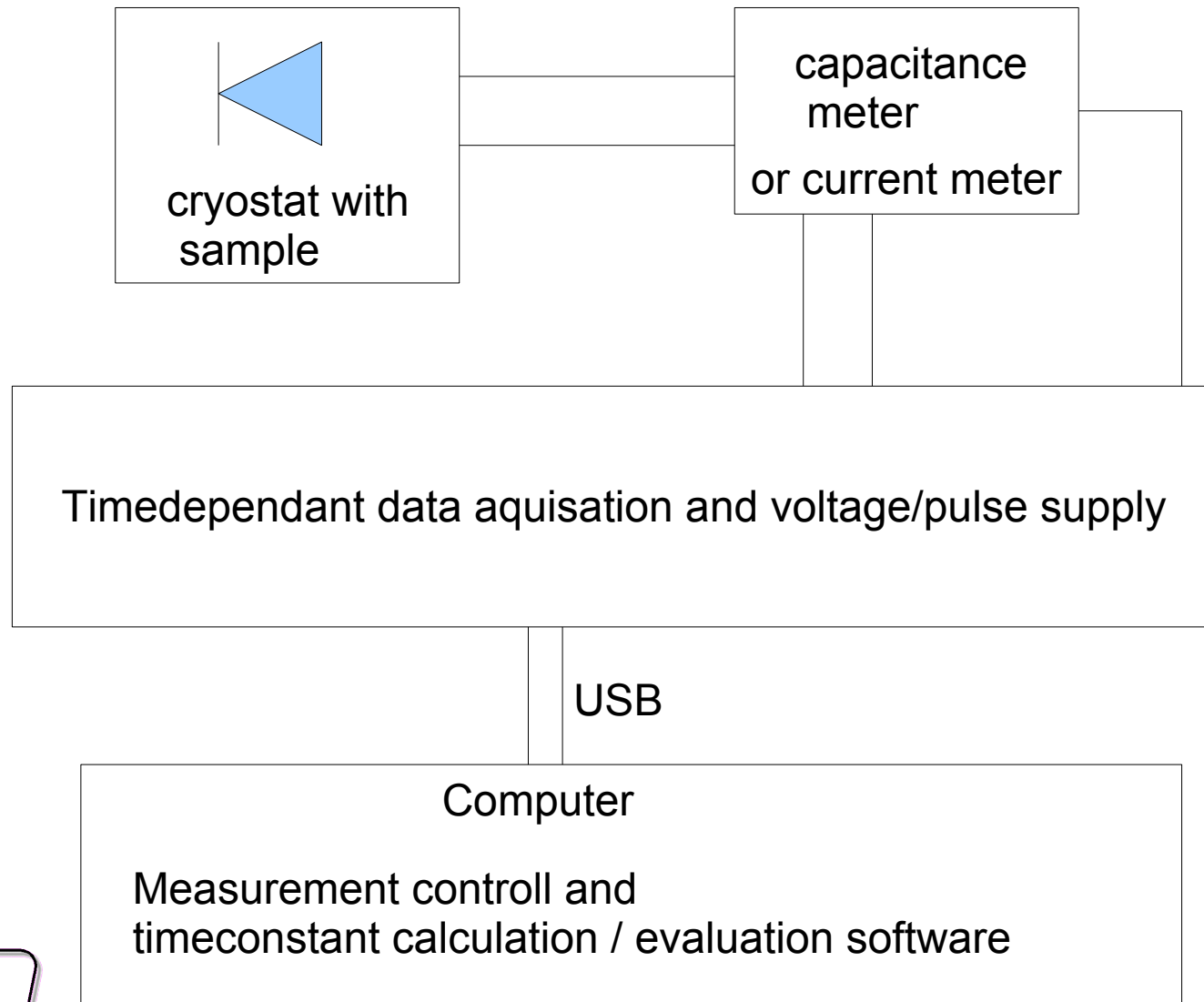
CP-Ccomp

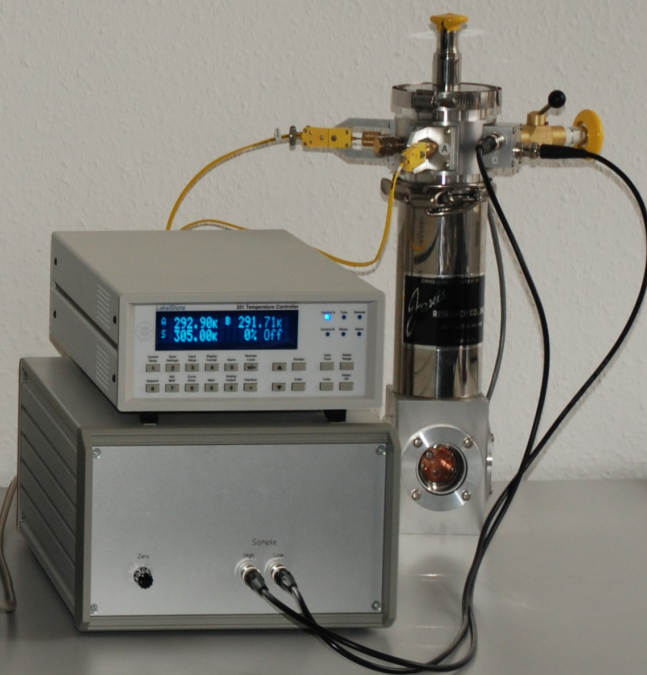
$$C(t) = C_0 + \Delta C * \exp(-t/\Pi)$$

CR-Ccomp



HERA DLTS FT1230



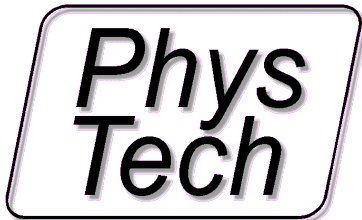


**Phys
Tech**



FT 1230 HERA DLTS features

- C/V , I/V
- C-DLTS / Capacitance - DLTS
- I-DLTS / Current - DLTS
- CC-DLTS / Constant Cap. DLTS
- Laplace DLTS
- ITS (ICTS)
- MIS Analysis / Zerbst DLTS



HERA-DLTS System FT 1230 available DLTS modes

- C-DLTS (Capacitance DLTS)
- CC-DLTS (Constant Capacitance DLTS , with CC option)
- I-DLTS (Current DLTS)
- Q-DLTS (Charge -DLTS)
- FET DLTS (3 term DLTS 2nd voltage source included)
- DD-DLTS (Transient difference DLTS)
- ITS (Isothermal Transient (C or I) Spectroscopy)
- O-DLTS, PICS (Photon induced transient (C or I) spectroscopy)
- Capture DLTS (capturing transient measurement)
- Laplace-DLTS (Logarithmic transient measurements and evaluat.)
- MIS - Nss DLTS (Surface states density measurement and evaluations)
- MIS - Zerst DLTS (Minorier carrier generation / lifetime measurem.)
- C(V), I(V), C(t),I(t)
- TSC und TSCAP (Temperature Stimulated Current , Capacitance

Phystech FT1230 HERA DLTS system	Other, Analog DLTS Systems
Uses 28 correlator functions	Only 1 correlator function used
Only one temperature scan for any Arrhenius plot necessary	For any 1 (or 2) data points in an Arrhenius plot a separate measured temperature scan is necessary.
Every transient measurement is independent of the next one. A temperature scan can be held and a C/V, I/V or period width scan can be added.	A parameter set can not be changed during a temperature scan.
More than 18 different measurement files with different parameter sets as reverse bias voltage, pulse voltage, pulse widths, pulse mode etc. can be measured in one temperature cycle.	Only one measurement parameter set can be measured in one temperature cycle. see above
After one temperature scan measurement all data for use of different DLTS analysis as correlation DLTS (28 correlators), Fourier DLTS, Laplace DLTS can be used. The results (Arrhenius plots) of it are mathematically independent and can be used for comparisons..	Only correlation DLTS is measured and can be evaluated.
C/V's, I/V's and C(t) can be measured during the temperature scan in one temperature cycle. The results can be used for Ns (T) correction.	The Lock-in measurement of DC can not be interrupted during the temperature cycle. A Ns(T) correction of the trap concentration is not possible (from a measurement).

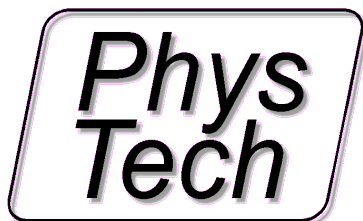
Phystech FT1230 HERA DLTS system	Other Analog DLTS Systems
<p>The Constant Capacitance mode (CC-DLTS or V-DLTS) keeps also the reverse bias capacitance over the temperature ($C(T)$) constant as well as the time dependant capacitance due to the emission process ($C(t,T)$).</p>	<p>The CC-DLTS (if available) can only keep the capacitance constant during the emission process constant. It can not change the reverse bias due to temperature dependant change of the capacitance.</p>
<p>Measurements with electrical pulses and with optical pulses can be done in the same temperature cycle.</p>	<p>Only one pulse mode in one temperature cycle is possible.</p>
<p>Due to the direct measurement of the emission also other emission processes can be observed and evaluated (MIS, Nss, Zerbst DLTS etc.).</p>	<p>Due to the fact, that only the correlated signal is measured other timedependances as exponential ones can not be analysed.</p>
<p>Overlapping emission processes can be separated by using the deconvolution of the DC correlator signals or with inverse Laplace transformation of the emission transient.</p>	<p>Overlapping levels can only be separated by asymmetric Gauss fit.</p>

Measurement options

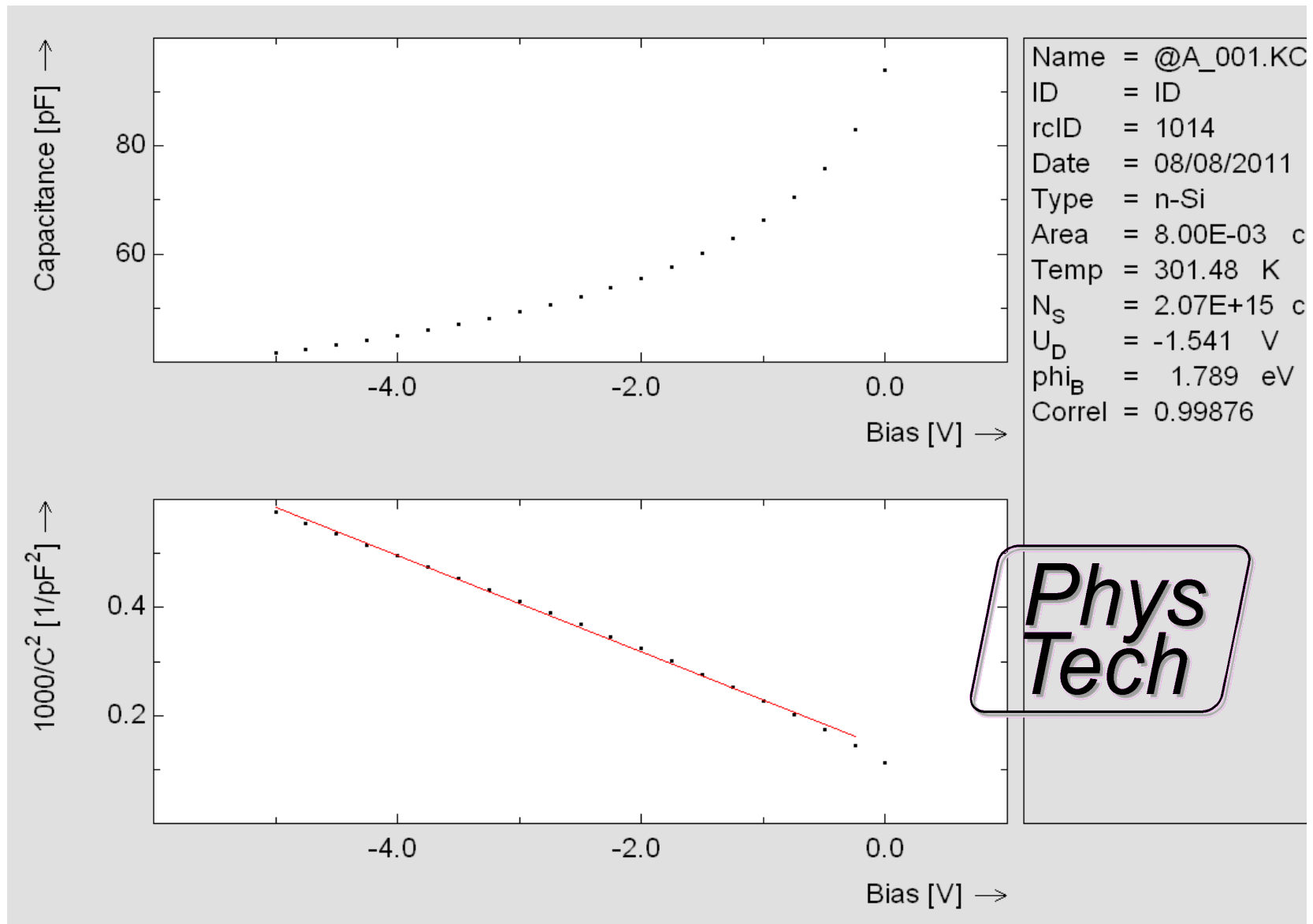
1. Voltage dependant measurements
Capacitance versus voltage
Current versus voltage
2. Timedependant measurements
Capacitance versus time
Current versus time

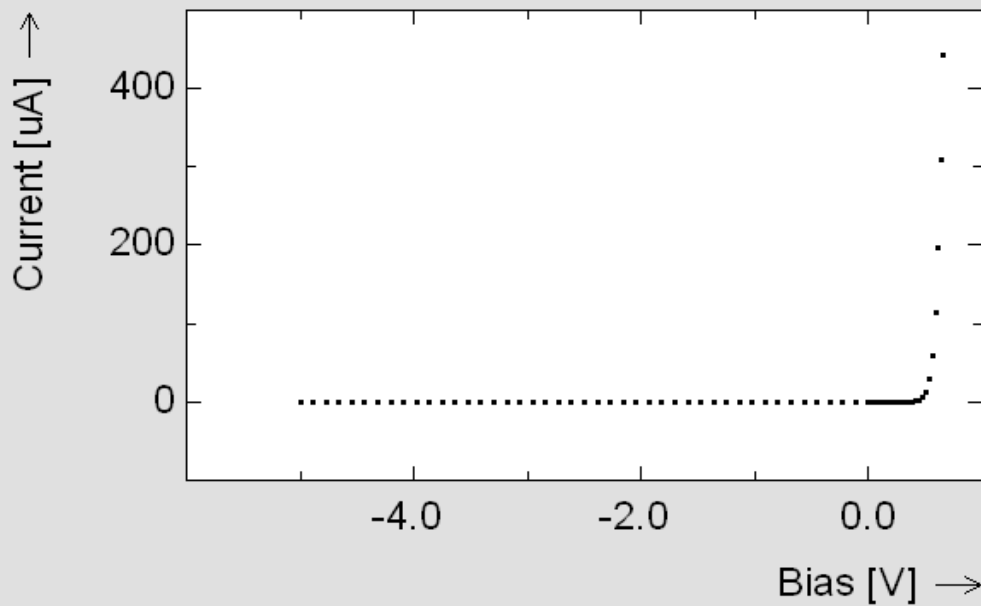
Parameters:

Temperature, no. of data points, low/high limits,
resolution, sensitivity, electrical / optical pulse values

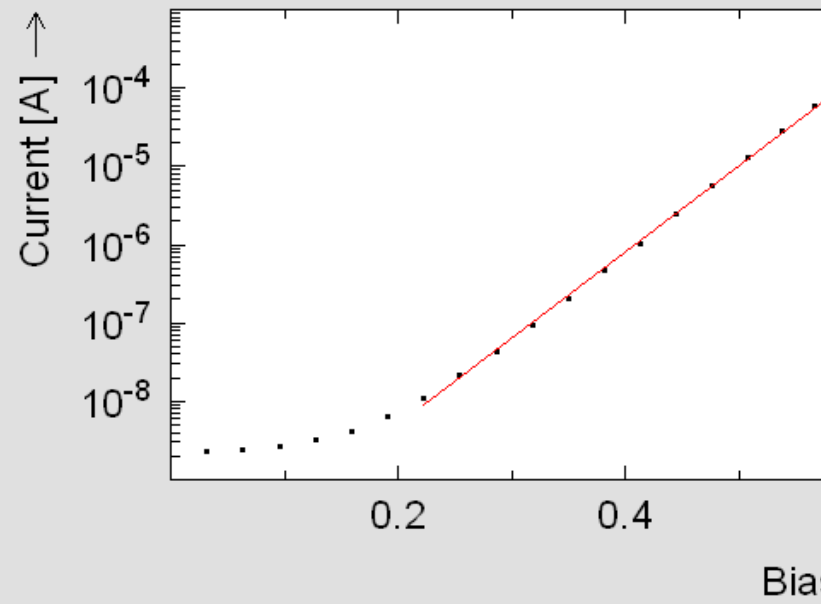
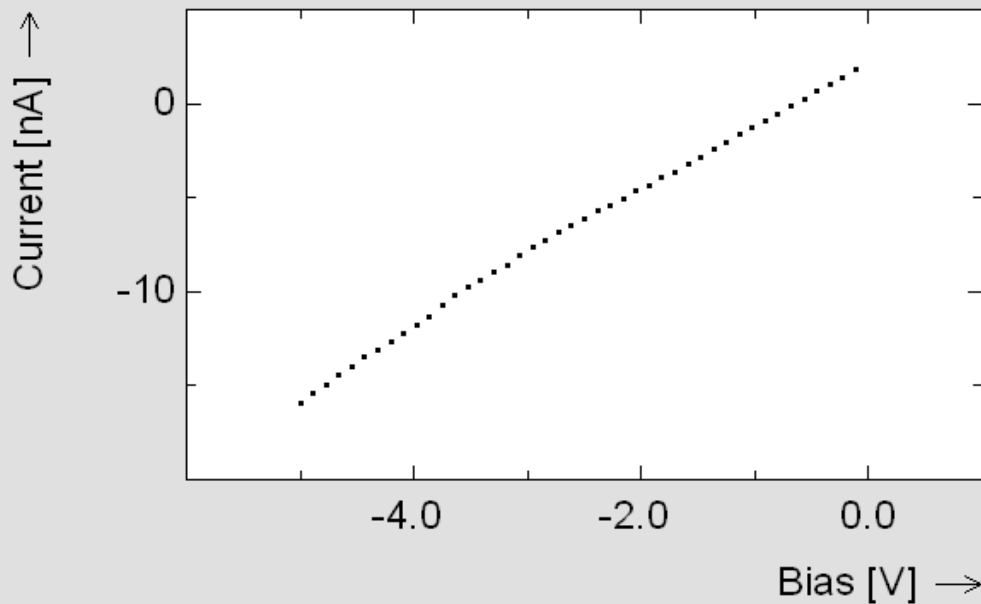
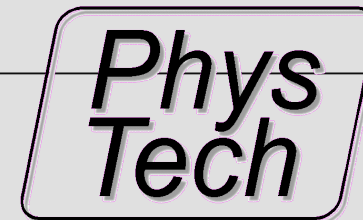


1. Voltage dependant measurements





Name = ID3@A_001.KIA
 ID = ID3 rcID = 1001
 Date = 07/01/2011 Type = n-Si
 Area = 8.00E-03 cm² N_S = 2.00E+15
 Temp = 300.00 K
 n-fac = 1.524 U_D = -0.674 V
 phi_B = 0.921 eV I_S = 3.15E-11
 Correl = 0.99971



Time dependant measurements

Capacitance or current measurement as function of time after an electrical or optical filling of the traps.

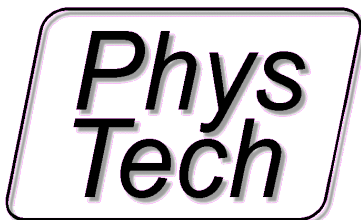
HERA DLTS Evaluations

Correlation DLTS (Tempscan, Periodwidthscan, Frequencyscan)

Fourier DLTS (Direct Transient Analysis)

Laplace DLTS (Direct Transient Analysis)

Deconvolution HERA DLTS (Tempscan , Periodwidthscan)



Emission Transient Measurement

C: $f(t)$ [T,V,P,...]
I: $f(t)$ [T,V,P,...]

Correlation DLTS

Direct DLTS

Π evaluation

28 correlation functions
28 Tempscan signals

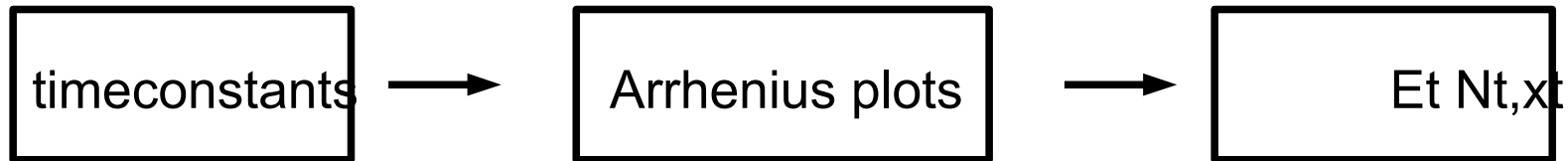
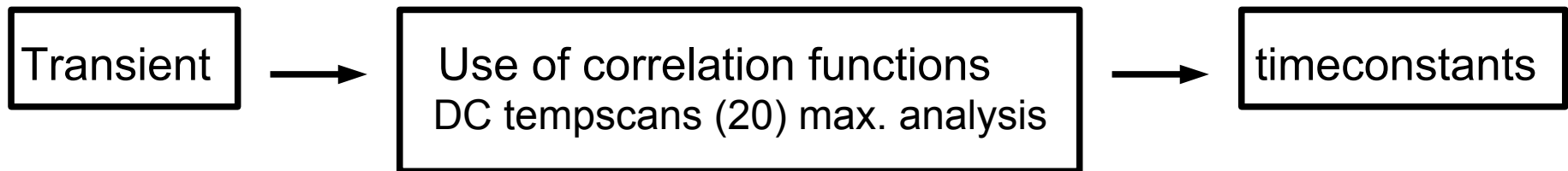
Π evaluation
Fourier analysis

Π evaluation
inverse Laplace
transformation

Tempscan
HERA
deconvolution

Arrhenius Plot ($\ln(\Pi)$ vers. $1/T$)
E, Q, NT

Correlation DLTS (DC -Tempscan Analysis)



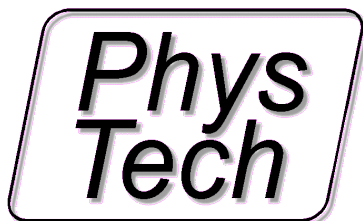
HERA DLTS Evaluations

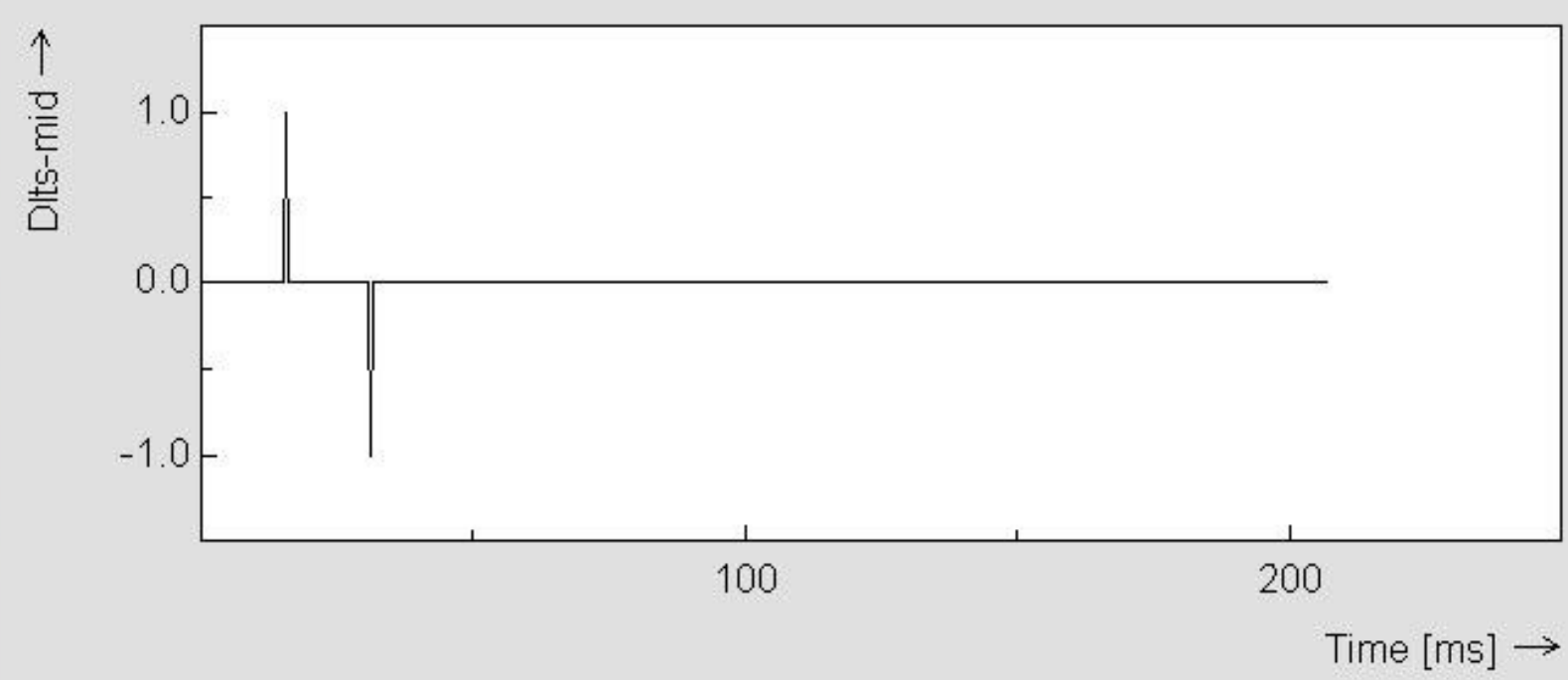
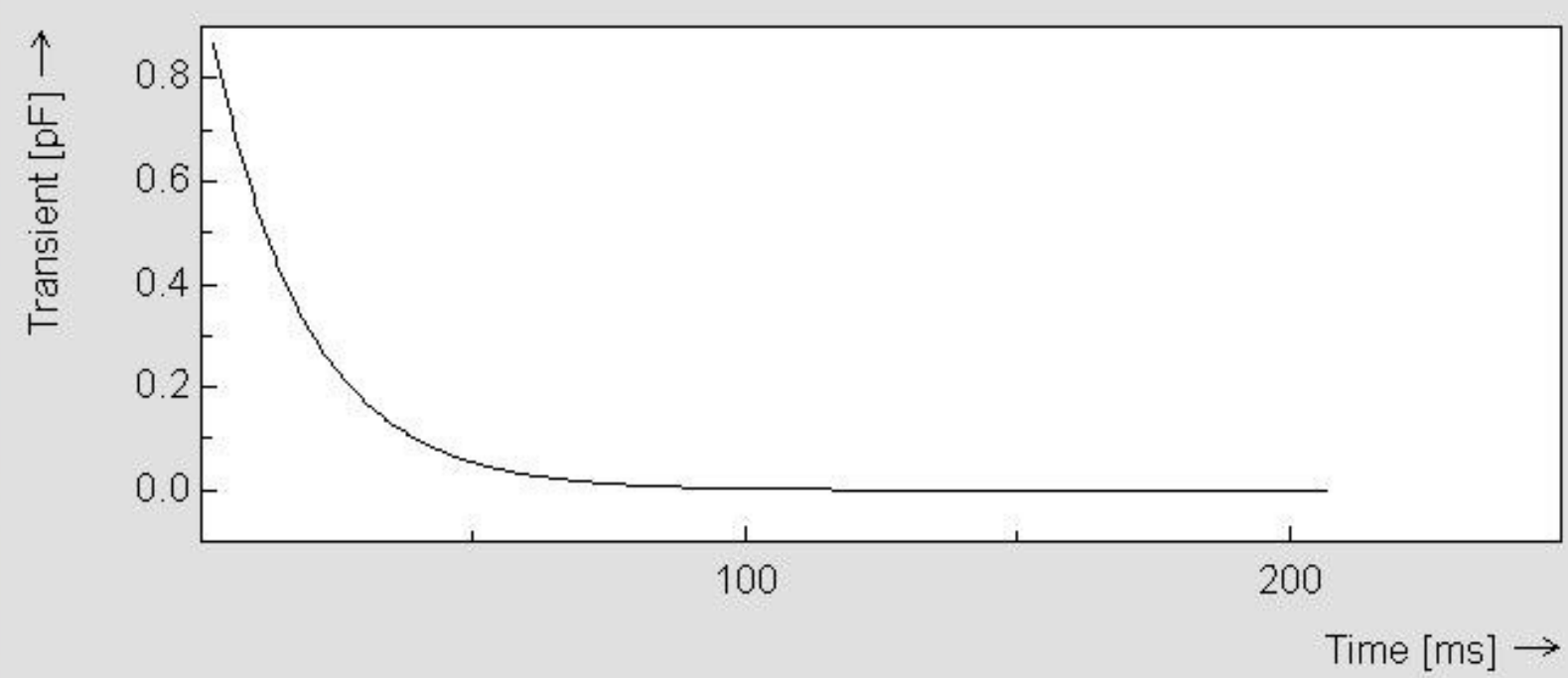
Correlation DLTS (Tempscan, Periodwidthscan, Frequencyscan)

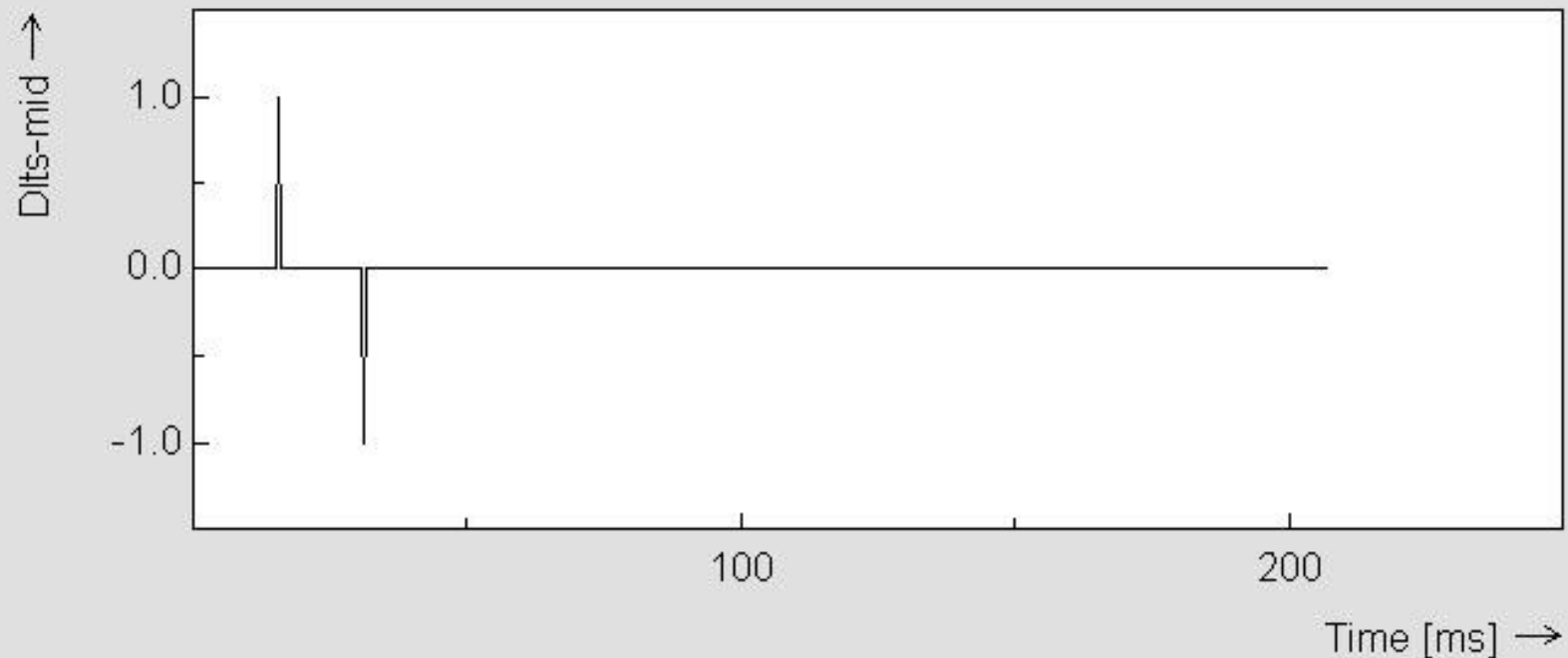
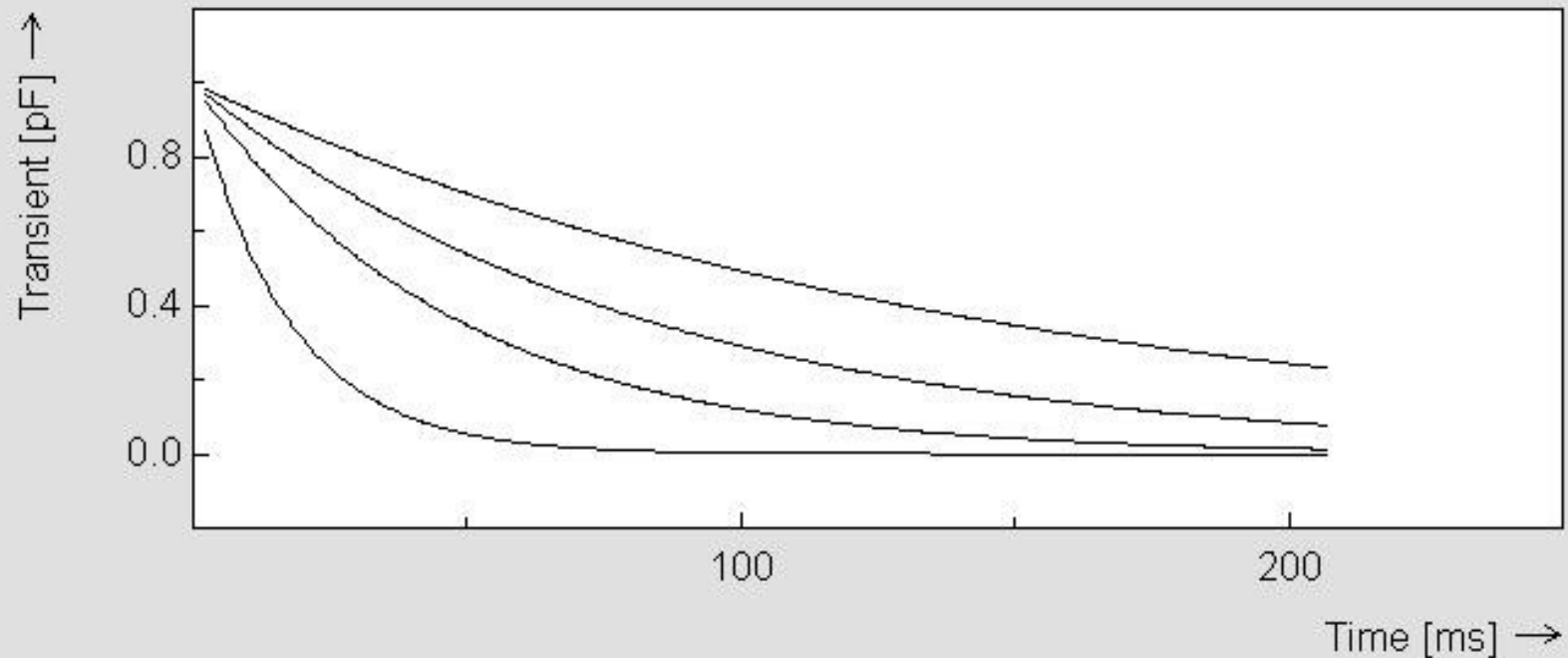
Fourier DLTS (Direct Transient Analysis)

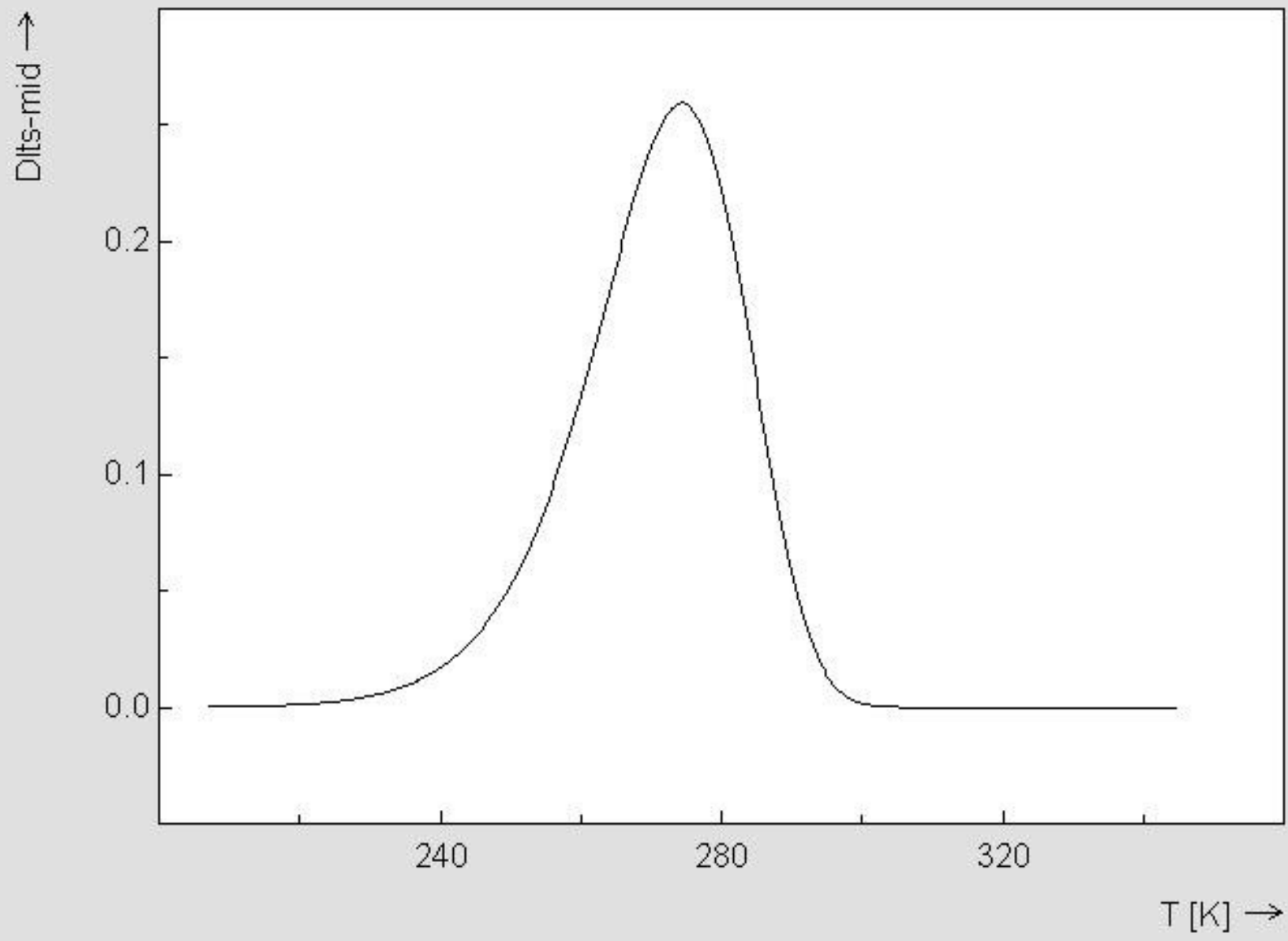
Laplace DLTS (Direct Transient Analysis)

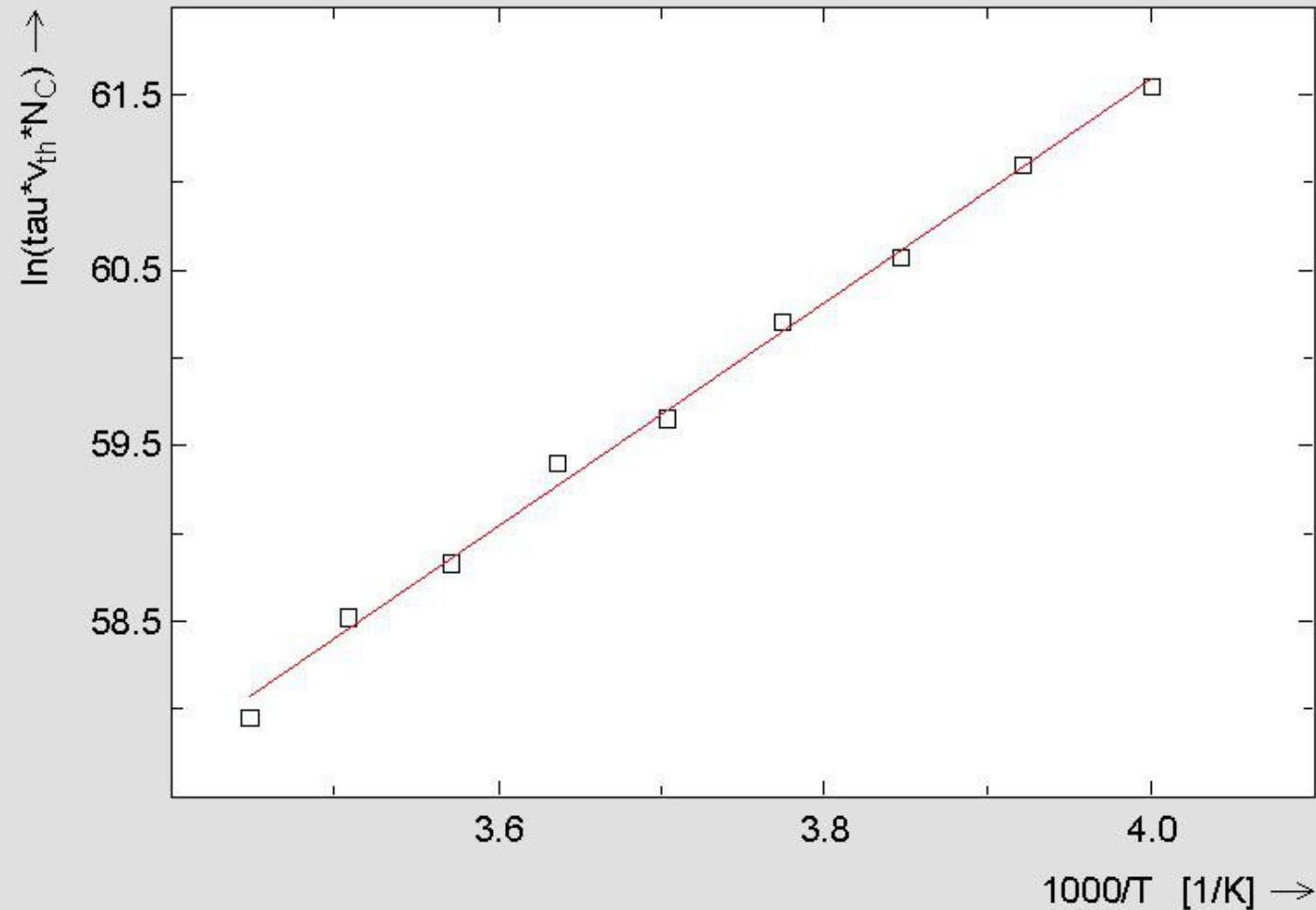
Deconvolution HERA DLTS (Tempscan , Periodwidthscan)





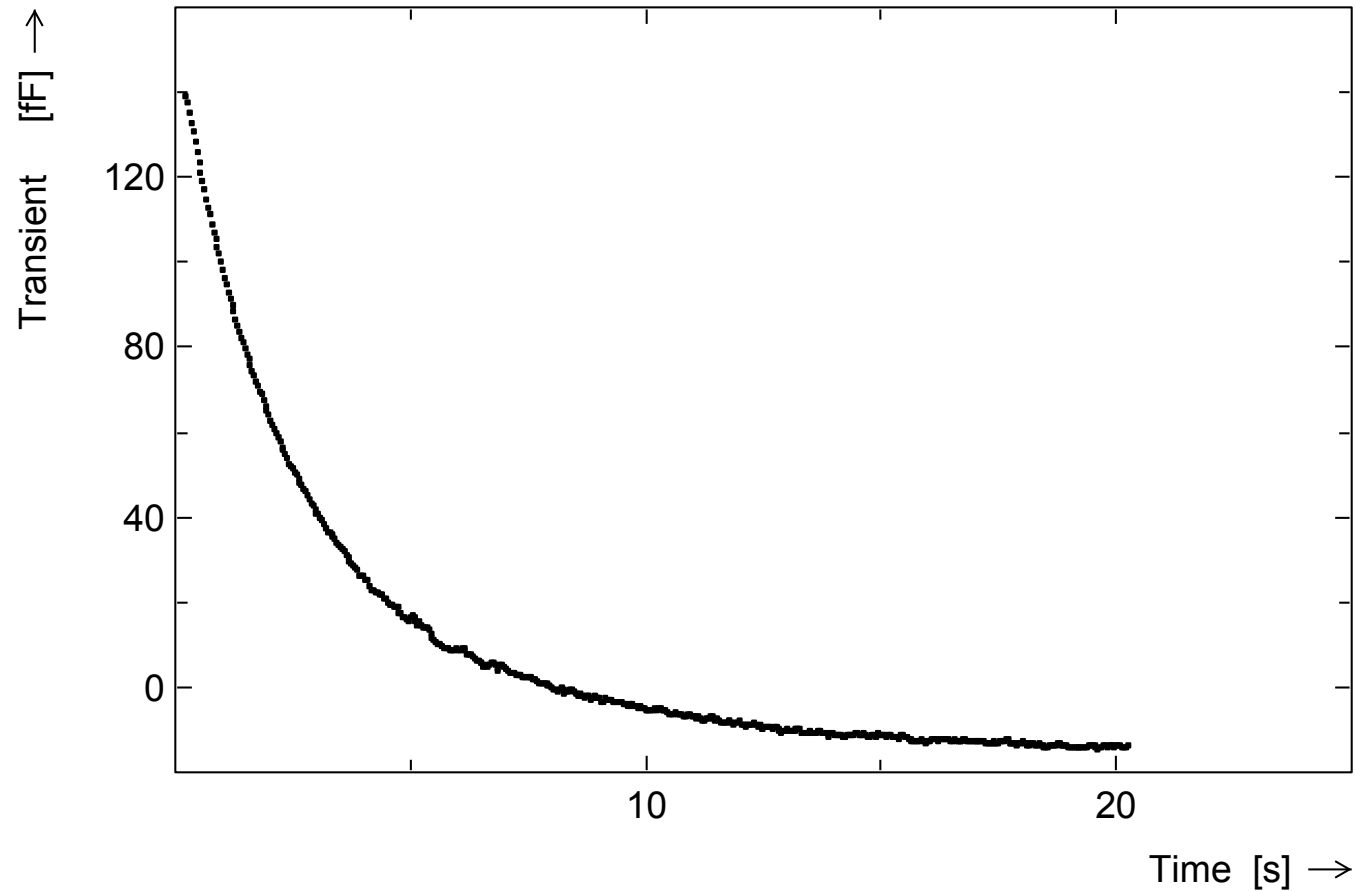




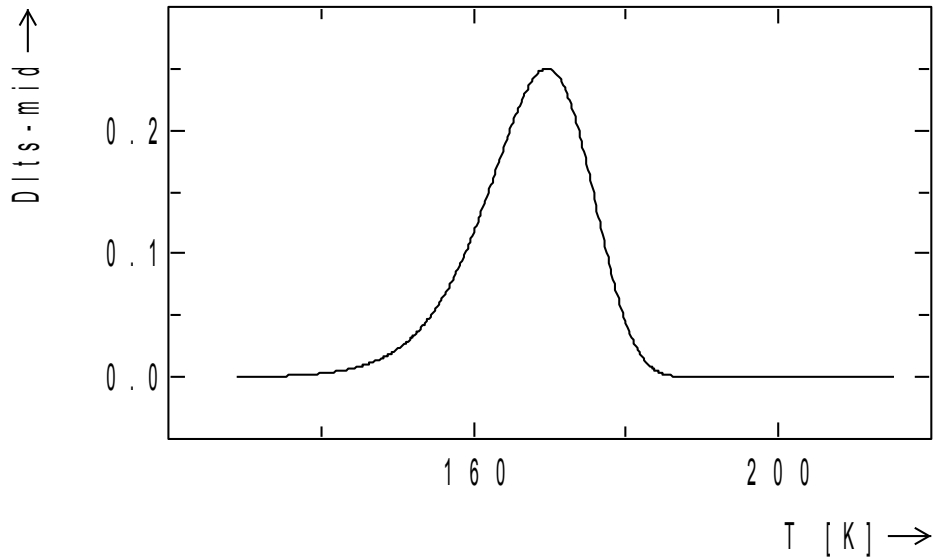


Name = _T1.AWA
 Comm = J7
 ID = GANA18
 rcID = 0000
 Date = 28.10.2004
 Type = n-GaN*
 Area = 3.14E-04 cm²
 N_S = 2.00E+17 cm⁻³
 t_P = 100.00 us
 U_R = -3.00 V
 U_P = 0.00 V
 Energy = 0.549 eV
 sigma = 2.09E-16 cm²
 N_T = 3.20E+15 cm⁻³
 Correl = 0.99807

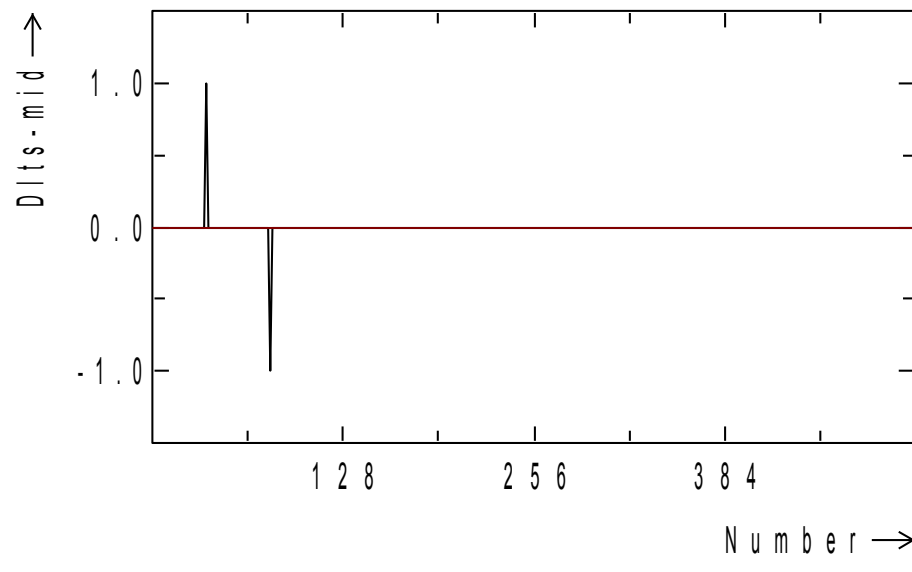
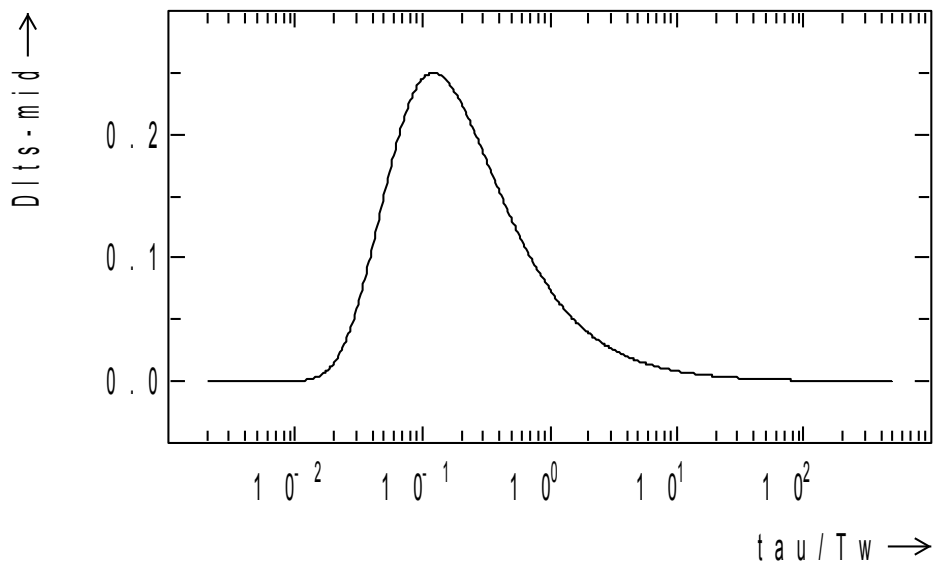
tau(a1,b1) =	3.206 s	Amplitude =	139.409 fF
tau(a2,b2) =	2.664 s	NT	= 3.09E+15 cm ⁻³
tau(b1,b2) =	2.368 s	NTs	= 7.44E+15 cm ⁻³
tau(a1,a2) =	3.163 s	Energy	= 0.636 eV
tau(Tw/4) =	2.341 s	tau,ts/Tw =	0.16,1.31
tau(Tw'/2) =	2.860 s	ExpClass	= 0.83
tau(a0,b1) =	4.641 s	TauClass	= 44

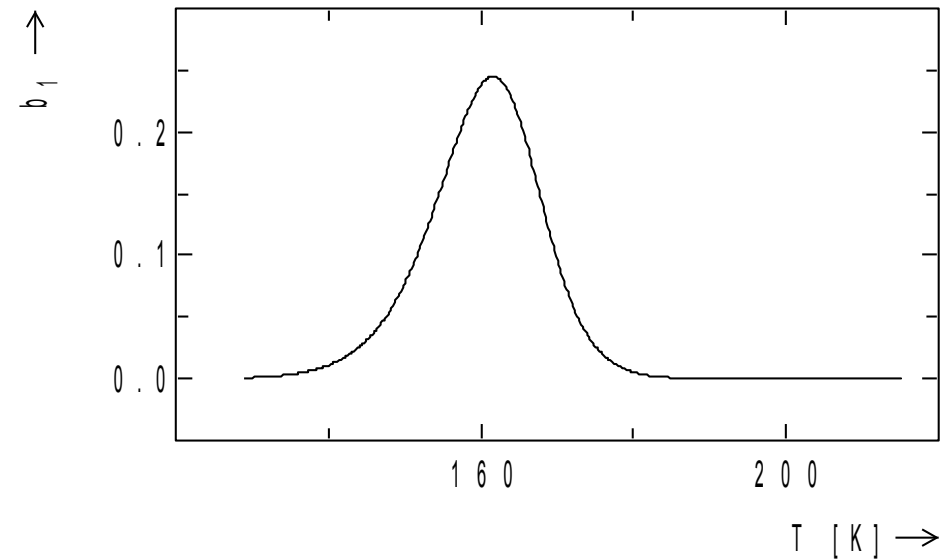


Name	=	@A_003.YEA
Comm	=	J7
ID	=	GAN18
rclD	=	1020
Date	=	29.10.2004
Type	=	n-GaN*
Area	=	3.14E-04 cm ²
N _S	=	2.07E+17 cm ⁻³
Temp	=	250.00 K
T _W	=	20.00 s
t _P	=	100.00 us
U _R	=	-3.00 V
U _P	=	-0.10 V
C _R	=	18.67 pF
I _R	=	-1.61 nA



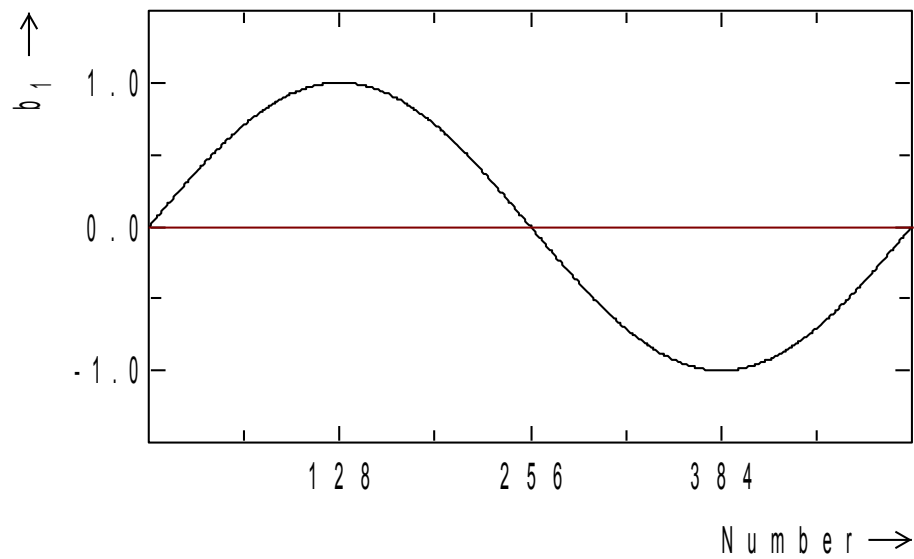
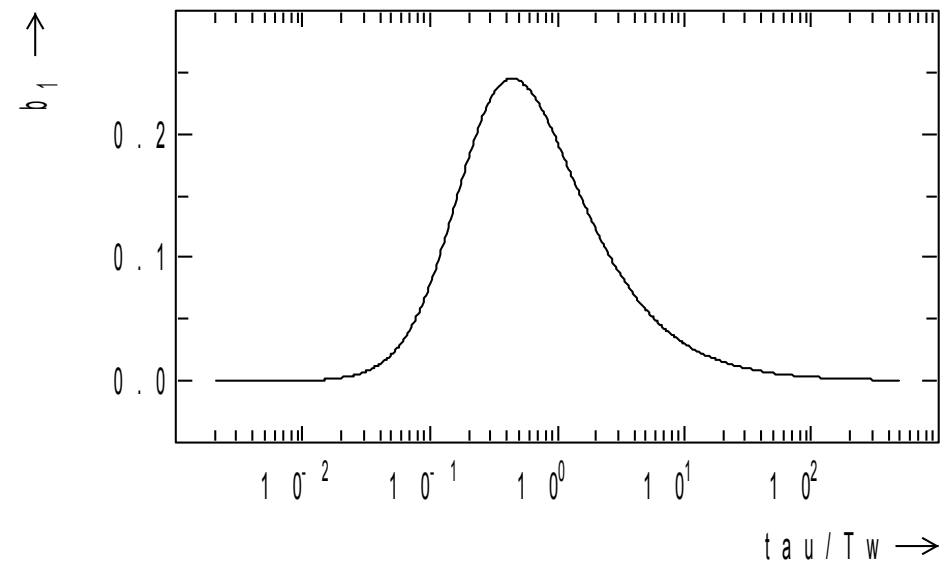
Name	=	Dlts-mid	Points	=	512
ArNo.	=	22	t_0	=	$2.800E-03$ s
T_w	=	$2.048E-01$ s	$T_w/t_0\text{-}eff$	=	$7.314E+01$
AmpMax	=	$2.500E-01$	τ_{Max}/T_w	=	$1.212E-01$
τ_{Max}	=	$2.483E-02$ s	TempMax	=	169.67 K
Integ	=	$3.003E-01$	$\langle \tau/T_w \rangle$	=	$2.084E-01$
Width	=	$1.082E+00$	WidthRat	=	$1.439E+00$
SNR	=	$4.514E-02$			

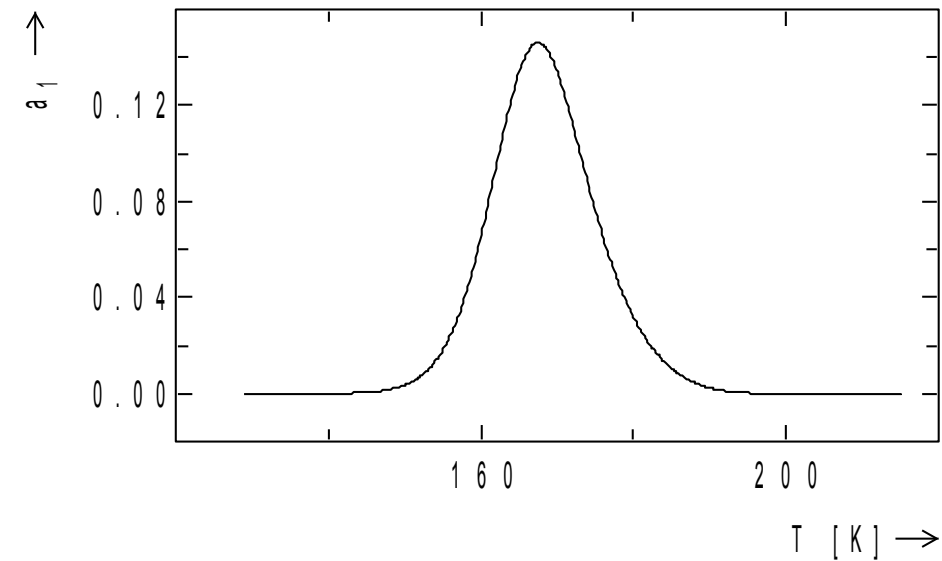




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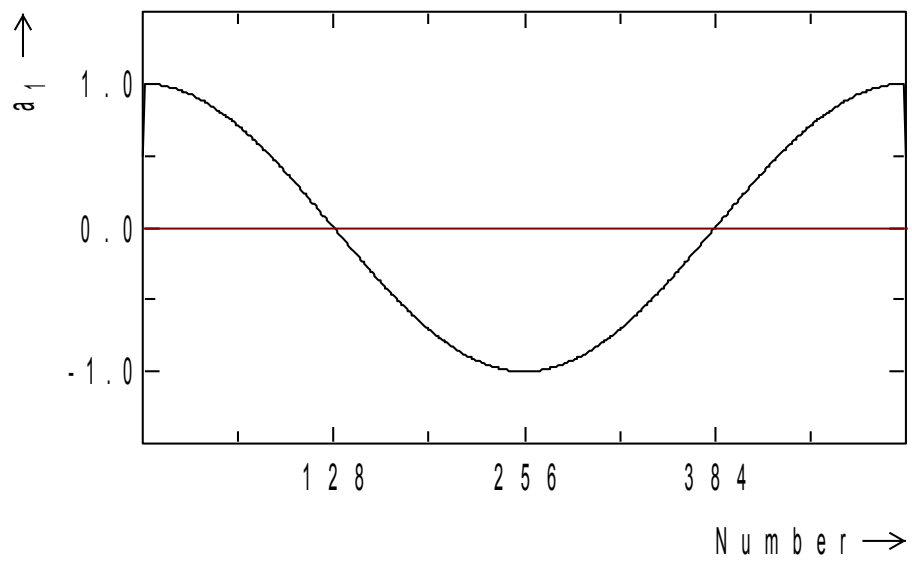
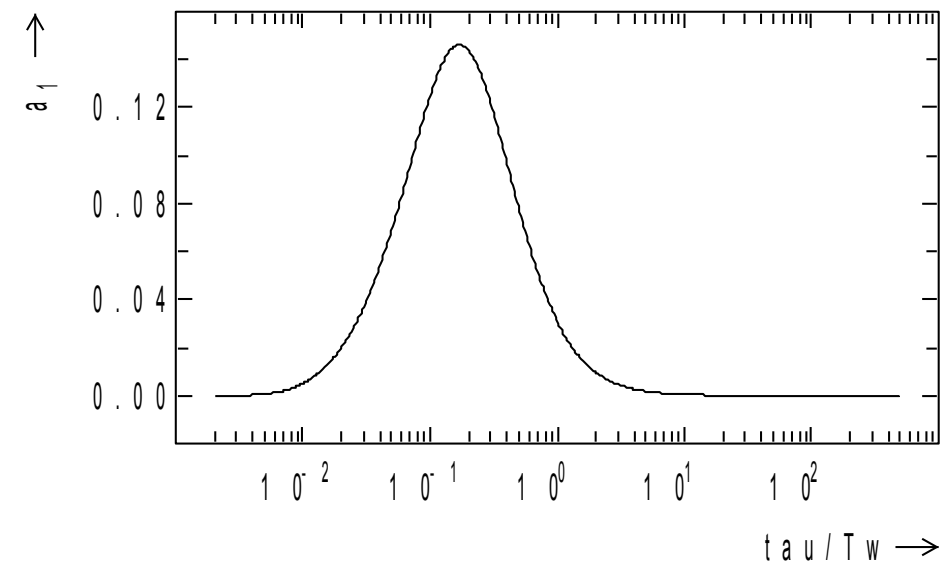
Name      = b1
ArNo.    =      1      Points    = 512
T w      = 2.048E-01s  t0      = 2.800E-03s
T w/t0-eff = 7.314E+01
Amp Max  = 2.448E-01   tau Max/Tw = 4.404E-01
tau Max  = 9.019E-02s Temp Max = 161.57 K
Integ    = 3.214E-01   <tau/Tw> = 6.699E-01
Width    = 1.157E+00   WidthRat  = 1.277E+00
S N R    = 1.000E+00
  
```

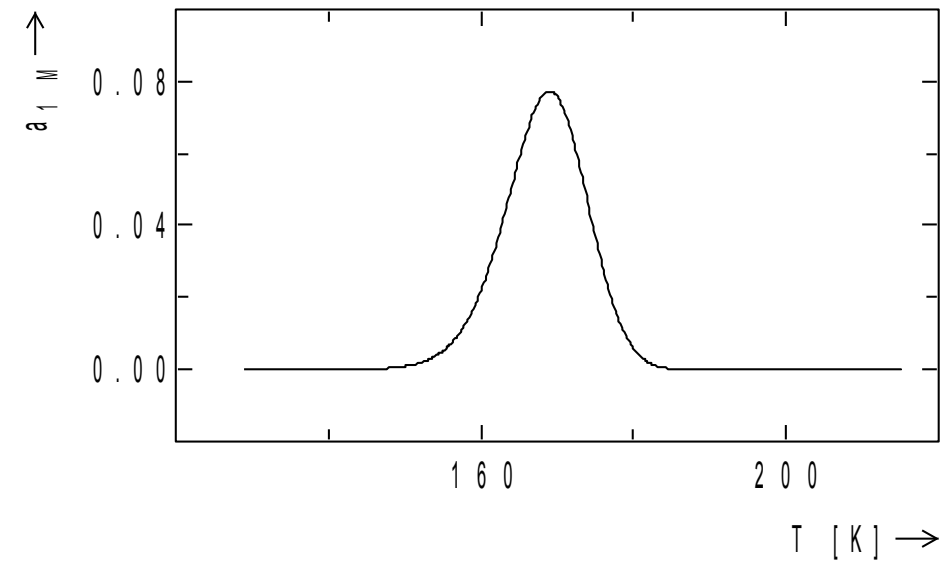




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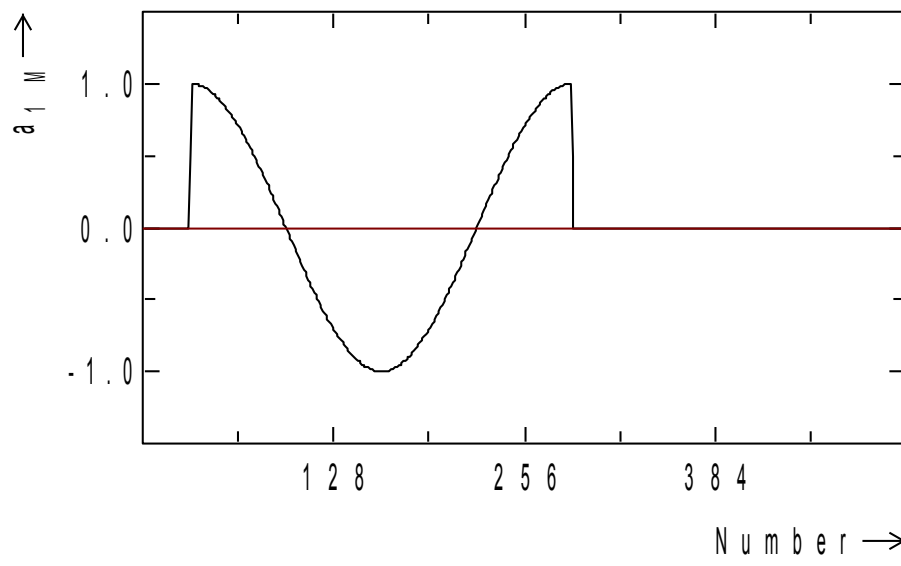
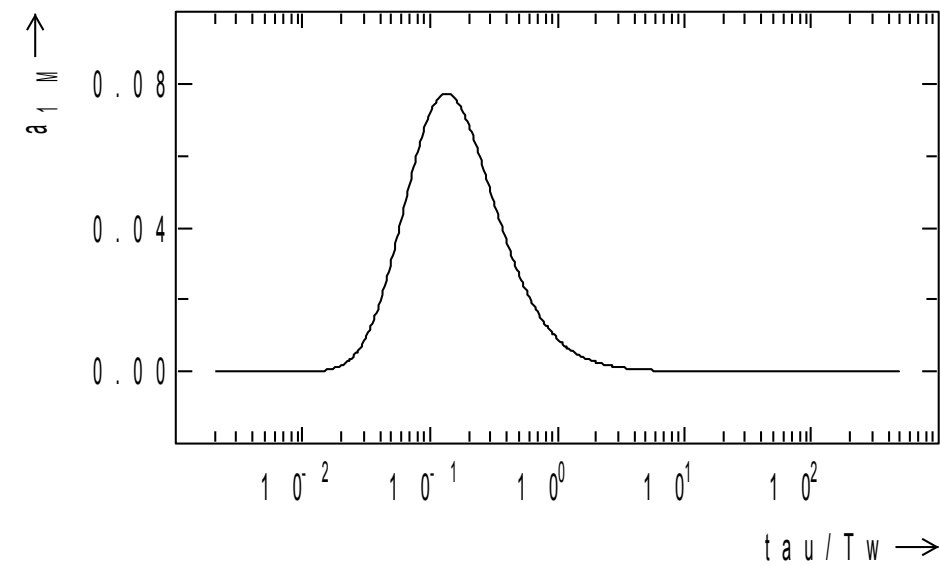
Name      = a1
ArNo.     =      5           Points    = 512
Tw        = 2.048E-01s      t0       = 2.800E-03s
Tw/t0-eff = 7.314E+01
AmpMax    = 1.461E-01      tauMax/Tw = 1.699E-01
tauMax    = 3.480E-02s    TempMax  = 167.43 K
Integ     = 1.614E-01      <tau/Tw> = 1.673E-01
Width     = 9.844E-01      WidthRat = 9.783E-01
SNR       = 5.976E-01
  
```

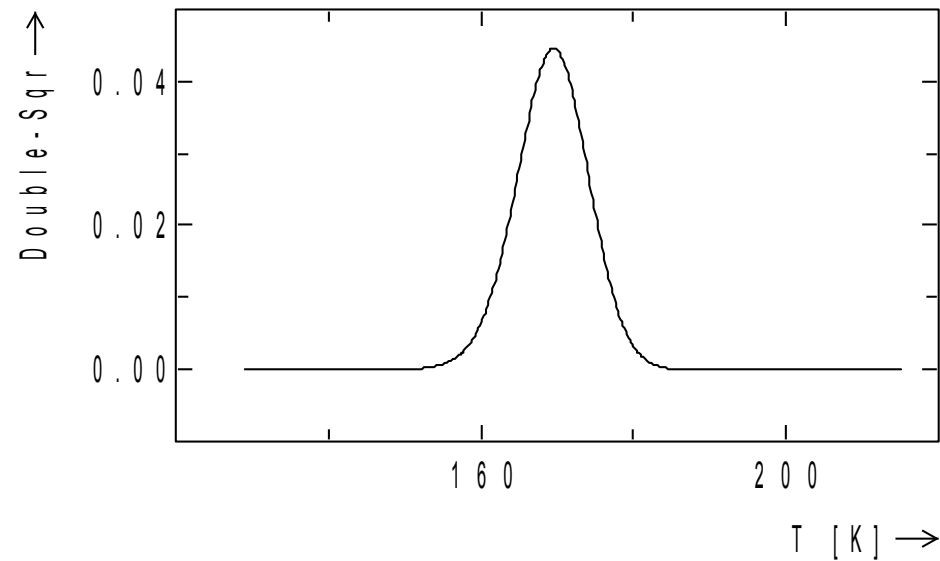




```

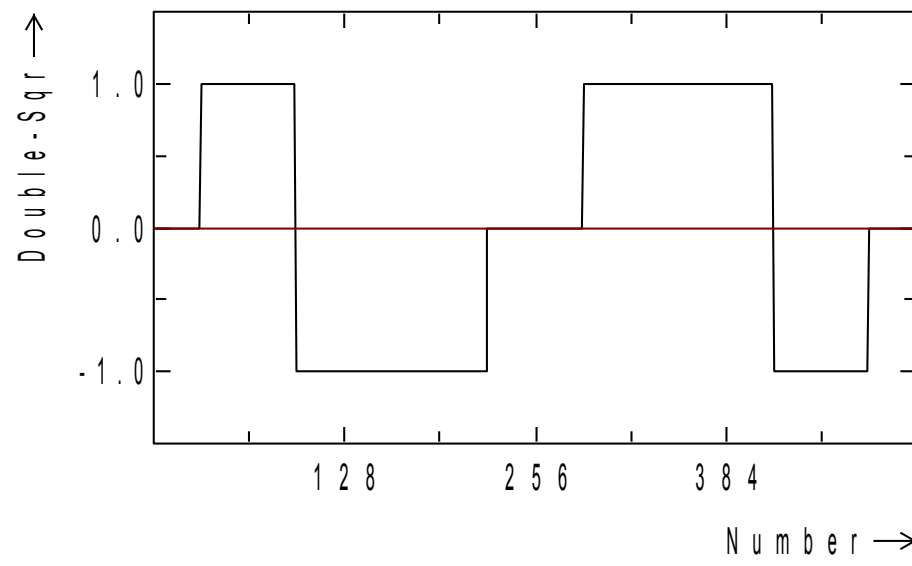
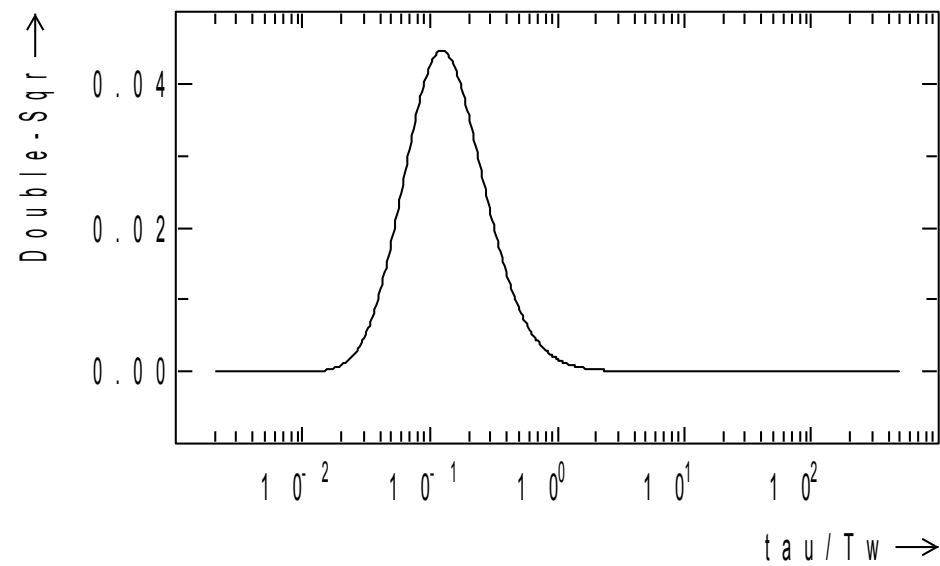
Name      = a1_M
ArNo.     = 15          Points    = 512
Tw        = 2.048E-01s  t0      = 2.800E-03s
Tw/t0-eff = 7.314E+01
AmpMax    = 7.726E-02   tauMax/Tw = 1.338E-01
tauMax    = 2.741E-02s  TempMax  = 168.98 K
Integ     = 6.951E-02   <tau/Tw> = 1.637E-01
Width     = 8.221E-01   WidthRat = 1.171E+00
SNR       = 2.236E-01
  
```

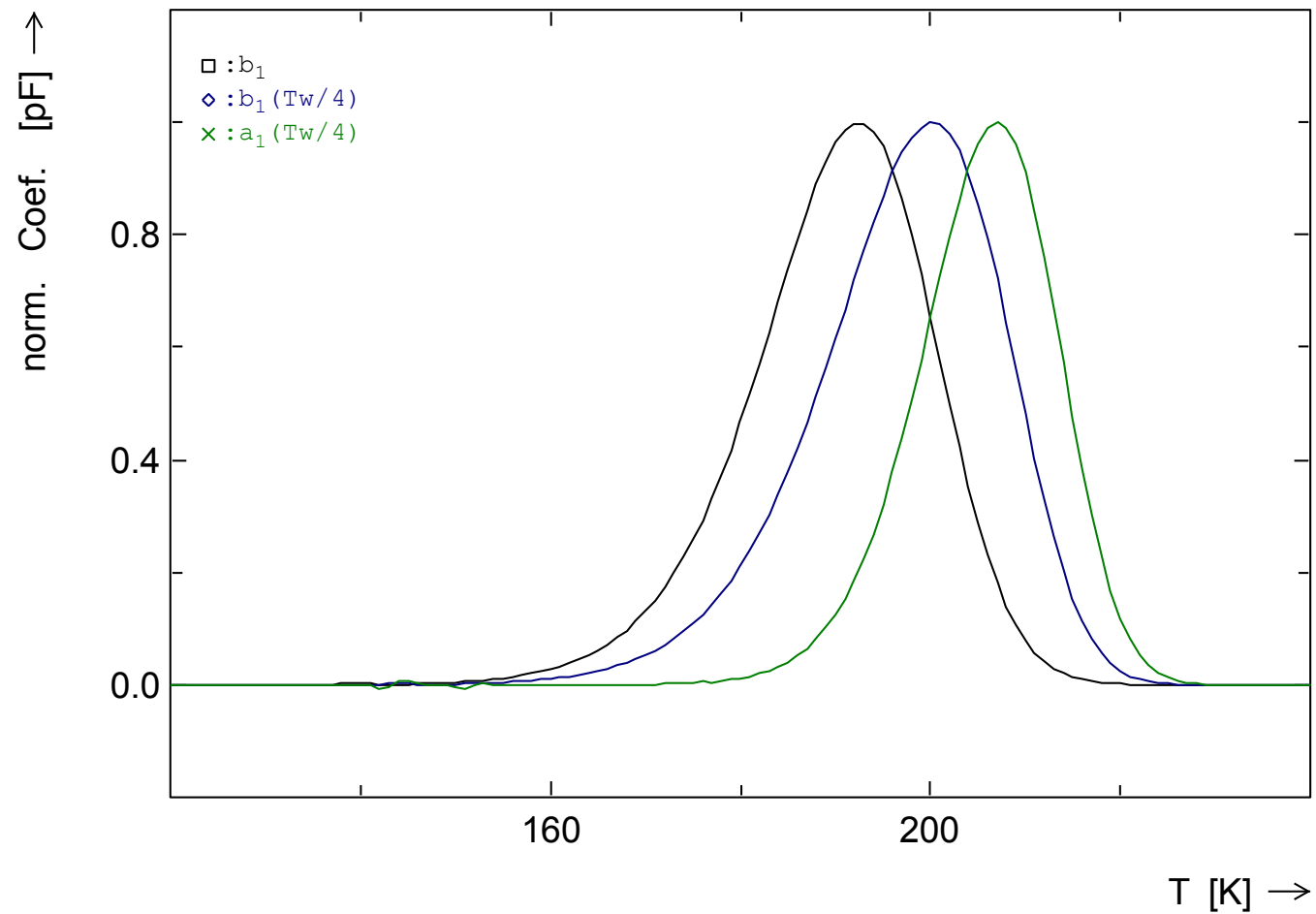




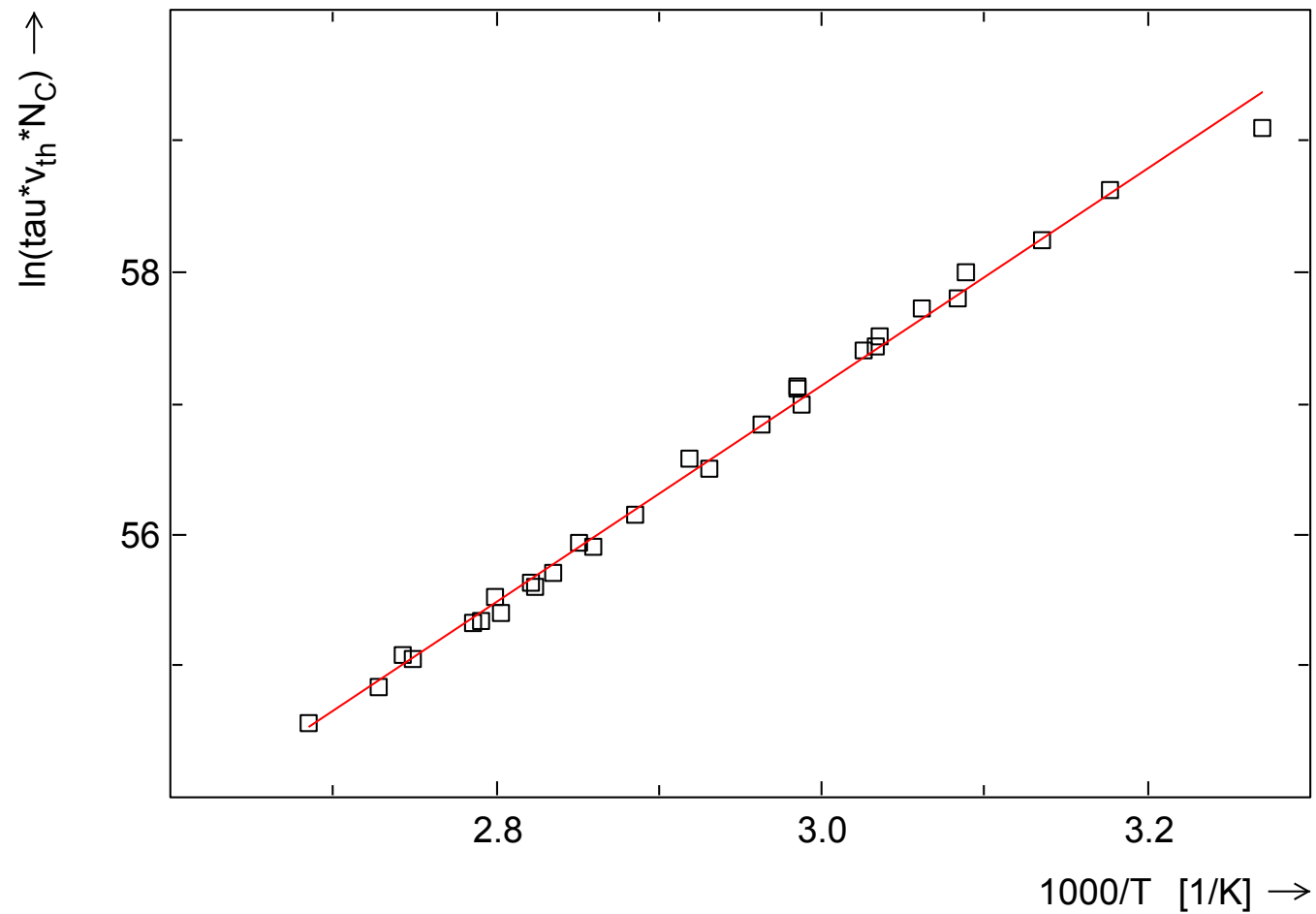
```

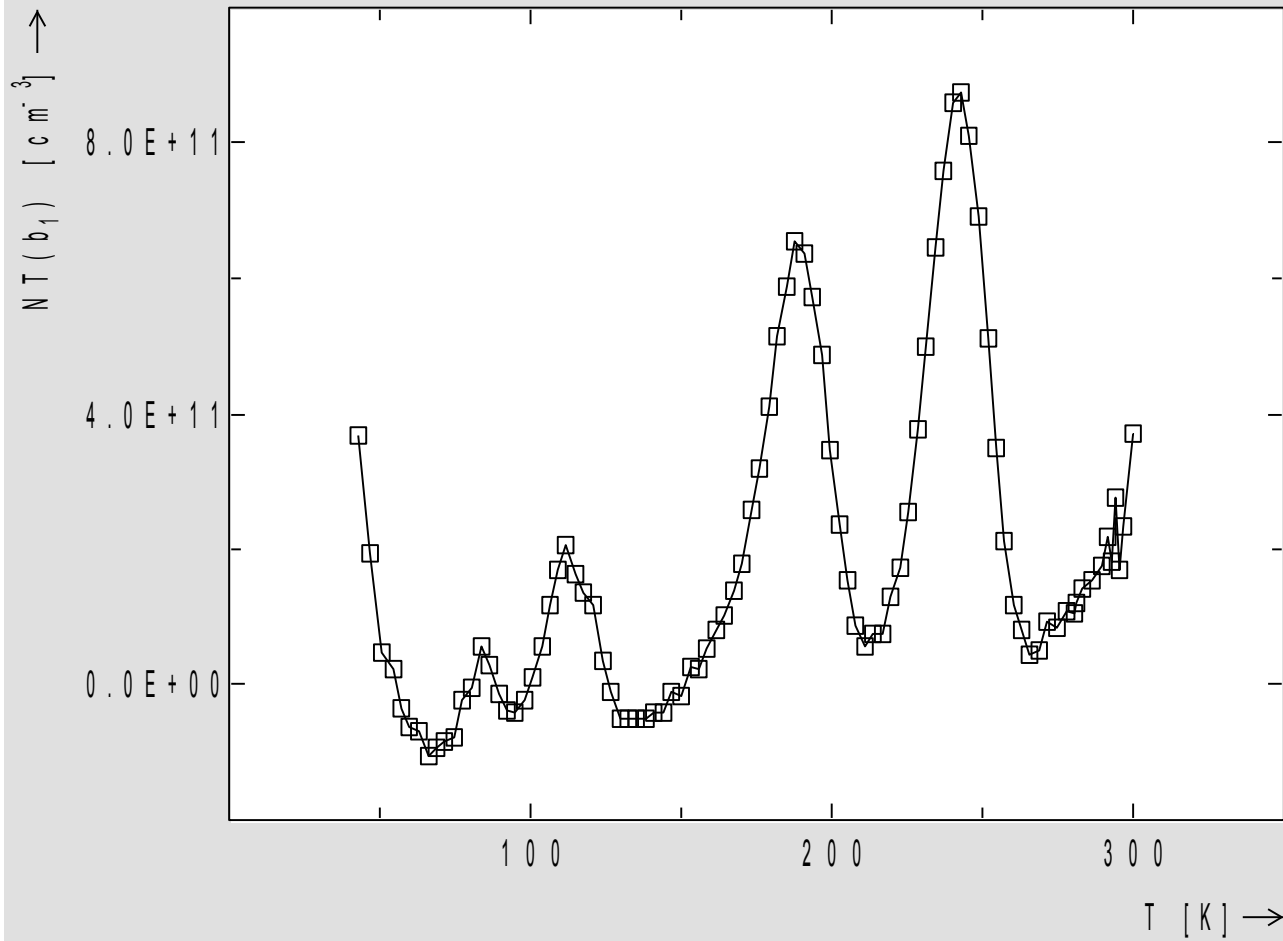
Name      = Double-Sqr
ArNo.    = 16          Points    = 512
Tw       = 2.048E-01s  t0      = 2.800E-03s
Tw/t0-eff = 7.314E+01
AmpMax   = 4.463E-02   tauMax/Tw = 1.232E-01
tauMax   = 2.523E-02s  TempMax  = 169.50 K
Integ    = 3.493E-02   <tau/Tw> = 1.358E-01
Width    = 7.140E-01   WidthRat = 1.063E+00
SNR      = 1.489E-01
  
```





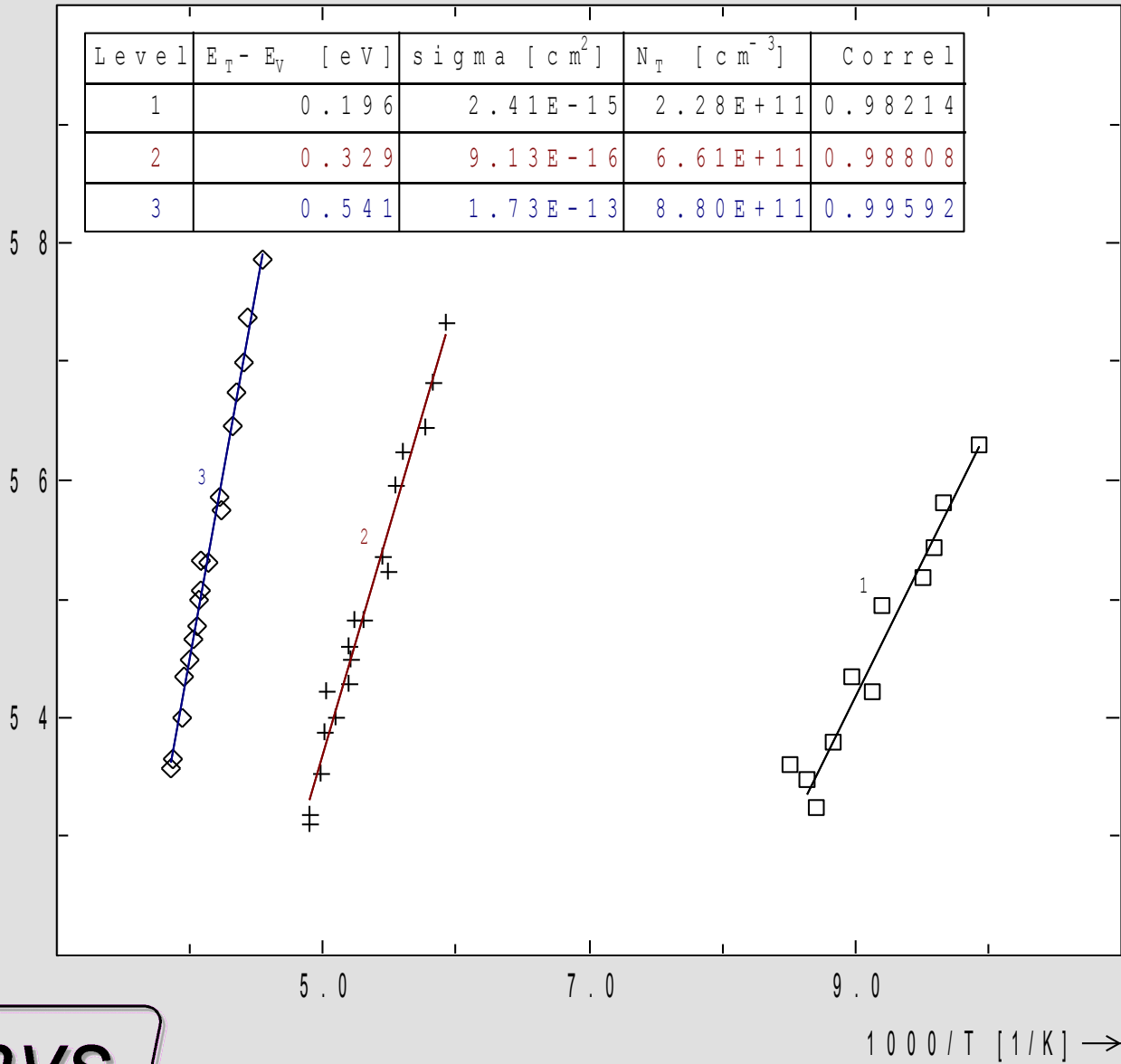
Name = @A_001.T1A
ID = ID
rcID = 1A11
Date = 2007-05-10
Type = n-Si
Area = 8.00E-03 cm²
N_S = 2.00E+15 cm⁻³
t₀ = 224.00 us
T_W = 2.05 ms
t_P = 100.00 us
U_R = -3.00 V
U_P = 0.01 V



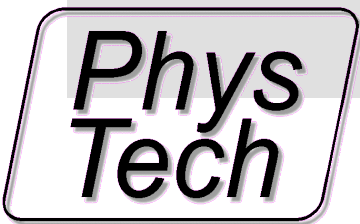


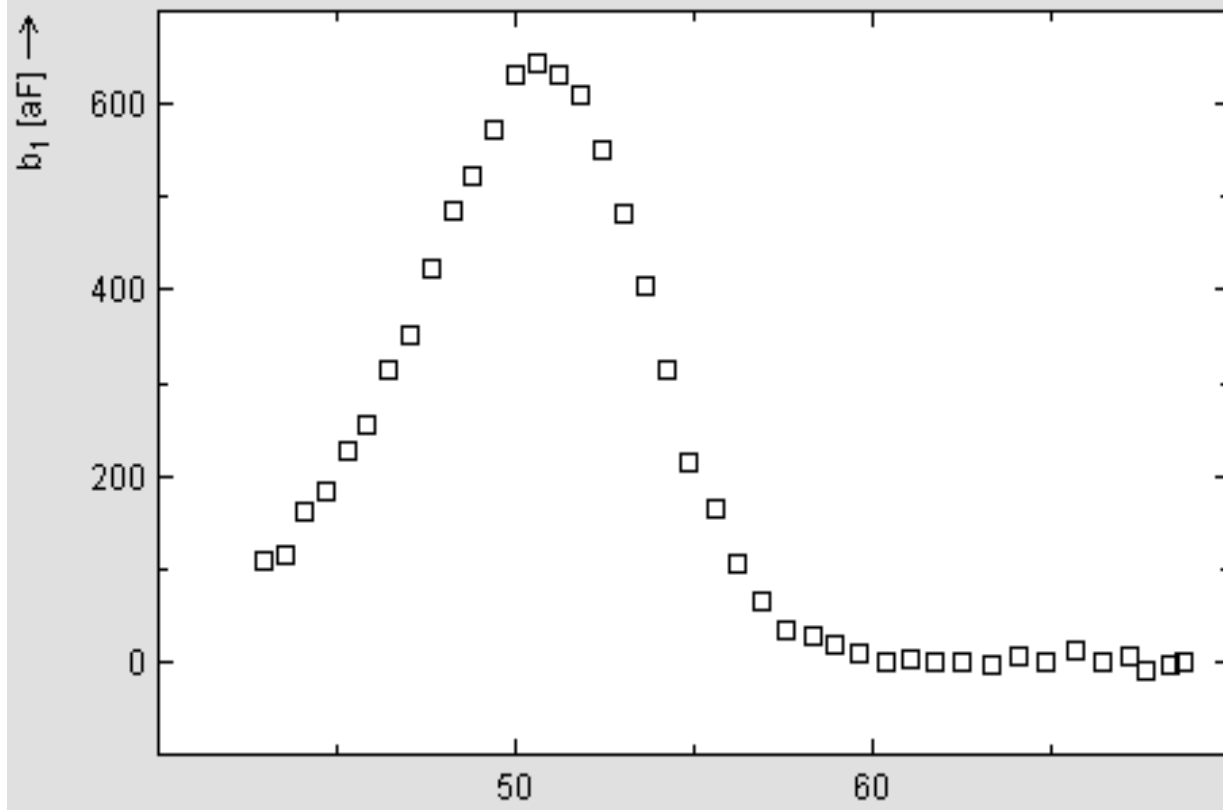
Name = @A_003.T2A
 Comm = Comment
 ID = 26287
 rclD = 0000*
 Date = 2003-01-15
 Type = p-Si
 Area = $9.08 \times 10^{-3} \text{ cm}^2$
 $N_s = 8.00 \times 10^{15} \text{ cm}^{-3}$
 $t_0 = 1.16 \text{ ms}$
 $TW = 20.48 \text{ ms}$
 $t_p = 450.00 \text{ us}$
 $U_R = 6.00 \text{ V}$
 $U_P = 1.00 \text{ V}$

↑
 $\ln(\tau_{th} \cdot v_{th} \cdot N_V)$



Name = @A_003.ATA
 Comm = Comment
 ID = 26287
 rclD = 0000*
 Date = 2003-01-15
 Type = p-Si
 Area = $9.08 \text{E} - 03 \text{ cm}^2$
 $N_s = 8.00 \text{E} + 15 \text{ cm}^{-3}$
 $t_p = 450.00 \text{ us}$
 $U_R = 6.00 \text{ V}$
 $U_P = 1.00 \text{ V}$





Name = @C_004.T1A
ID = 0918-1
rcID = 1A41*
Date = 18.09.2014
Type = p-Si
Area = 7.85E-03 cm²
N_s = 2.28E+15 cm⁻³
t₀ = 1.29 ms
T_{wr} = 19.97 ms
t_p = 20.00 us
U_R = 5.00 V
U_p = 1.00 V

Emission Transient Measurement

C: $f(t)$ [T,V,P,...]
I: $f(t)$ [T,V,P,...]

Correlation DLTS

Direct DLTS

Π evaluation

28 correlation functions
28 Tempscan signals

Π evaluation
Fourier analysis

Π evaluation
inverse Laplace
transformation

Tempscan
HERA
deconvolution

Arrhenius Plot ($\ln(I)$ vers. $1/T$)
E, Q, NT

Exponential Time Dependence

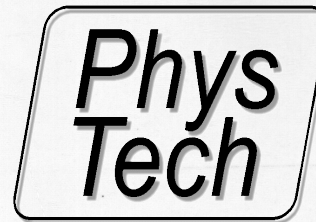
$$f(t) = A \exp\left(-\frac{t+t_0}{\tau}\right) + B \quad A : \text{amplitude, } \tau : \text{time constant, } B : \text{offset}$$

Fourier coefficients:

$$a_0 = \frac{2A}{T_W} \exp\left(-\frac{t_0}{\tau}\right) \left(1 - \exp\left(-\frac{T_W}{\tau}\right)\right) \tau + 2B$$

$$a_n = \frac{2A}{T_W} \exp\left(-\frac{t_0}{\tau}\right) \left(1 - \exp\left(-\frac{T_W}{\tau}\right)\right) \frac{\frac{1}{\tau}}{\frac{1}{\tau^2} + n^2\omega^2} \quad \text{cosine coefficient}$$

$$b_n = \frac{2A}{T_W} \exp\left(-\frac{t_0}{\tau}\right) \left(1 - \exp\left(-\frac{T_W}{\tau}\right)\right) \frac{n\omega}{\frac{1}{\tau^2} + n^2\omega^2} \quad \text{sine coefficient}$$



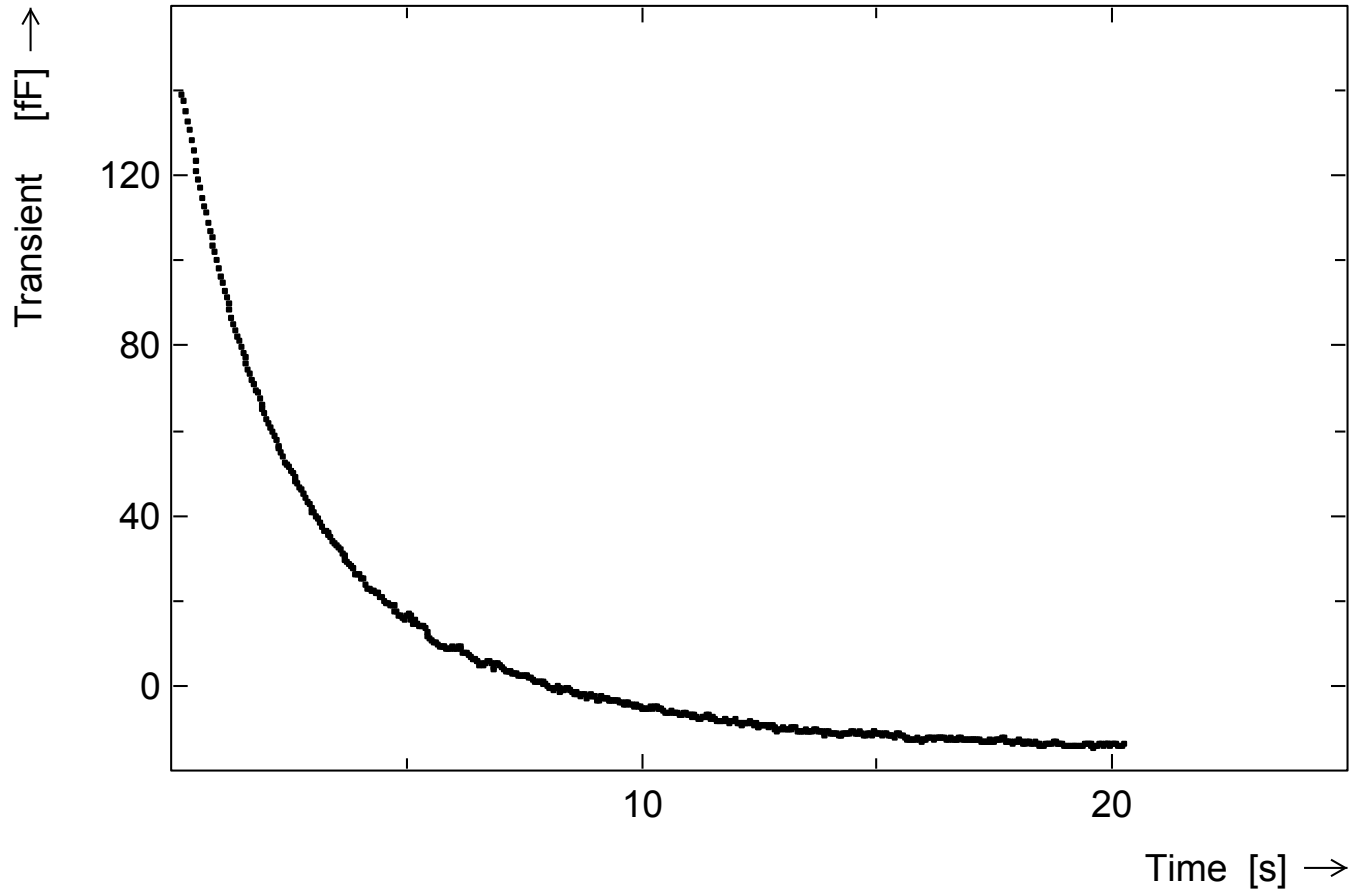
calculation of time constant:

$$\text{a) } \tau(a_n, a_k) = \frac{1}{\omega} \sqrt{\frac{a_n - a_k}{k^2 a_k - n^2 a_n}} \quad \text{from cosine coefficient}$$

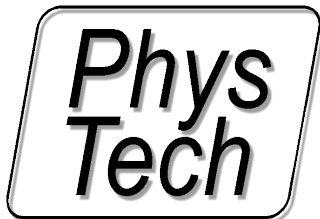
$$\text{b) } \tau(b_n, b_k) = \frac{1}{\omega} \sqrt{\frac{k b_n - n b_k}{k^2 n b_k - n^2 k b_n}} \quad \text{from sine coefficient}$$

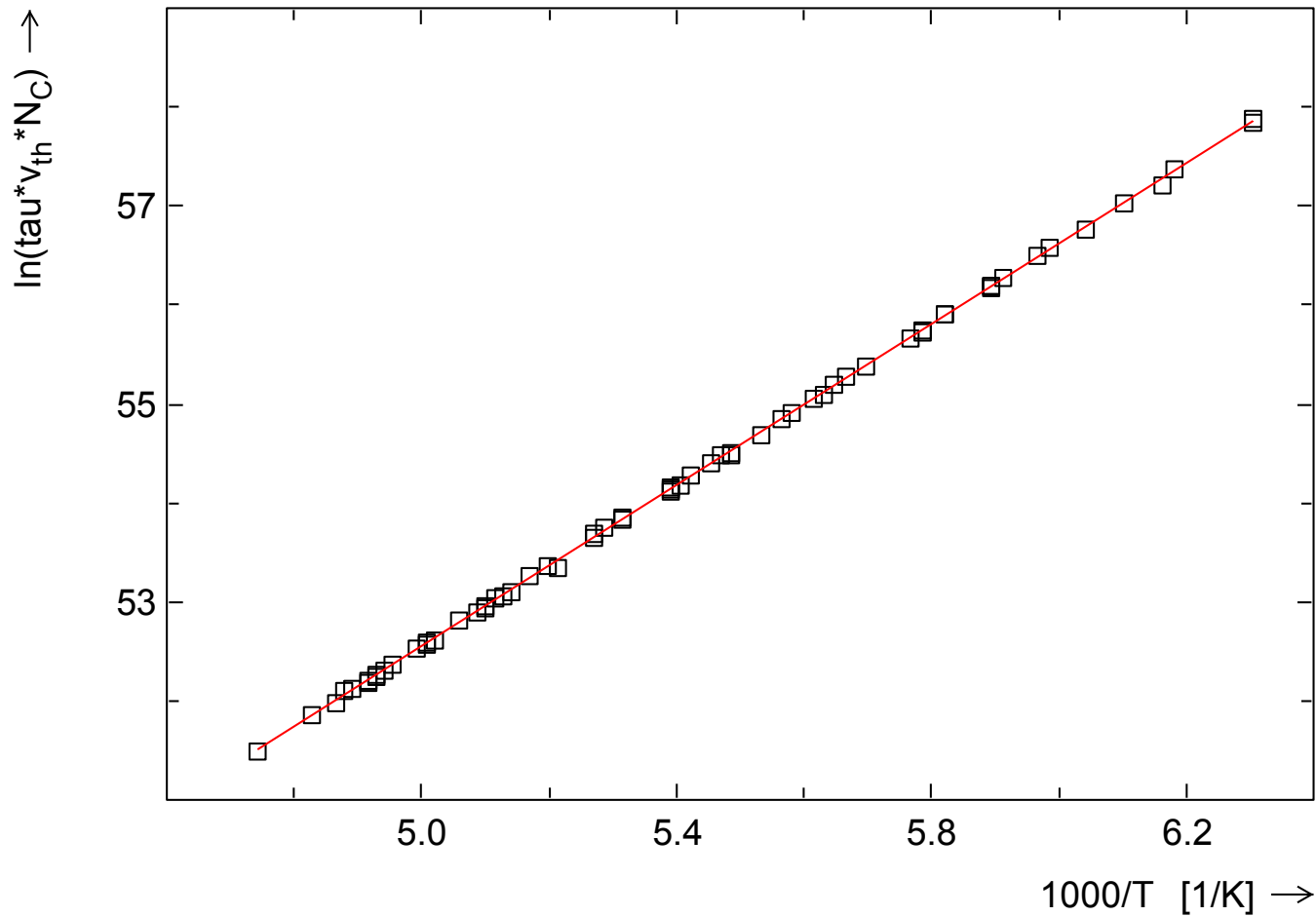
$$\text{c) } \tau(a_n, b_n) = \frac{1}{n\omega} \frac{b_n}{a_n} \quad \text{from cosine and sine coefficient}$$

tau(a1,b1) =	3.206 s	Amplitude =	139.409 fF
tau(a2,b2) =	2.664 s	NT	= 3.09E+15 cm ⁻³
tau(b1,b2) =	2.368 s	NTs	= 7.44E+15 cm ⁻³
tau(a1,a2) =	3.163 s	Energy	= 0.636 eV
tau(Tw/4) =	2.341 s	tau,ts/Tw	= 0.16,1.31
tau(Tw'/2) =	2.860 s	ExpClass	= 0.83
tau(a0,b1) =	4.641 s	TauClass	= 44

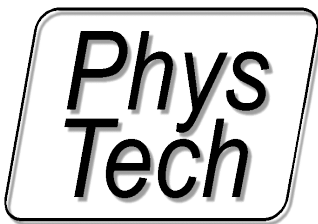


Name	=	@A_003.YEA
Comm	=	J7
ID	=	GANA18
rcID	=	1020
Date	=	29.10.2004
Type	=	n-GaN*
Area	=	3.14E-04 cm ²
N _S	=	2.07E+17 cm ⁻³
Temp	=	250.00 K
T _W	=	20.00 s
t _P	=	100.00 us
U _R	=	-3.00 V
U _P	=	-0.10 V
C _R	=	18.67 pF
I _R	=	-1.61 nA



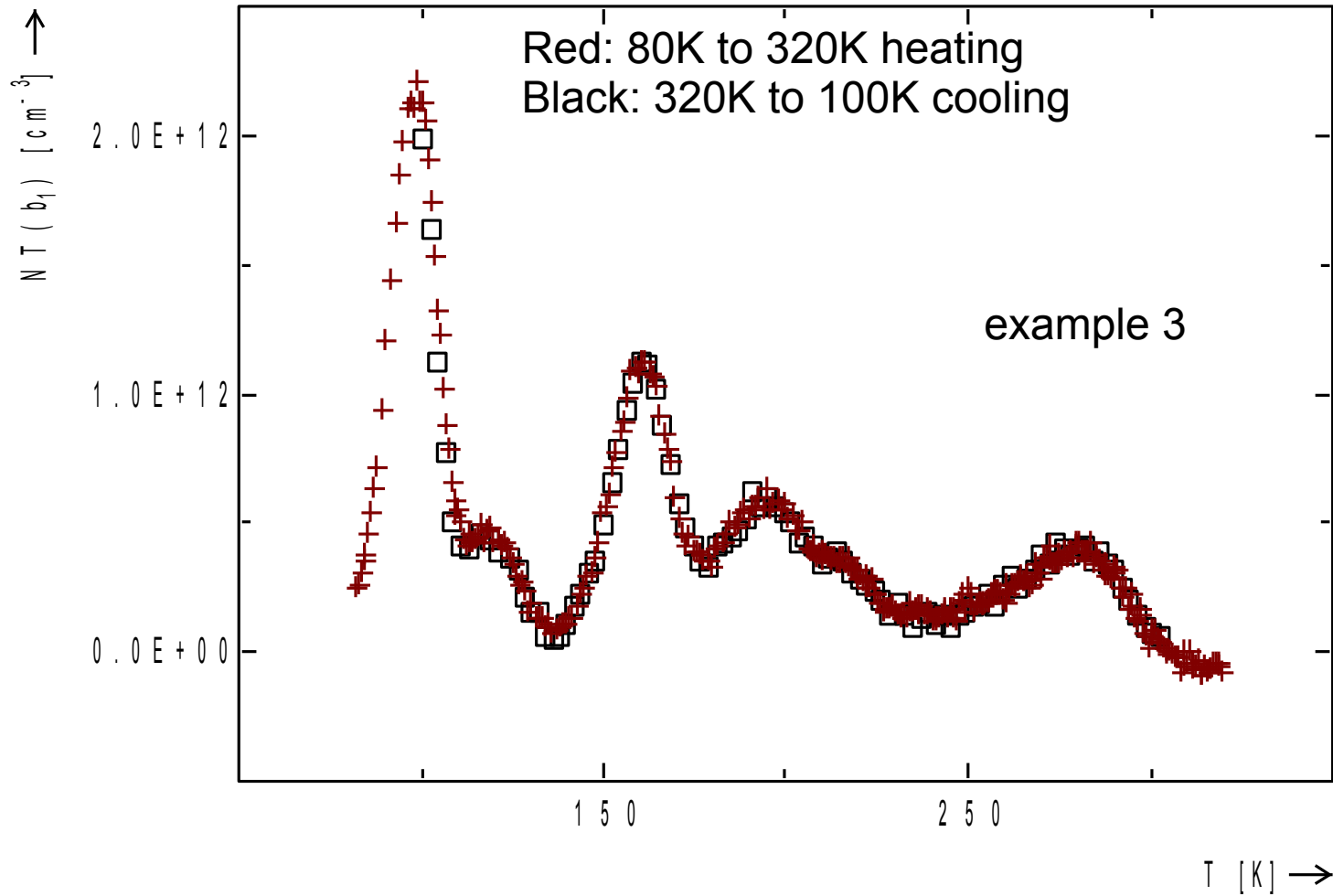


Name	=	@A_002.ATA
ID	=	ID
rcID	=	A001
Date	=	2007-05-10
Type	=	n-Si
Area	=	8.00E-03 cm ²
N _S	=	2.00E+15 cm ⁻³
t _p	=	100.00 us
U _R	=	-3.00 V
U _P	=	0.01 V
Energy	=	0.350 eV
sigma	=	1.01E-14 cm ²
N _T	=	7.36E+13 cm ⁻³
N _{Ts}	=	1.35E+14 cm ⁻³
x _p	=	2.82E-01 um
x _R	=	1.18E+00 um
Correl	=	0.99991

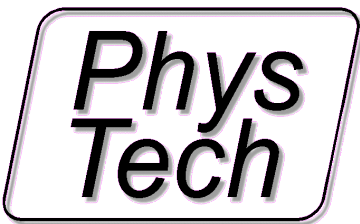


DLTS Simulation (SRH)
and
comarison with measurement results

(Physical emission process model check)

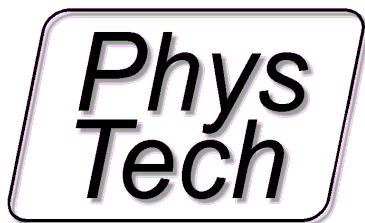
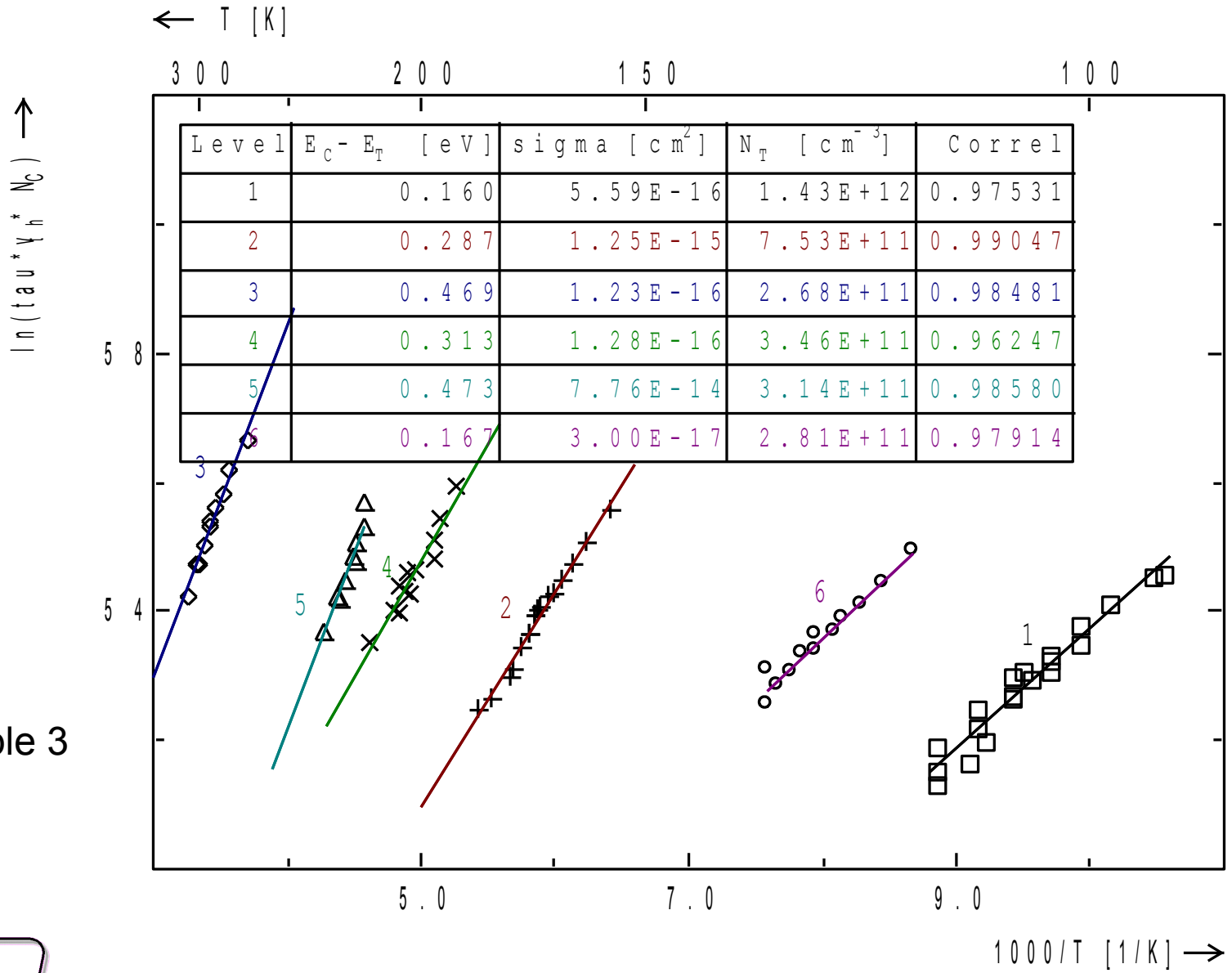


Name	= @C_002.T1A
ID	= L_xxxxx
rcID	= 1A21*
Date	= 20.07.2015
Type	= n-Si-MIS
Area	= $3.14 \times 10^{-2} \text{ cm}^2$
N_s	= $8.00 \times 10^{14} \text{ cm}^{-3}$
C_{ox}	= 100.00 pF
t_0	= 440.00 μ s
T_W	= 20.48 m s
t_p	= 80.00 μ s
U_R	= -2.00 V
U_P	= -0.01 V

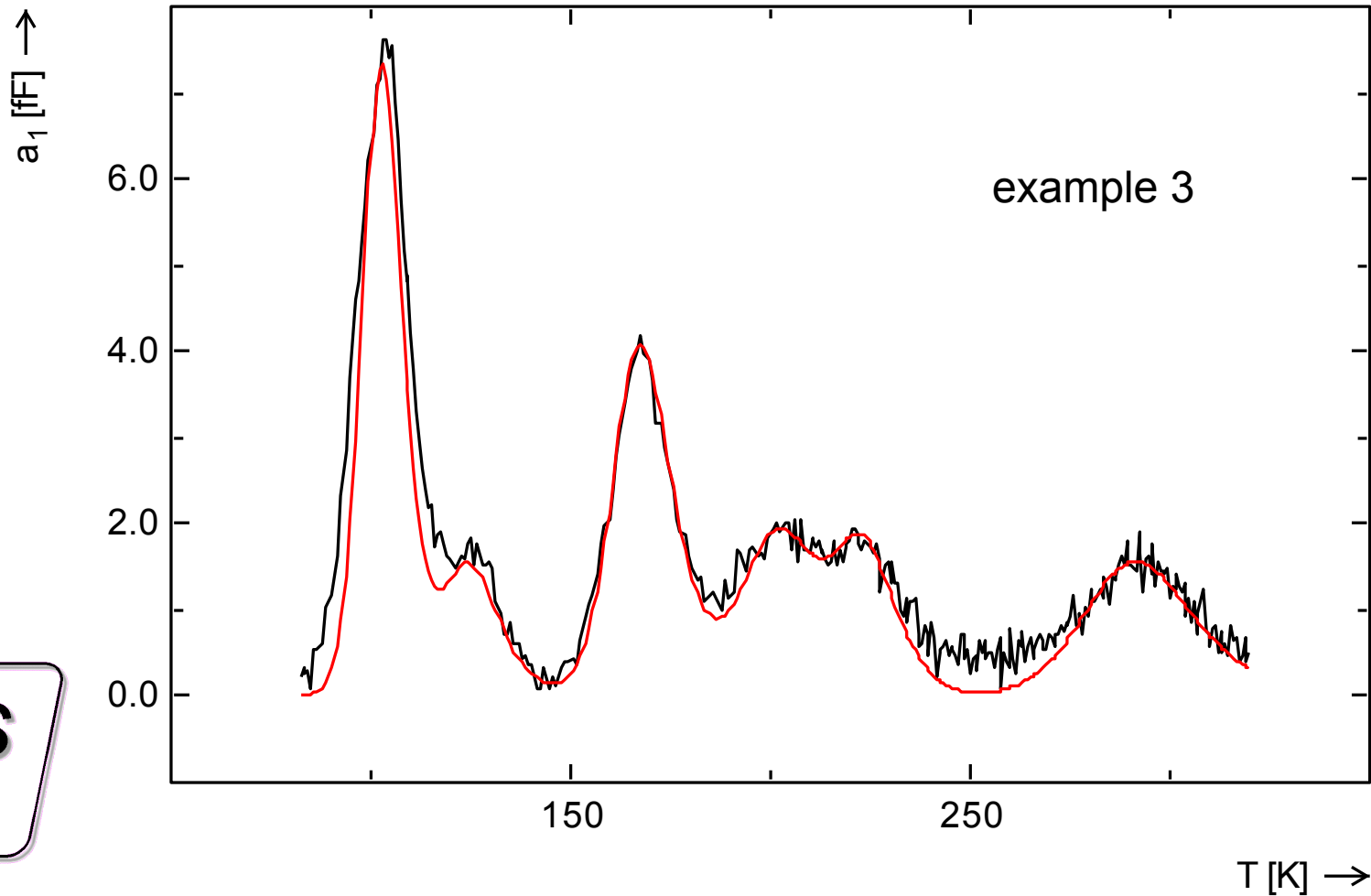


DLTS signal b_1 normalized in Trapconcentration versus temperature measured during cooling down 320K – 100K (black squares) and during heating up 80K – 320K (red crosses)

example 3



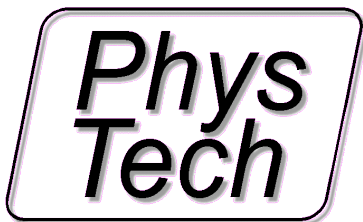
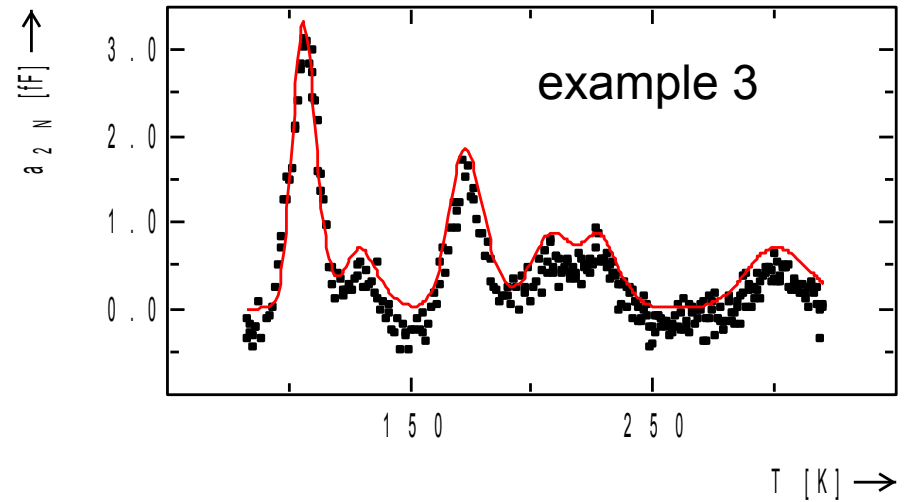
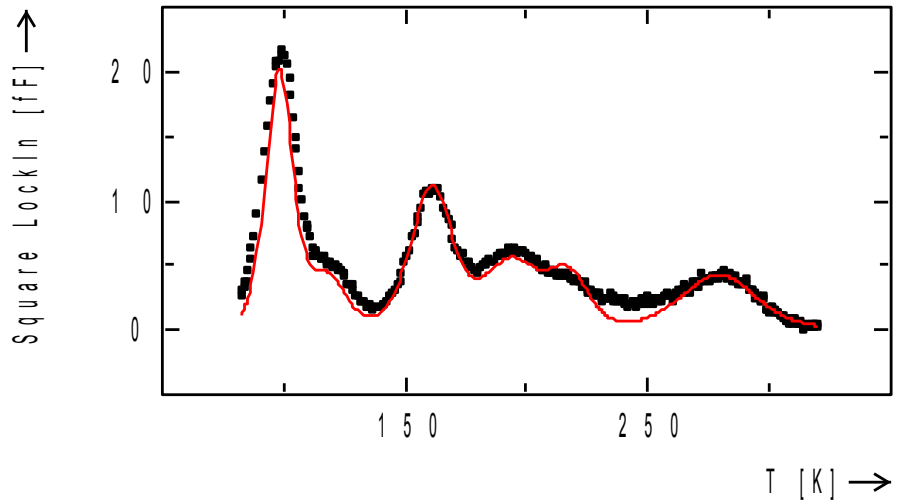
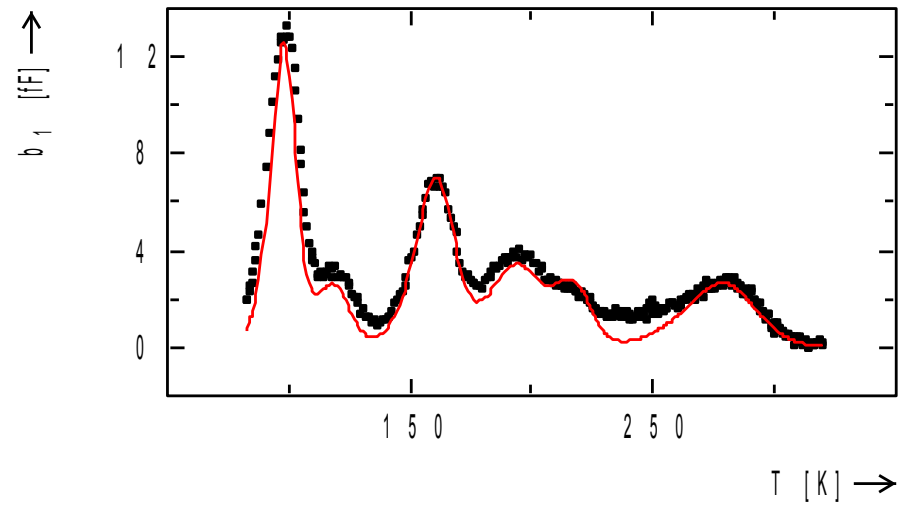
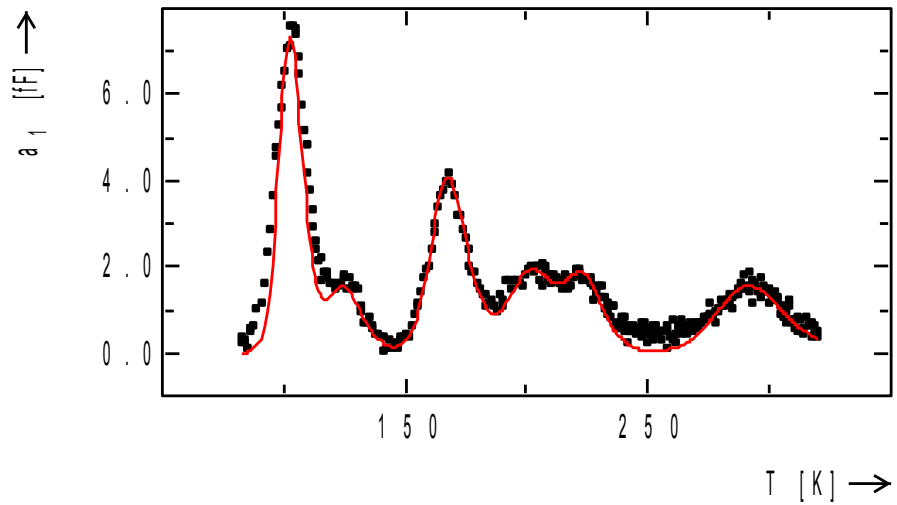
Arrhenius plot of the measurements of above plot



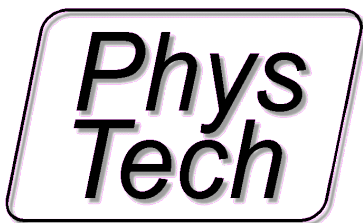
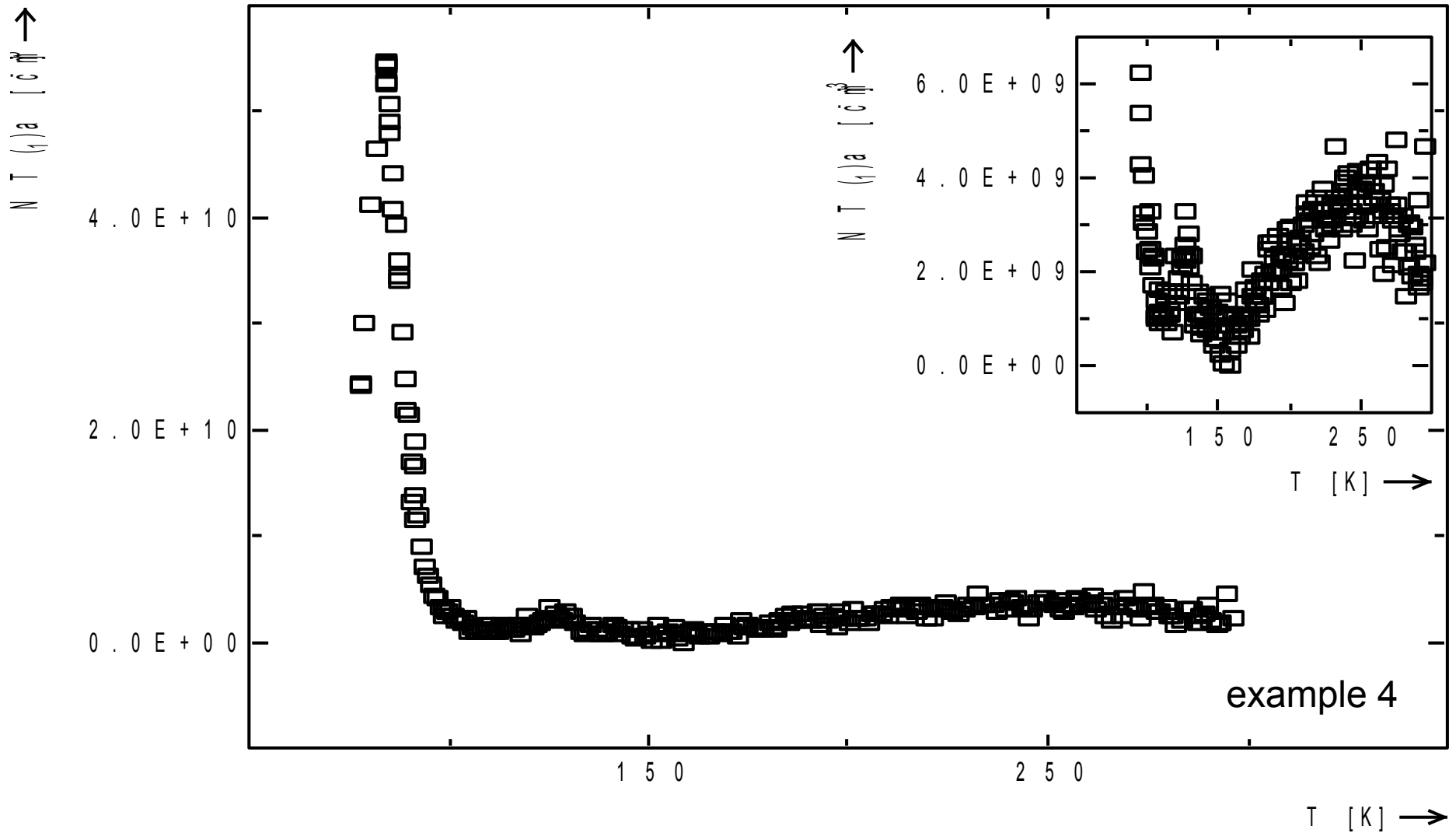
**Phys
Tech**

DLTS signal a_1 vers. temperature:
black: measured data, red: simulated data (SRH) using the Arrhenius data above.

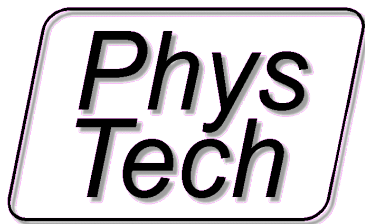
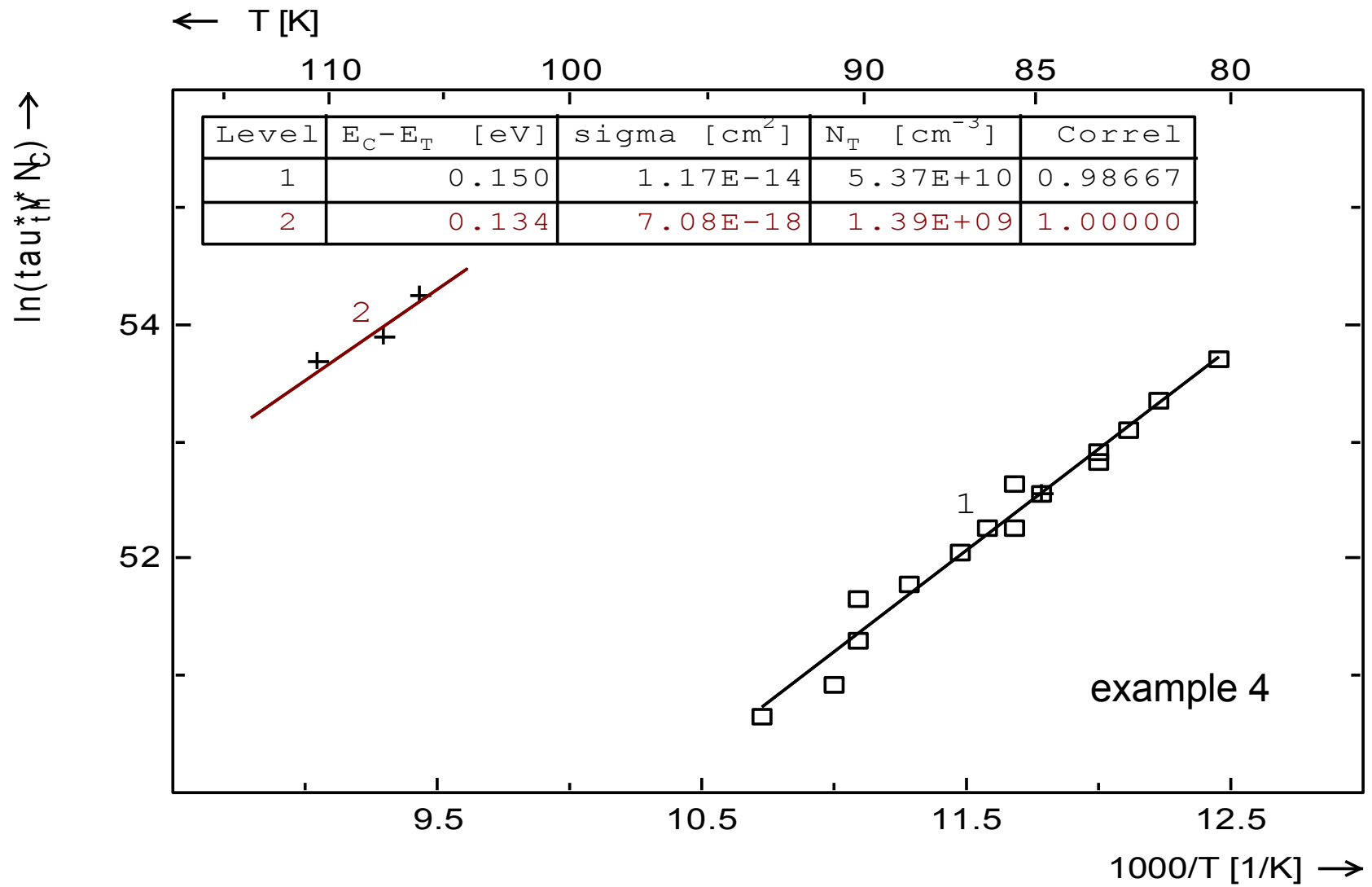
Plot 5



Different DLTS signals (DC values of different correlation functions) of the measurement (black dots) compared to the simulation of the measurements with the results of the Arrhenius plot above (red line).

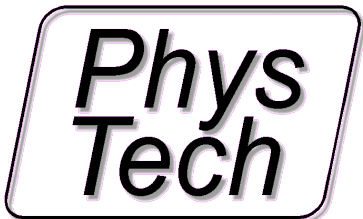
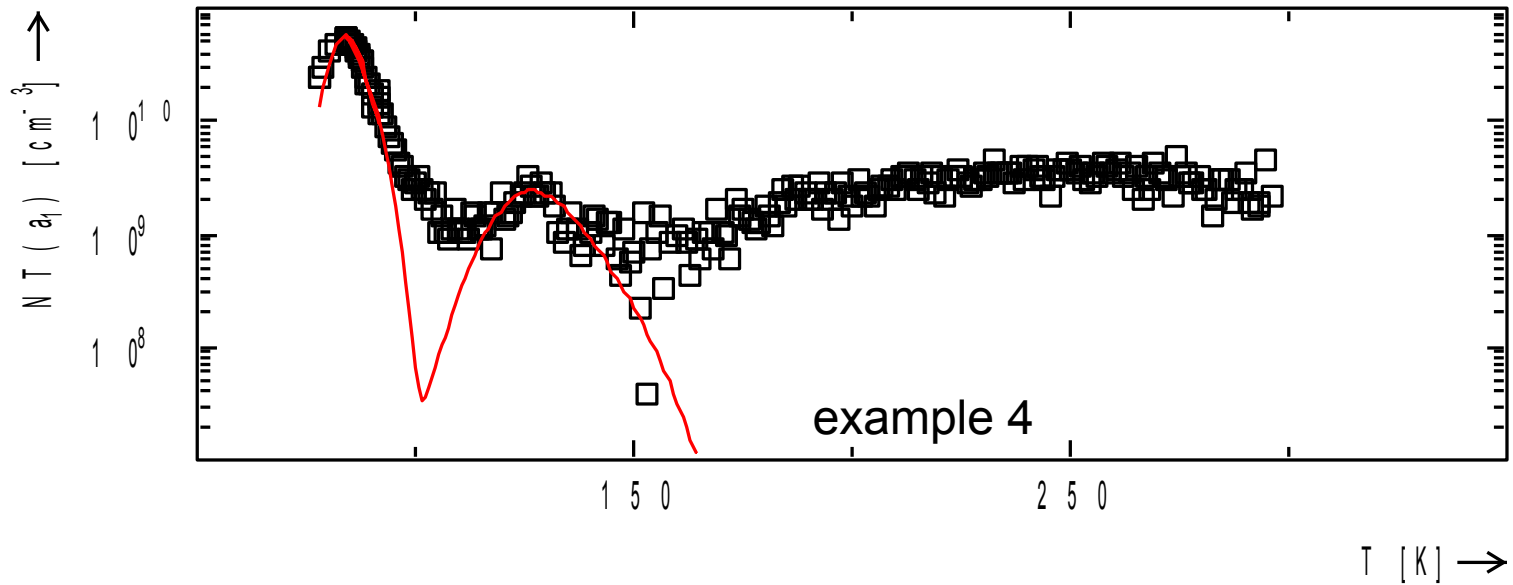
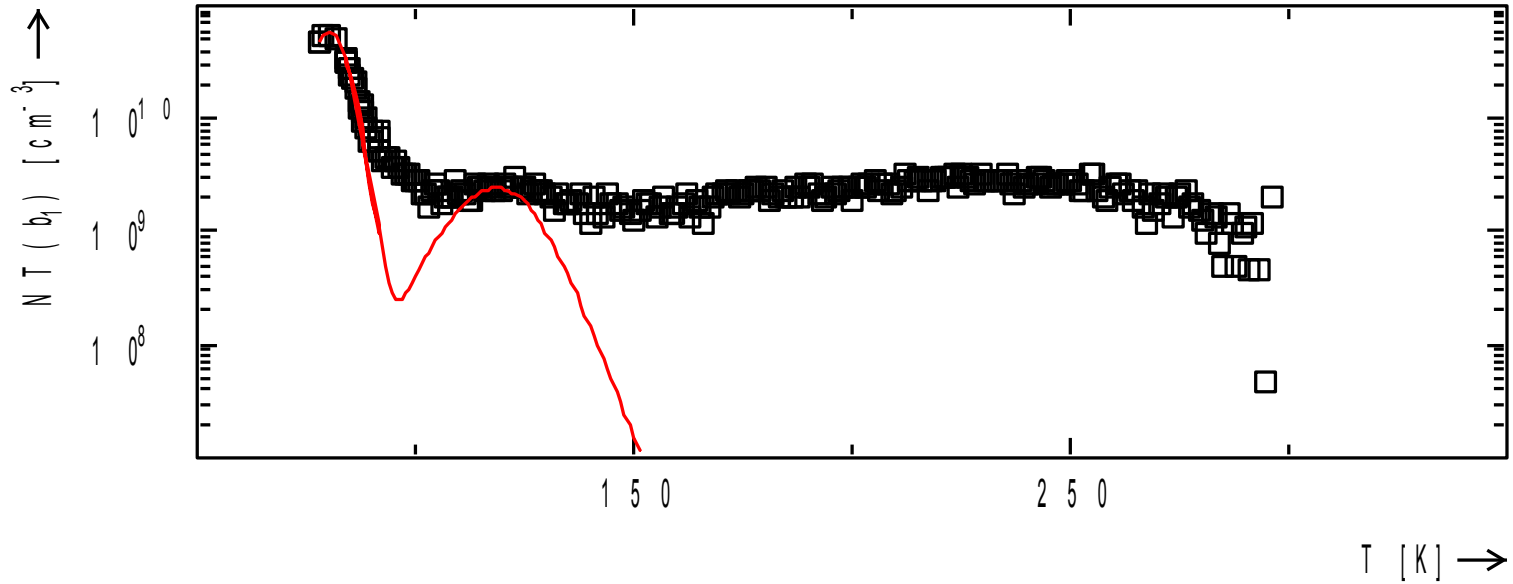


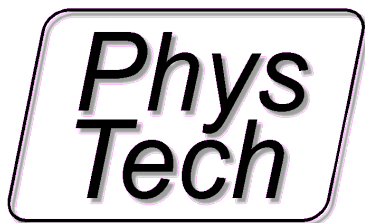
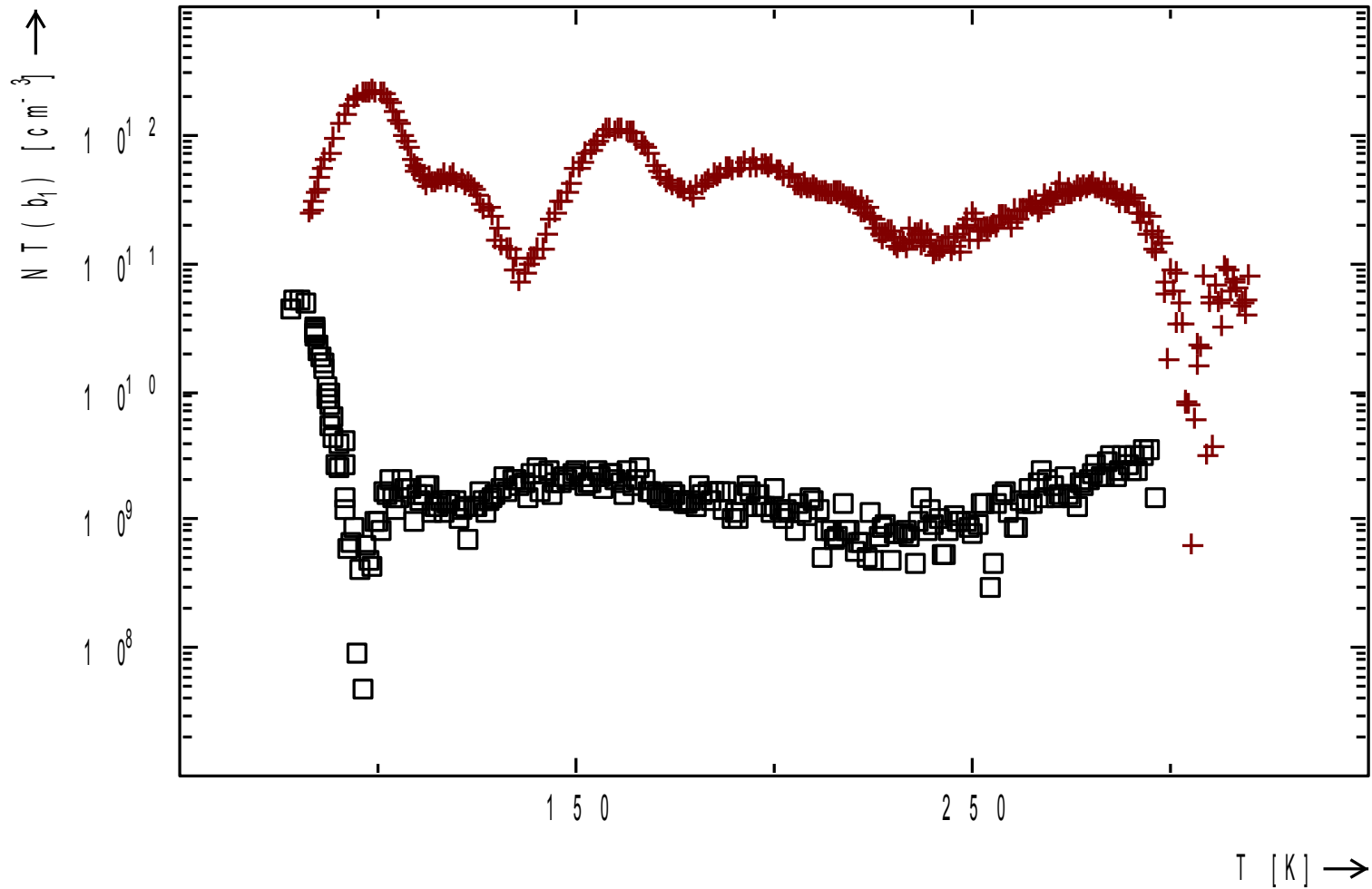
DLTS signal a1 vers. temperature (tempscan) of a Si sample inlet zoomed without main peak



Arrhenius plot of the data above
Two peaks have been evaluated

Two tempscans
(a1, b1) log scale
of above
measurement
compared with
simulated data
(SRH) using the
results from the
above Arrhenius
plot

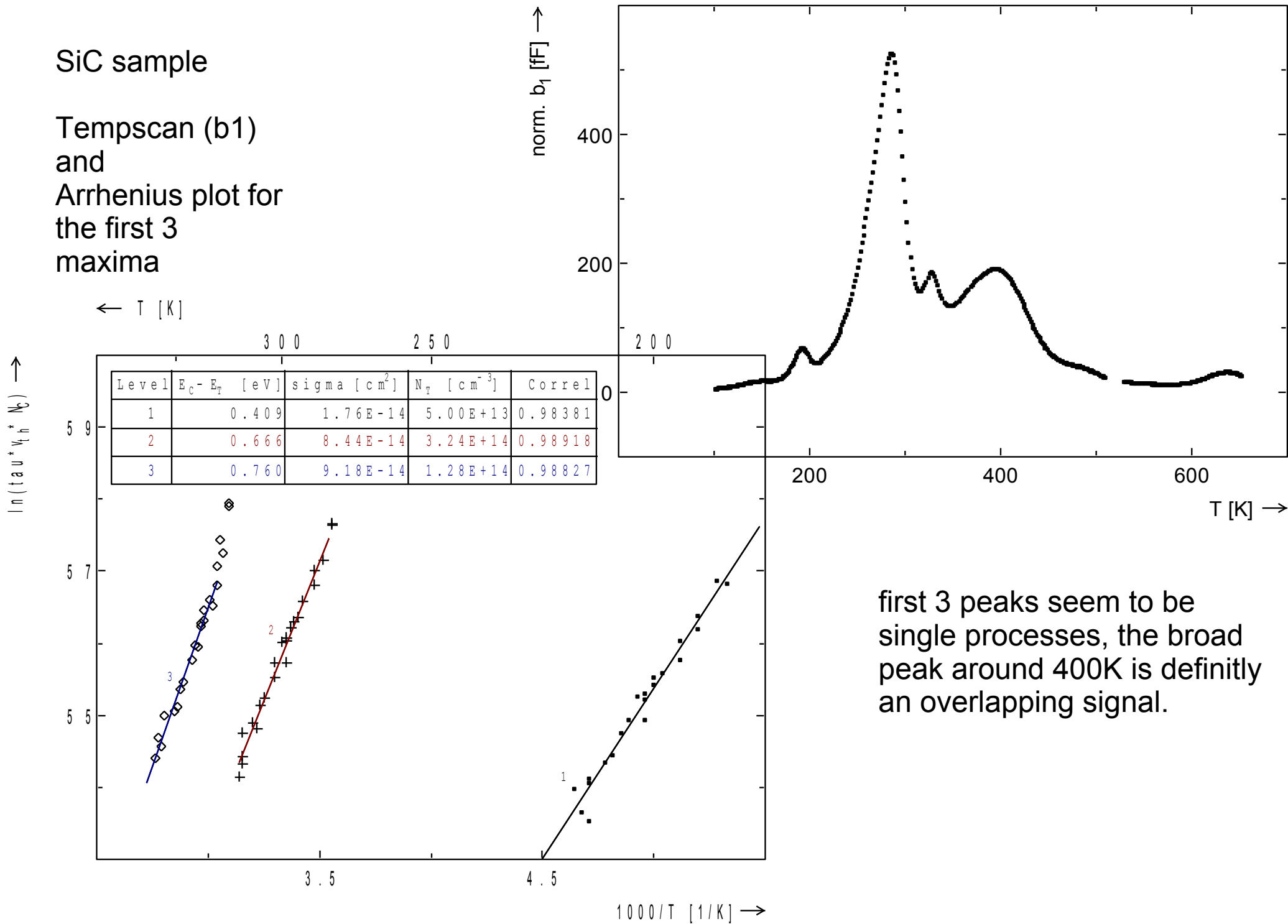




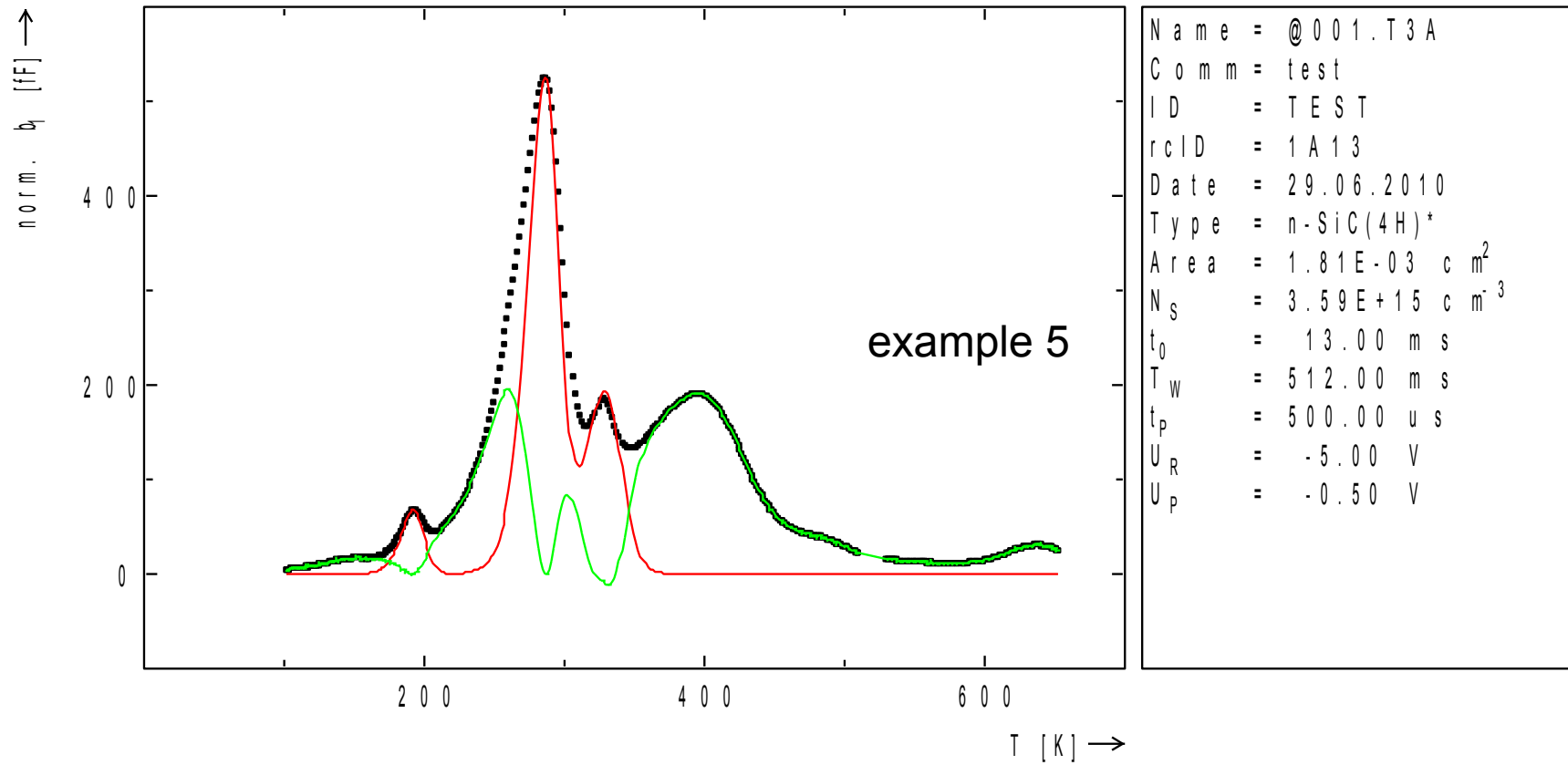
DLTS signal b_1 for example 4 (blacksquares) and example 3 (red crosses) in a logarithmic scale.

SiC sample

Tempscan (b1)
and
Arrhenius plot for
the first 3
maxima



first 3 peaks seem to be
single processes, the broad
peak around 400K is definitely
an overlapping signal.

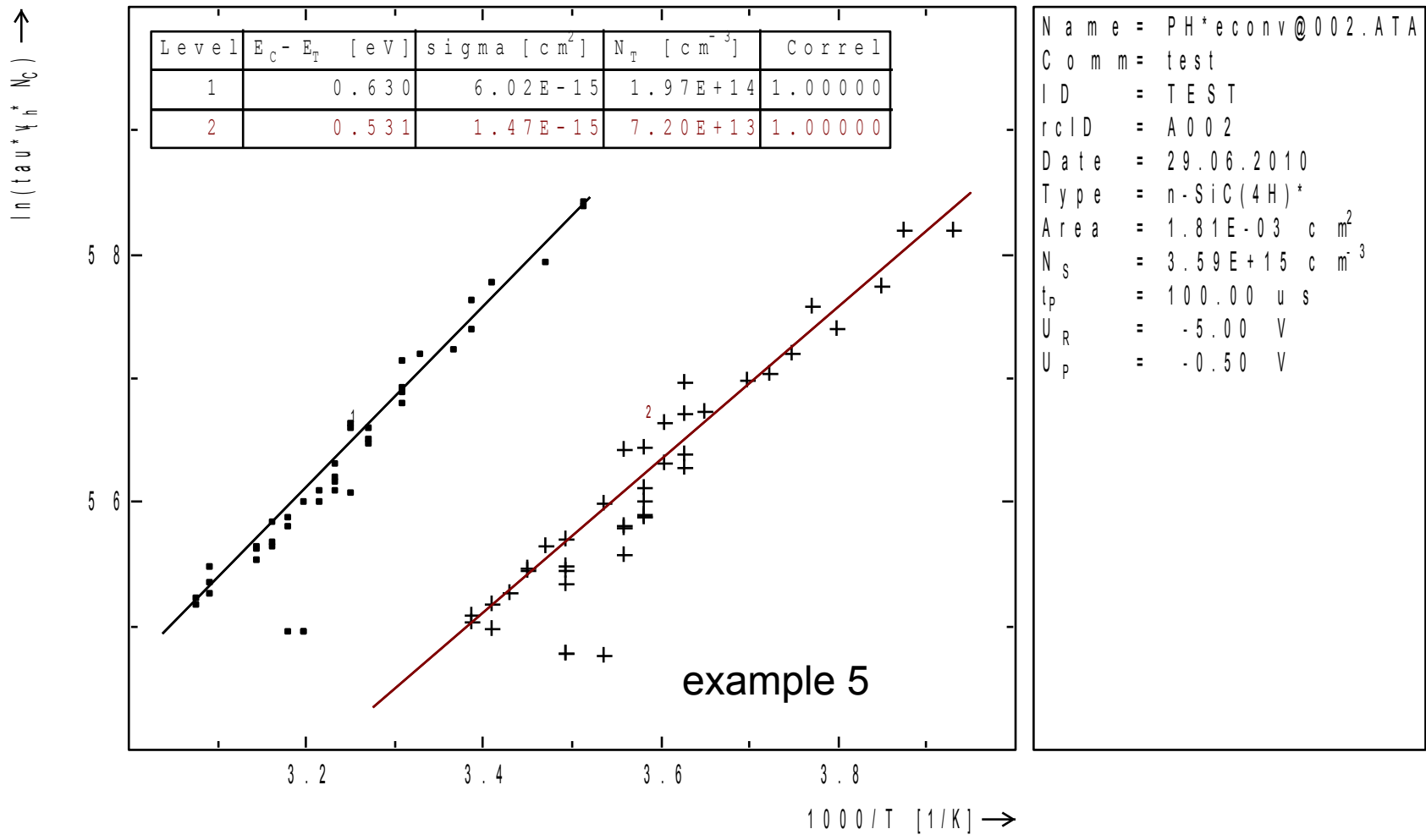


DLTS signal a1 vers. temperature:

black: measured data, red: simulated data (SRH) using the Arrhenius data above
 green: difference between black and red data.

the difference curve is used for detecting another 2 levels hidden in the main peak

the Arrhenius plot for these peaks is shown on the next page



Arrhenius plot of the evaluation of the above plot (green curve)

Emission Transient Measurement

C: $f(t)$ [T,V,P,...]
I: $f(t)$ [T,V,P,...]

Correlation DLTS

Direct DLTS

Π evaluation

28 correlation functions
28 Tempscan signals

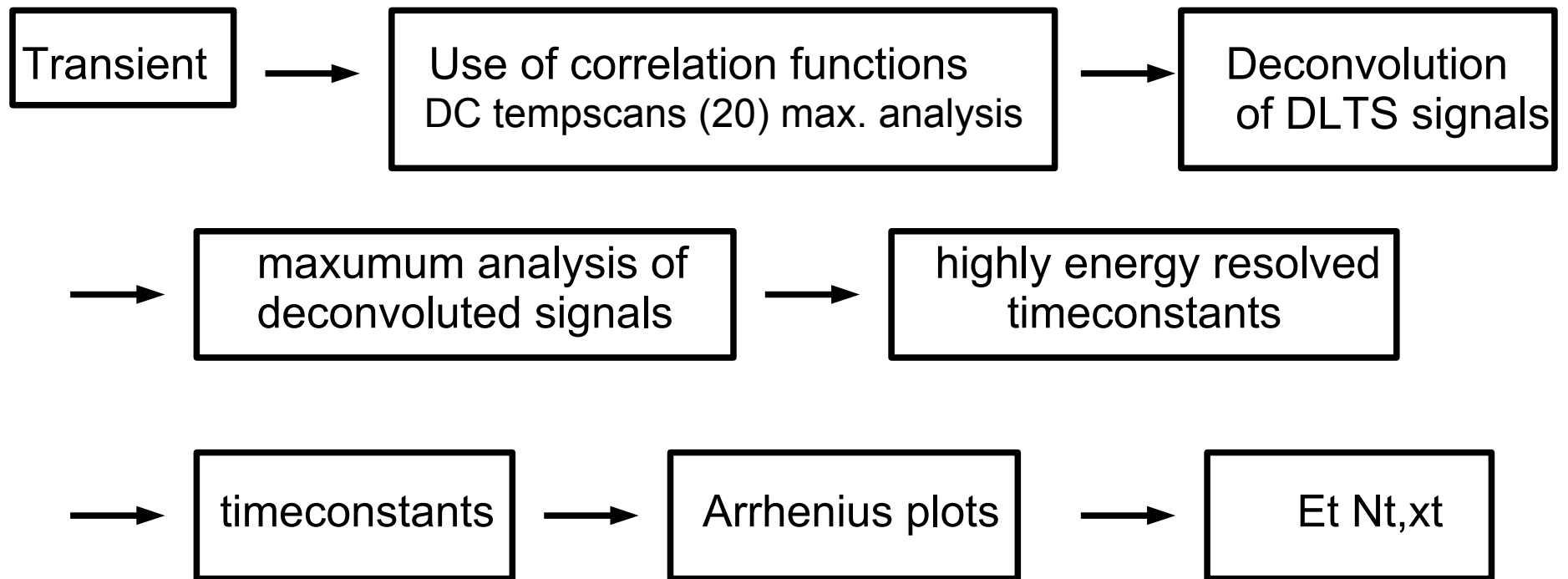
Π evaluation
Fourier analysis

Π evaluation
inverse Laplace
transformation

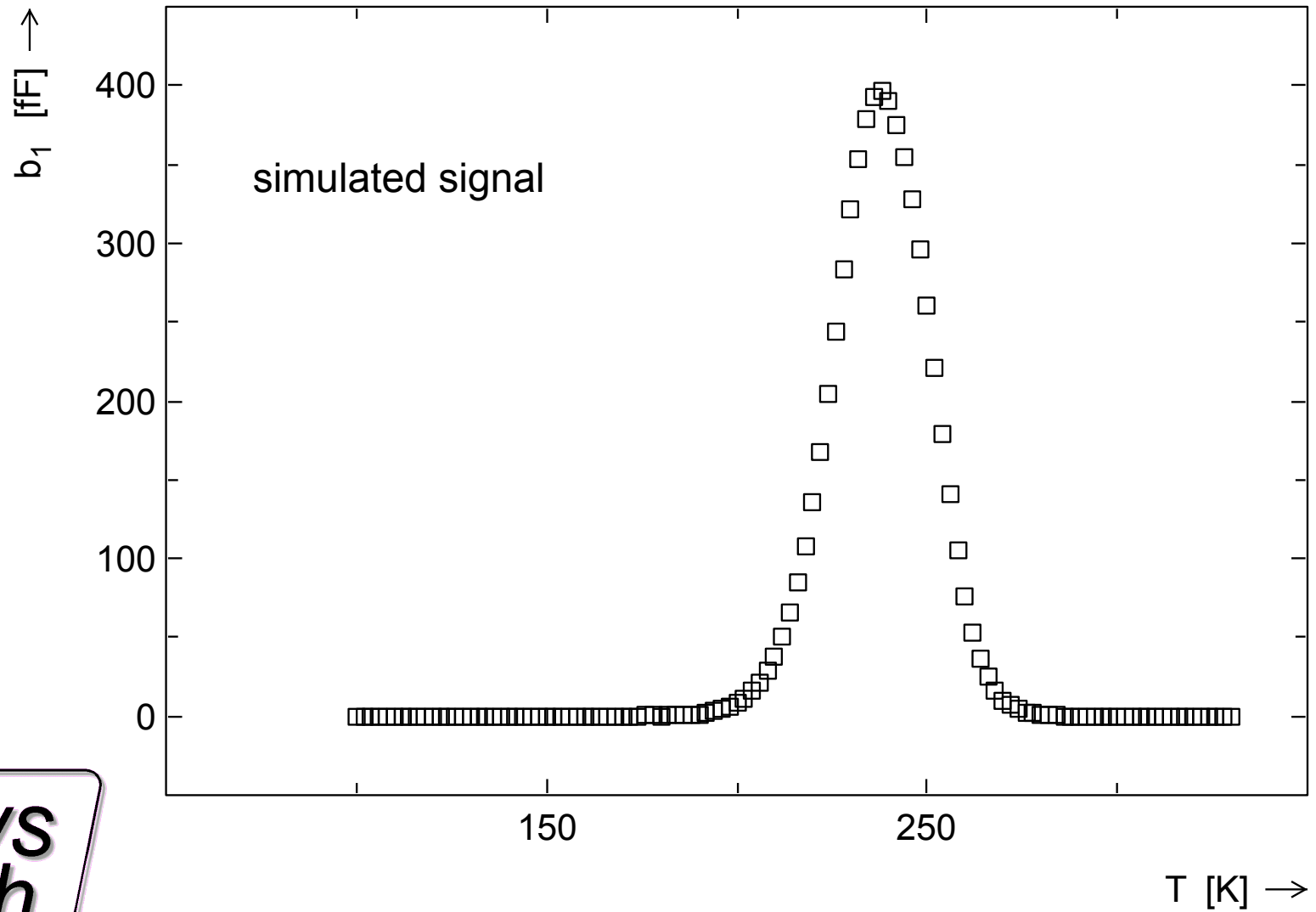
Tempscan
HERA
deconvolution

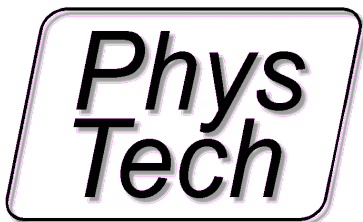
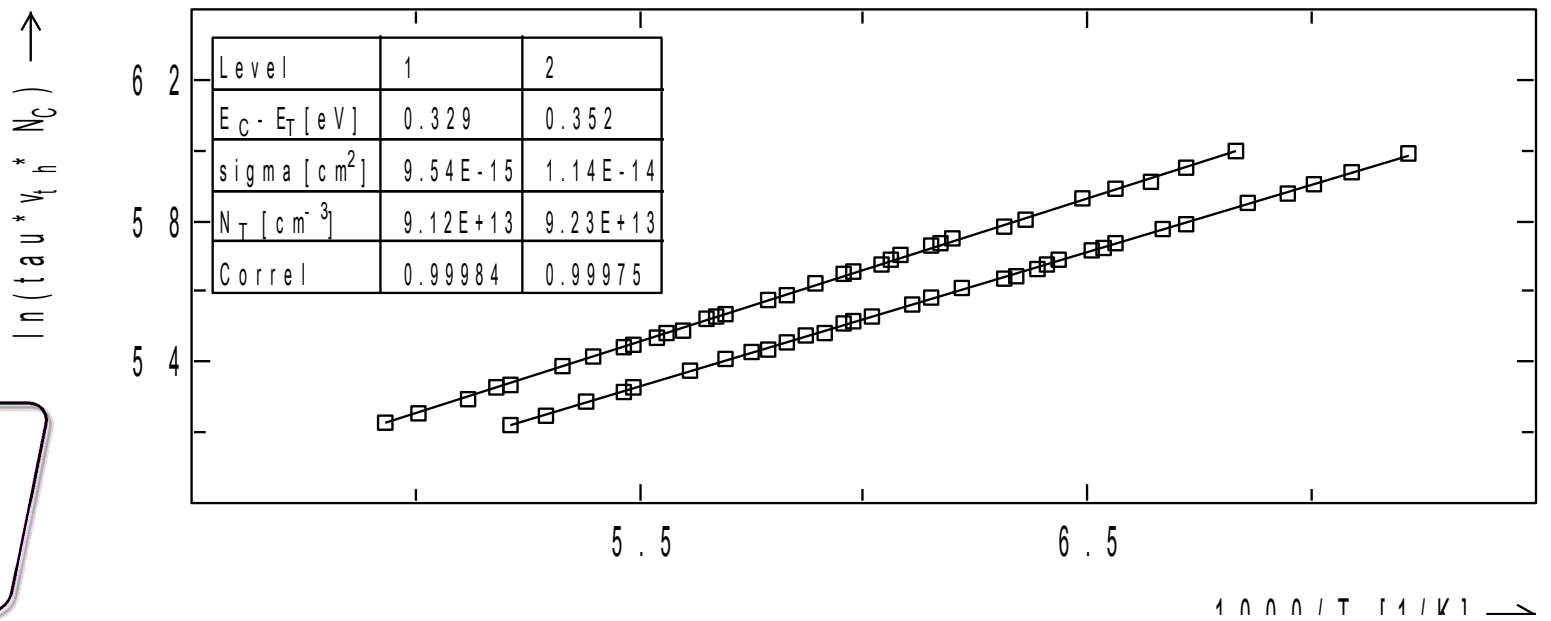
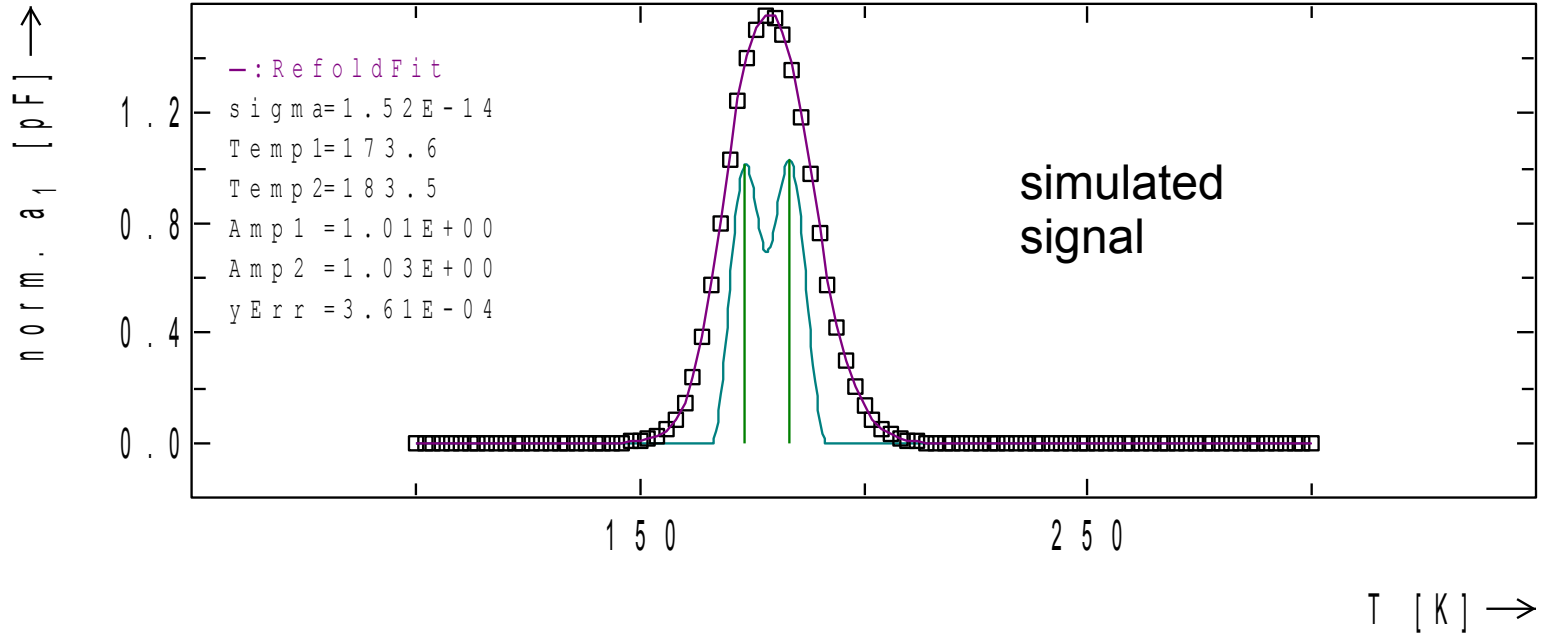
Arrhenius Plot ($\ln(I)$ vers. $1/T$)
E, Q, NT

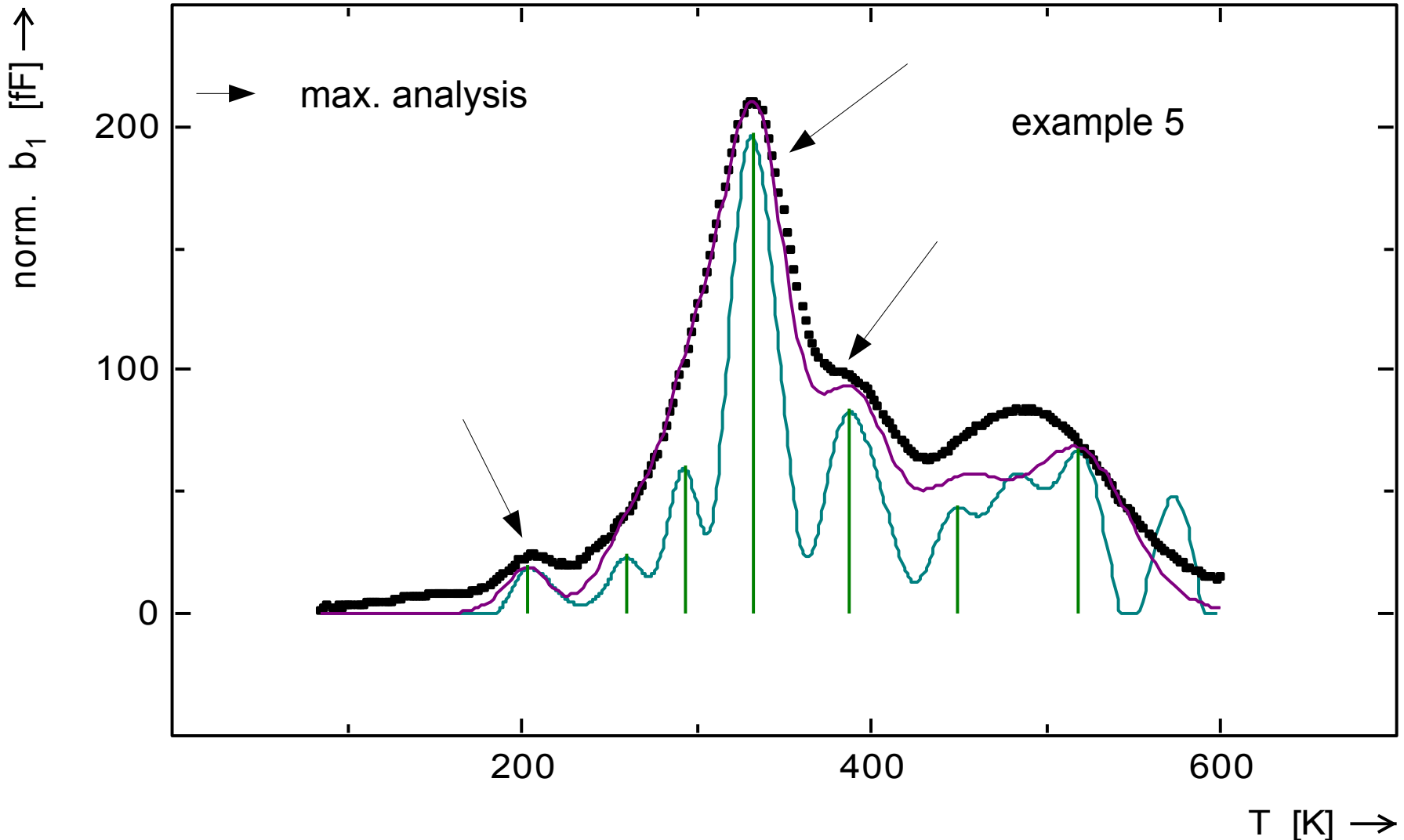
High Energy Resolution Correlation DLTS



Deconvolution of correlation DLTS signal







DC DLTS signal (b_1): black dots
 the deconvolution results of it: blue line
 marked maxima: green vertical lines
 calculated (SRH) DLTS signal (b_1): purple line

Emission Transient Measurement

C: $f(t)$ [T,V,P,...]
I: $f(t)$ [T,V,P,...]

Correlation DLTS

Direct DLTS

Π evaluation

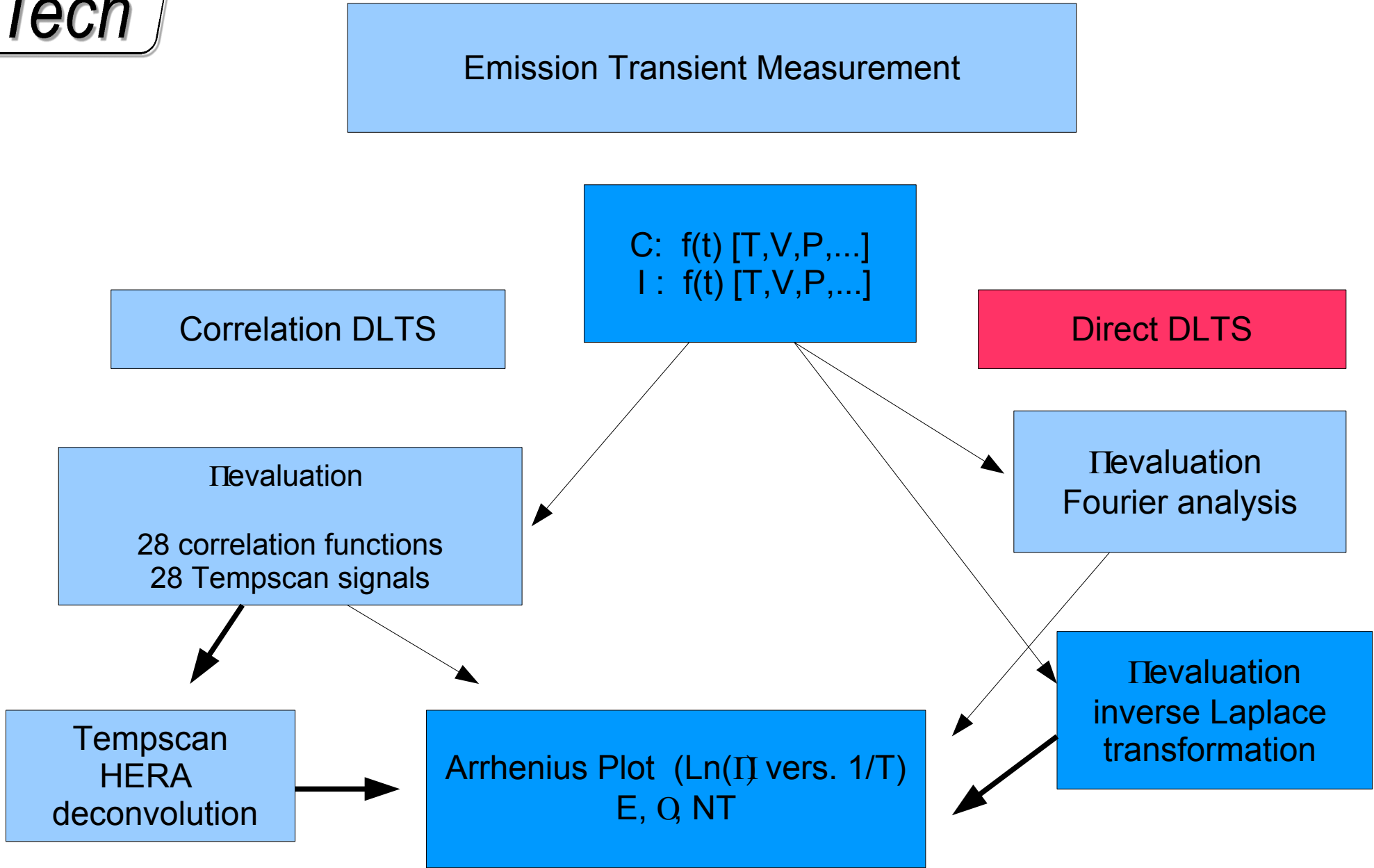
28 correlation functions
28 Tempscan signals

Π evaluation
Fourier analysis

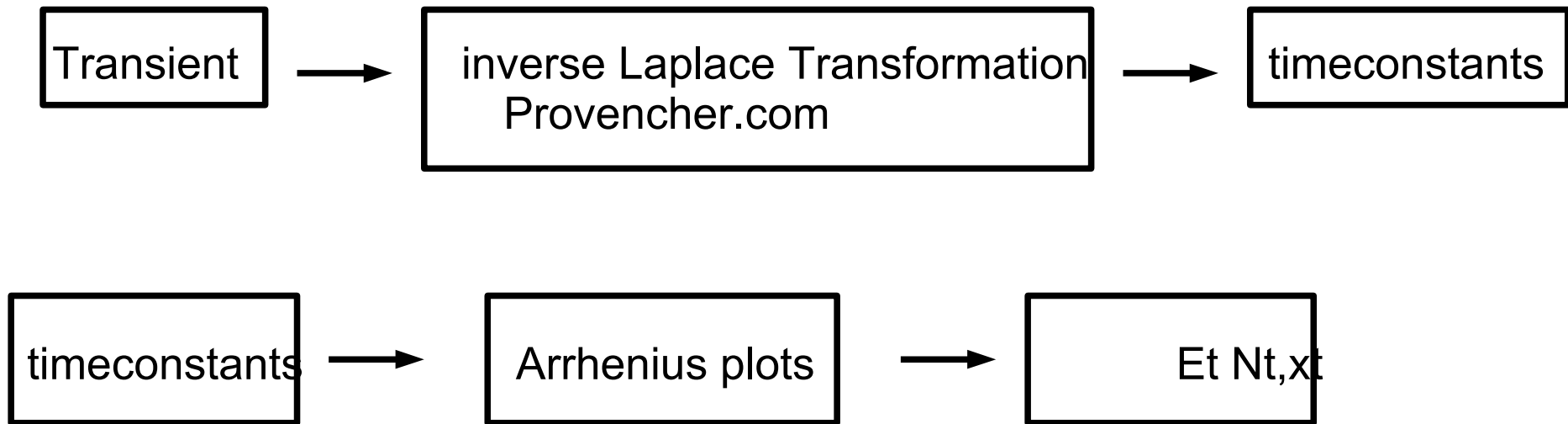
Π evaluation
inverse Laplace
transformation

Tempscan
HERA
deconvolution

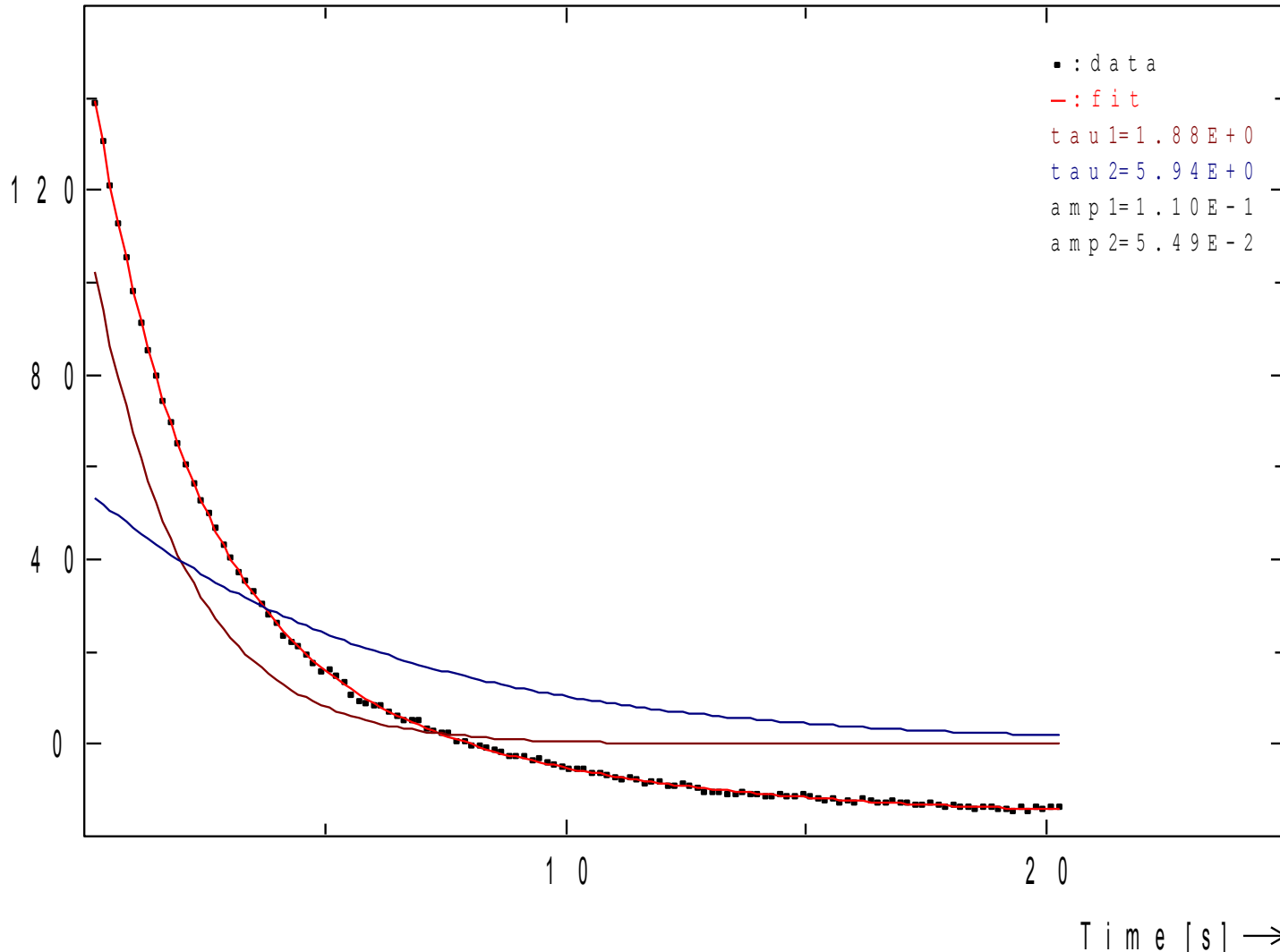
Arrhenius Plot ($\ln(I)$ vers. $1/T$)
E, Q, NT



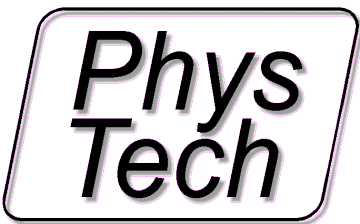
Laplace DLTS (Direct Transient Analysis)

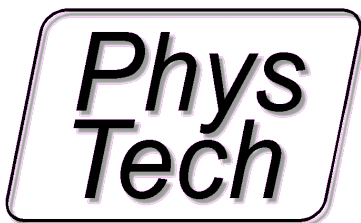
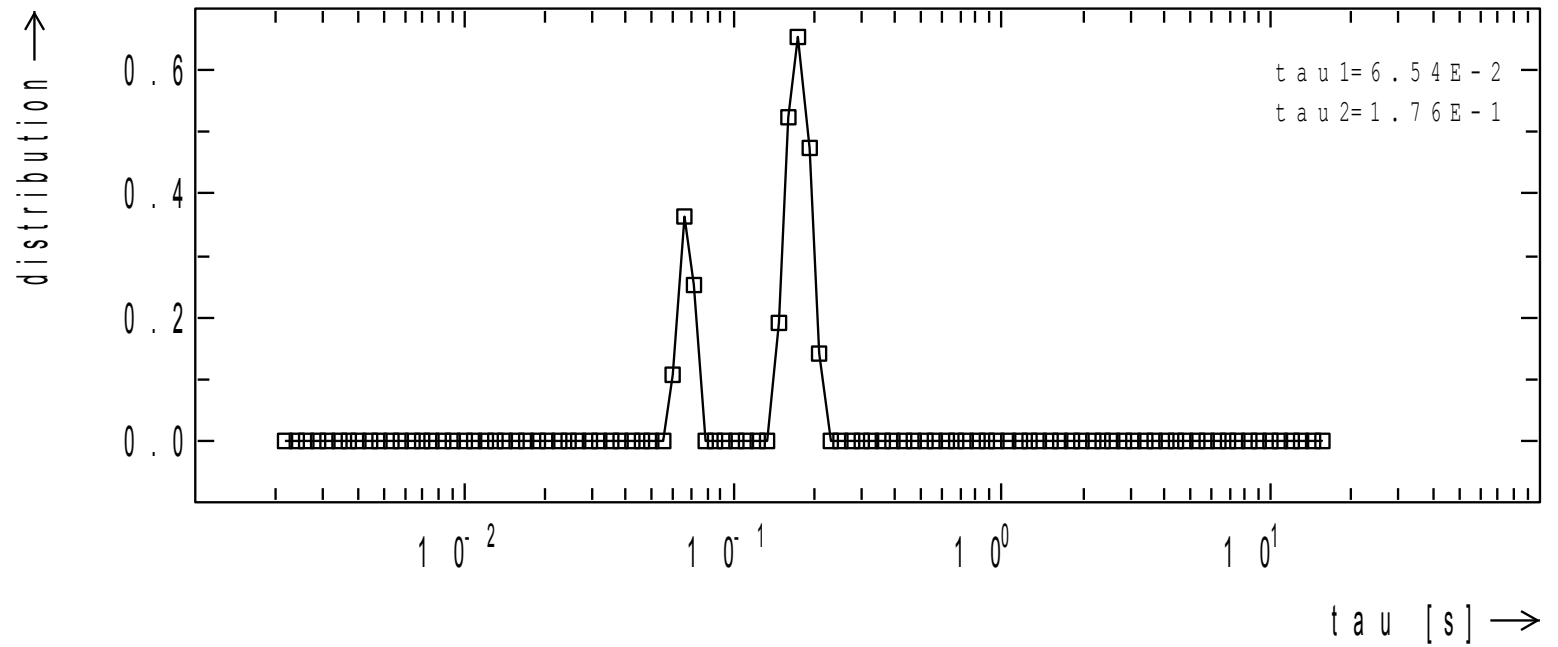
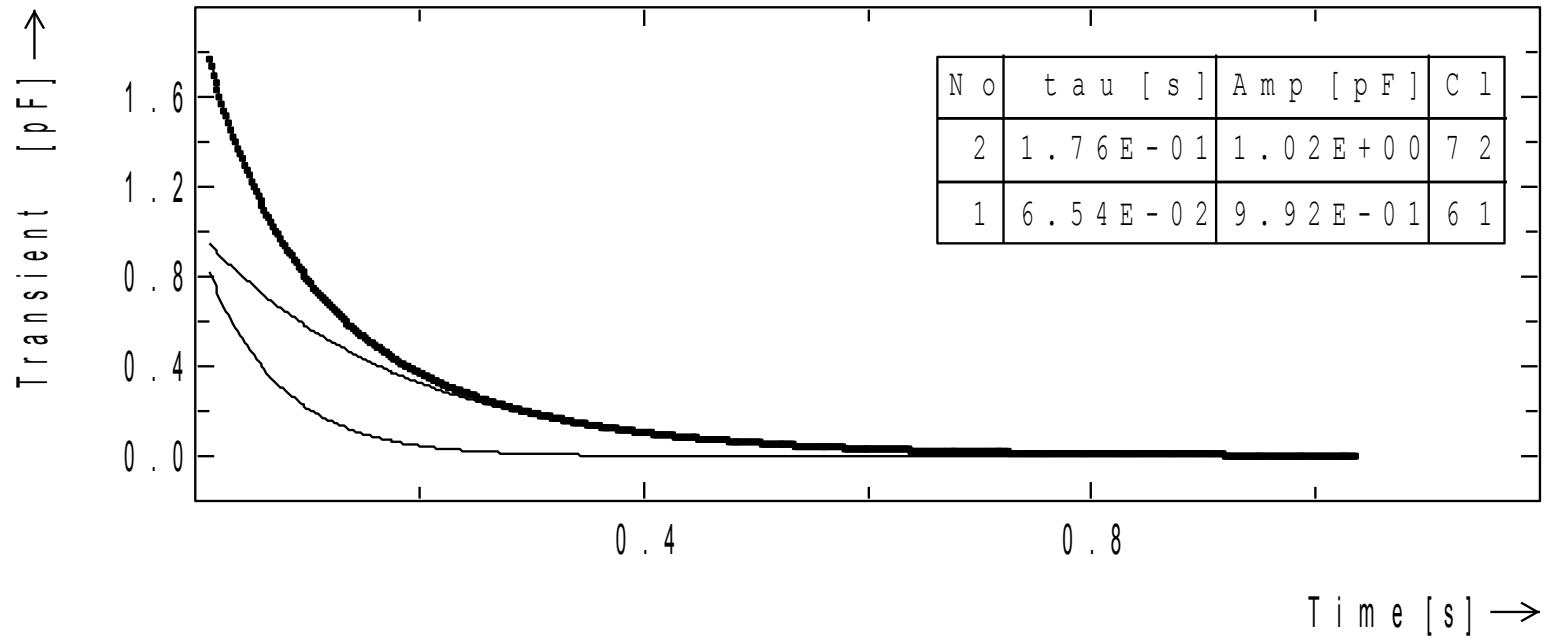


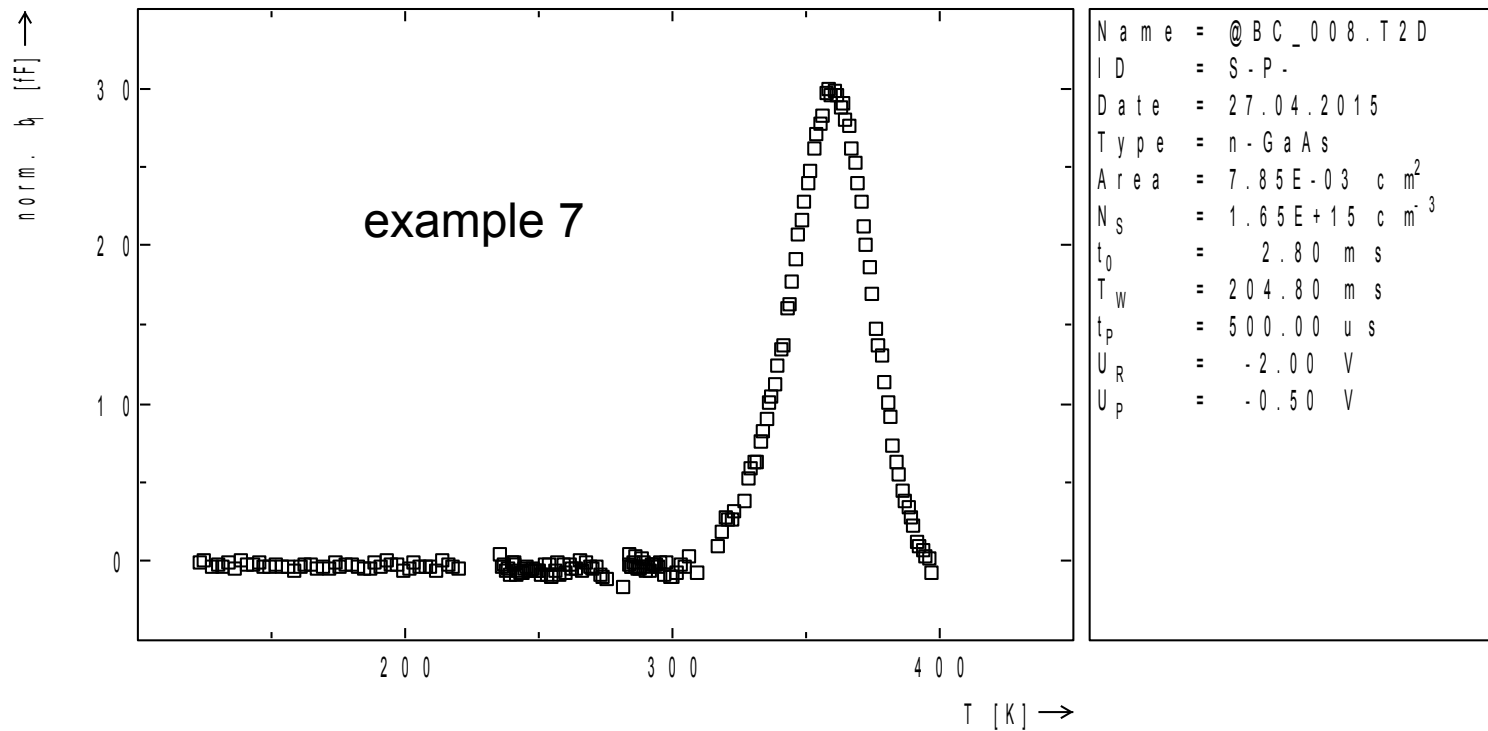
↑
Transient [fF]



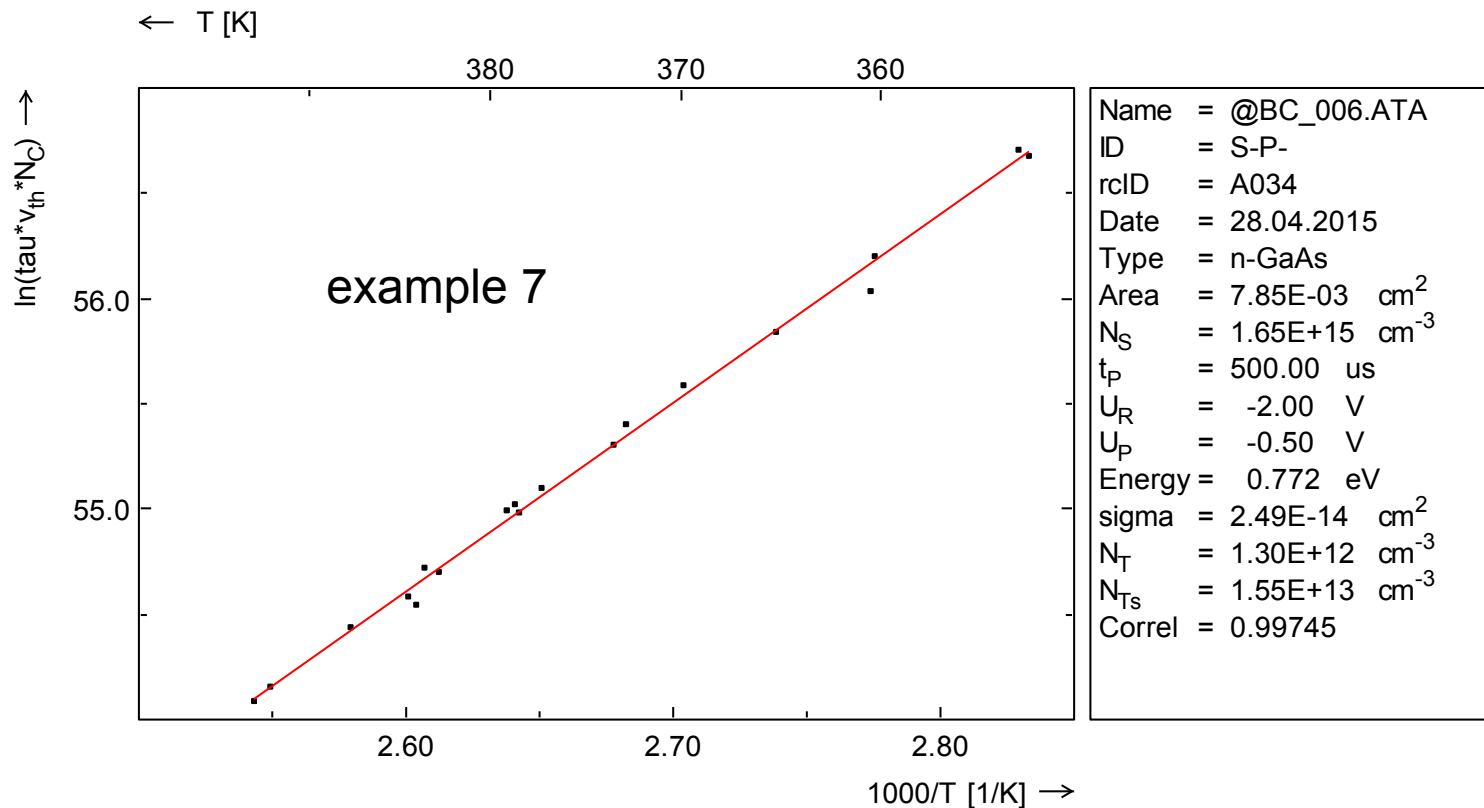
Name = @A_003.YEA
Comm = J7 - Provencher
discrete
ID = GANA18
rcID = 1020
Date = 29.10.2004
Type = n-GaN*
Area = $3.14E-04 \text{ cm}^2$
 $N_s = 2.07E+17 \text{ cm}^{-3}$
Temp = 250.00 K
 $T_W = 20.00 \text{ s}$
 $t_p = 100.00 \text{ us}$
 $U_R = -3.00 \text{ V}$
 $U_P = -0.10 \text{ V}$
 $C_R = 18.67 \text{ pF}$
 $I_R = -1.61 \text{ nA}$



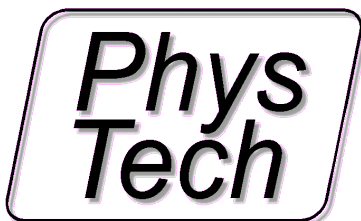


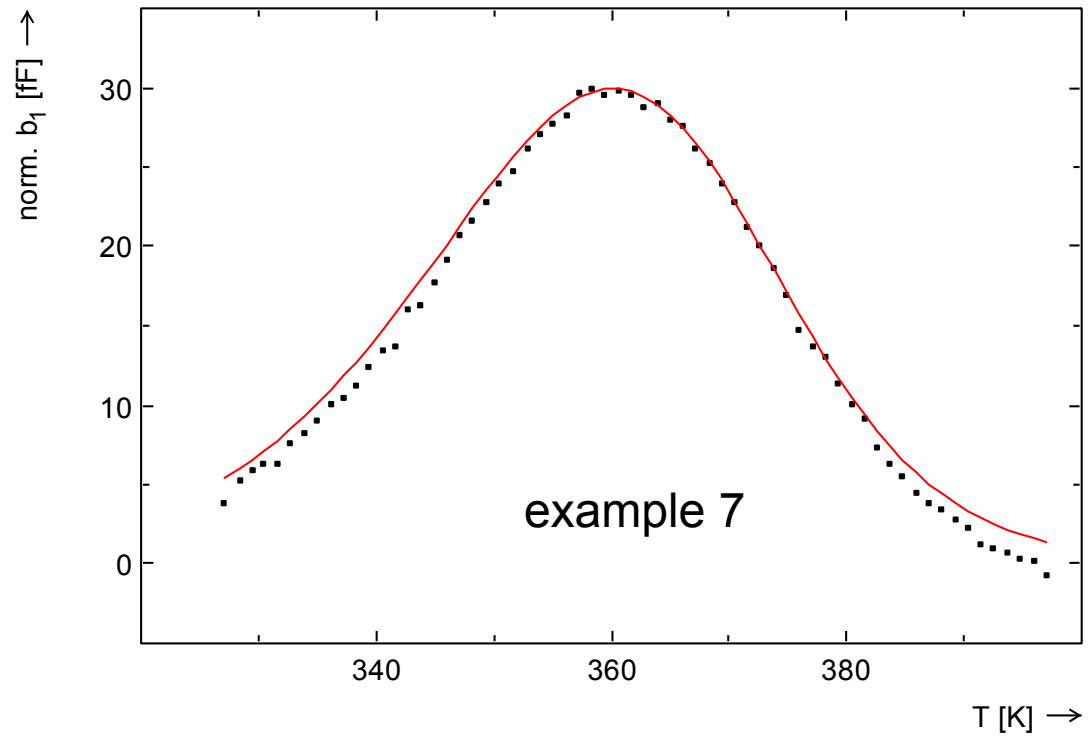


DLTS measurement (DLTS signal b1 versus temperature.
 Both measurements have been combined to a total
 temperature range DLTS measurement



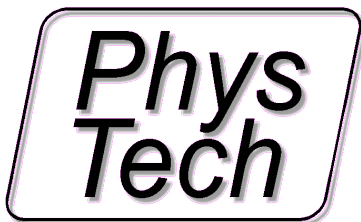
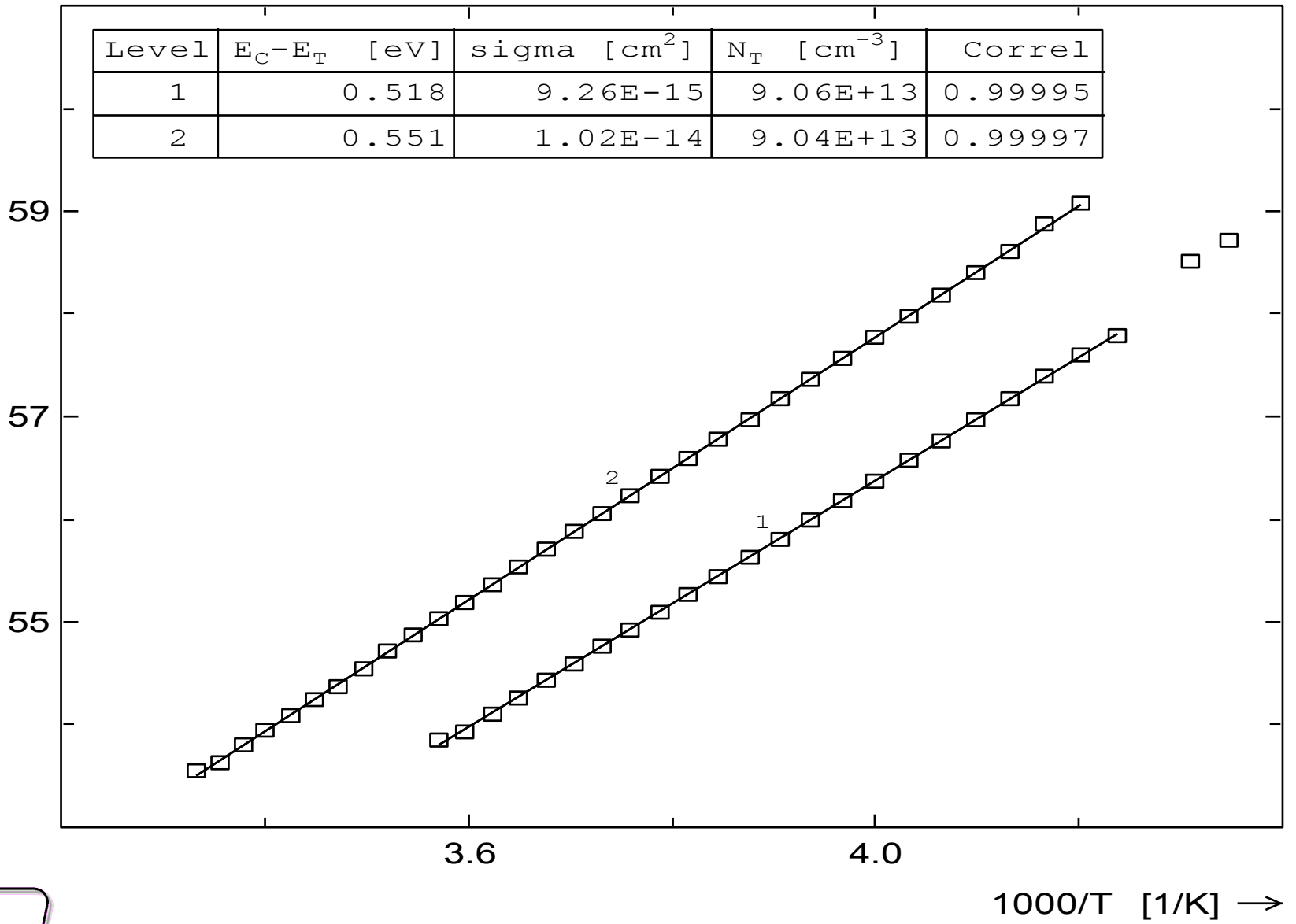
Arrhenius plot of the above measurement using the maximum analysis.
 Energy:0.77eV, capture cross section: 2.5 E-14cm2
 See also last page

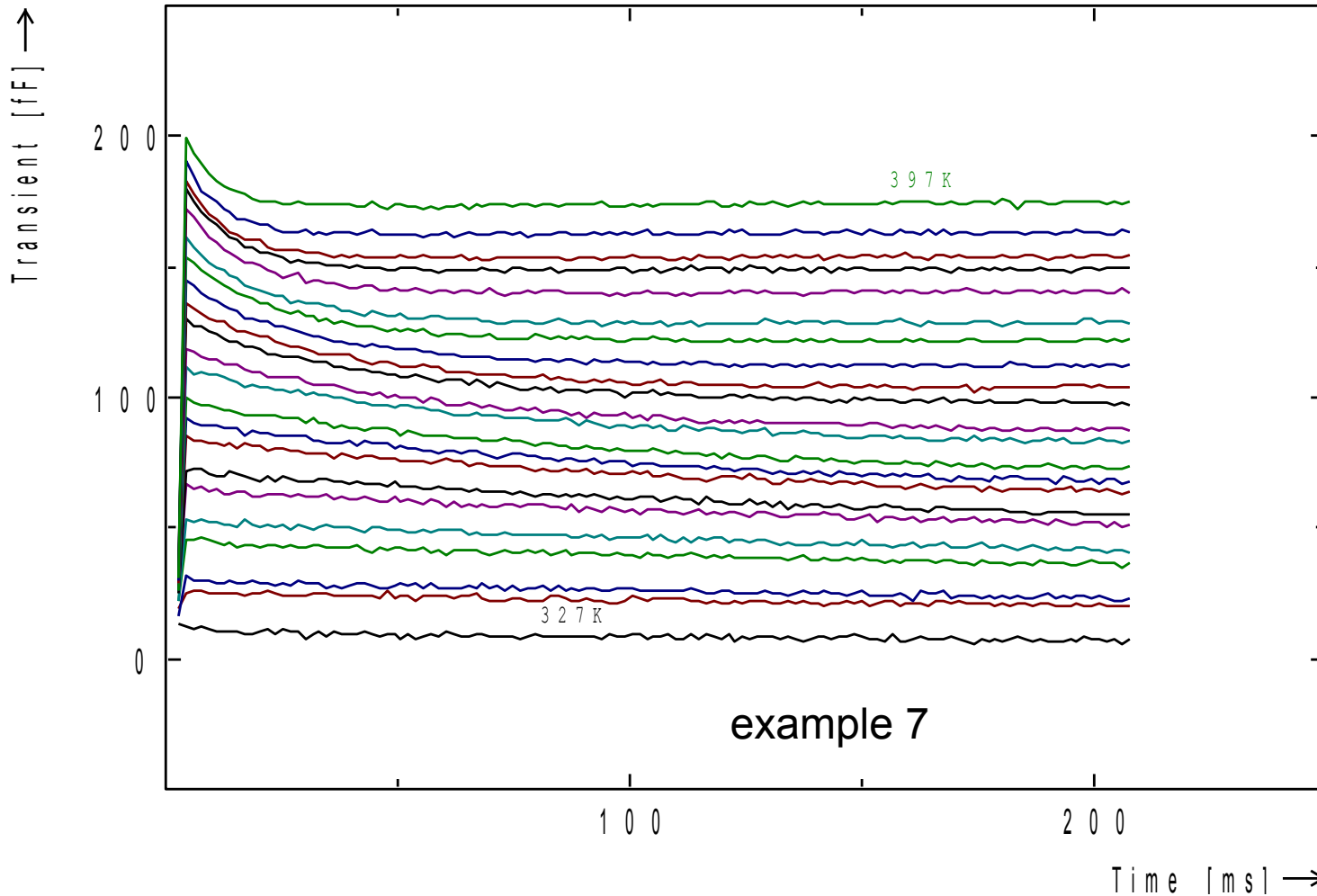




Name = @BC_006.T2A
ID = S-P-
rcID = 1A72
Date = 28.04.2015
Type = n-GaAs
Area = 7.85E-03 cm²
N_S = 1.65E+15 cm⁻³
t₀ = 2.80 ms
T_W = 204.80 ms
t_P = 500.00 us
U_R = -2.00 V
U_P = -0.50 V

$\ln(\tau_t^* N_c) \rightarrow$

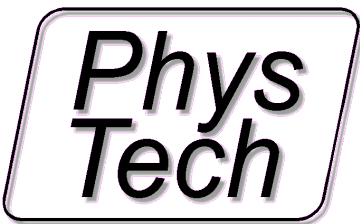


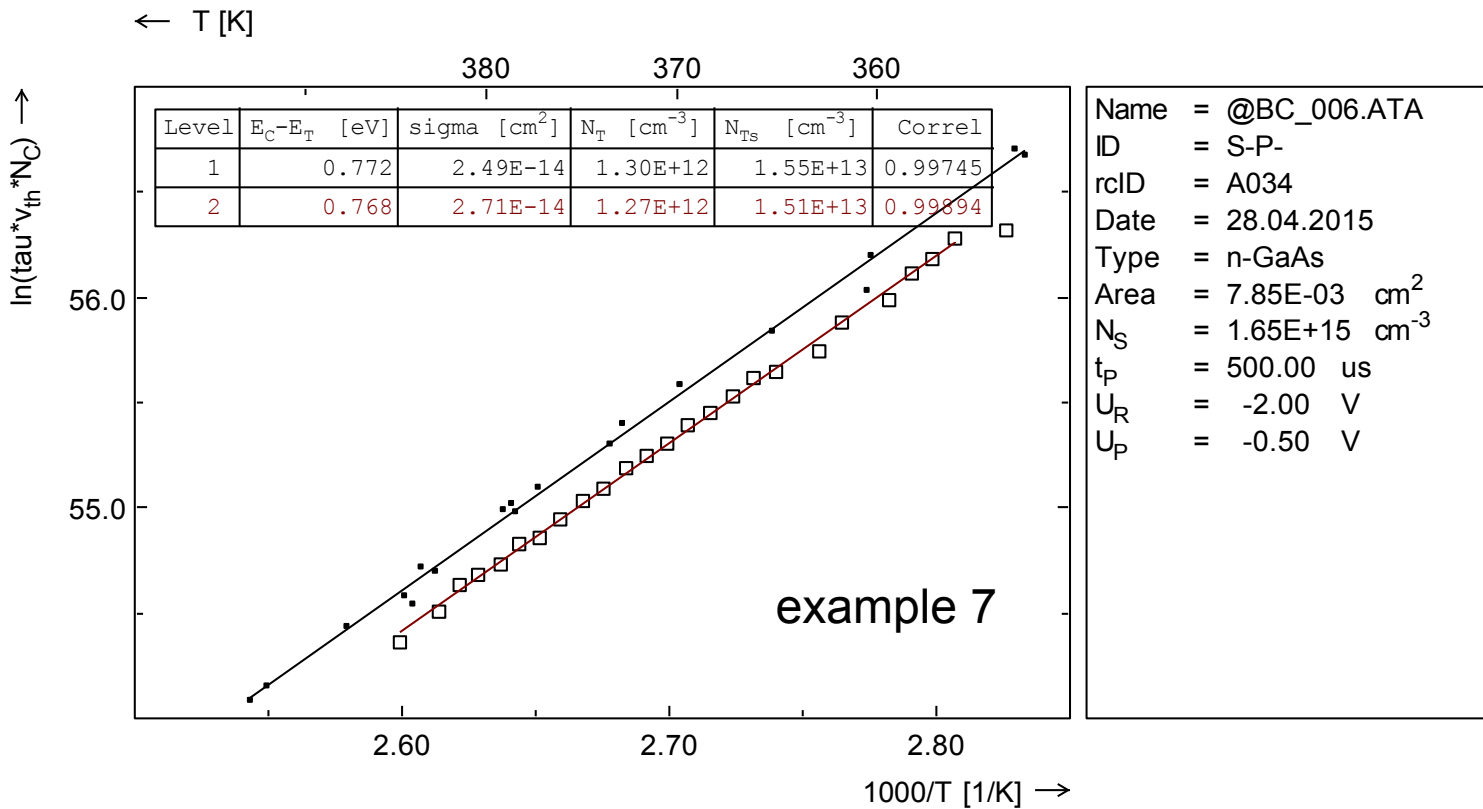


Name	=	@BC_006.T2A
ID	=	S-P-
rcID	=	1A72
Date	=	28.04.2015
Type	=	n-GaAs
Area	=	7.85E-03 cm ²
N _S	=	1.65E+15 cm ⁻³
T _W	=	204.80 ms
t _p	=	500.00 μs
U _R	=	-2.00 V
U _P	=	-0.50 V
C _R	=	91.30 pF
I _R	=	-120.82 μA

Some of the measured transients of the high temperature DLTS measurement

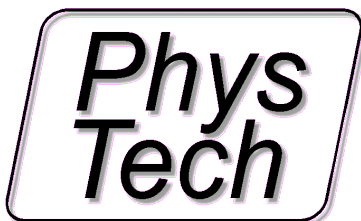
It is nice to see the temperature depending change of the timeconstant. These transients can (and are in the next page) used for the so called Laplace evaluation (direct transient timeconstant evaluation)

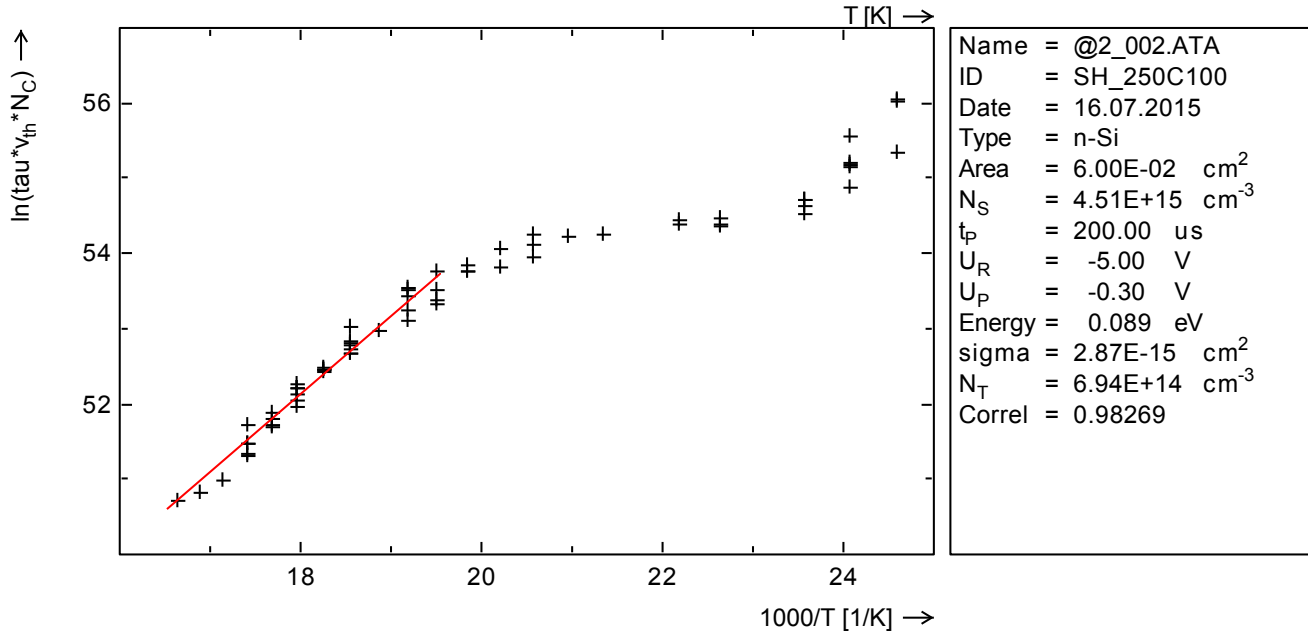
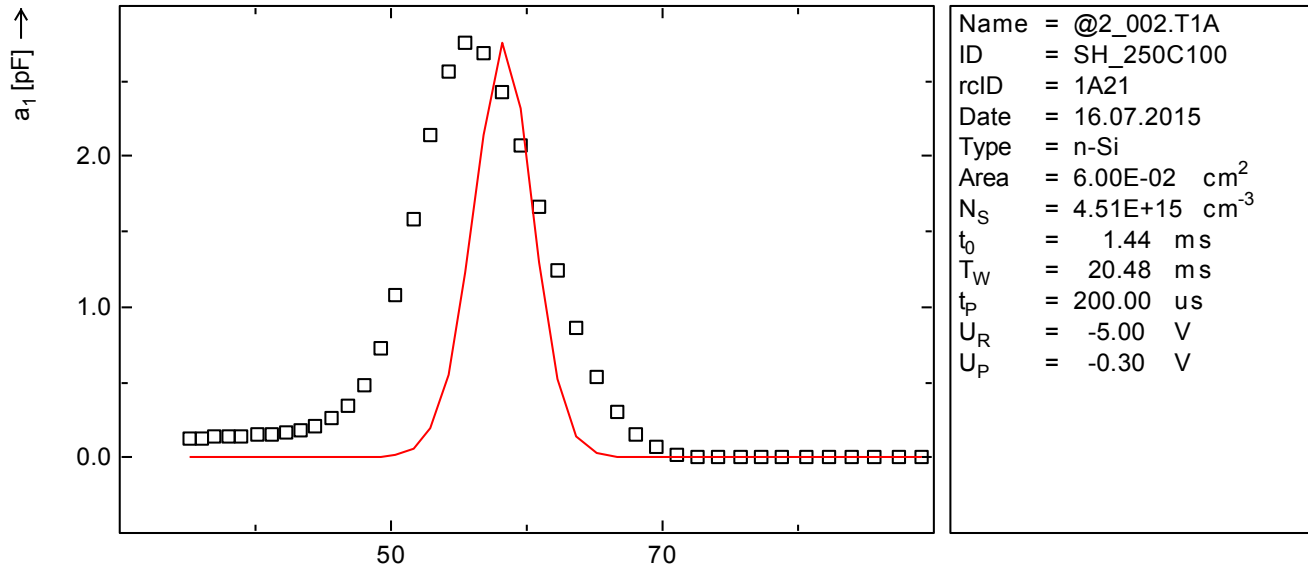




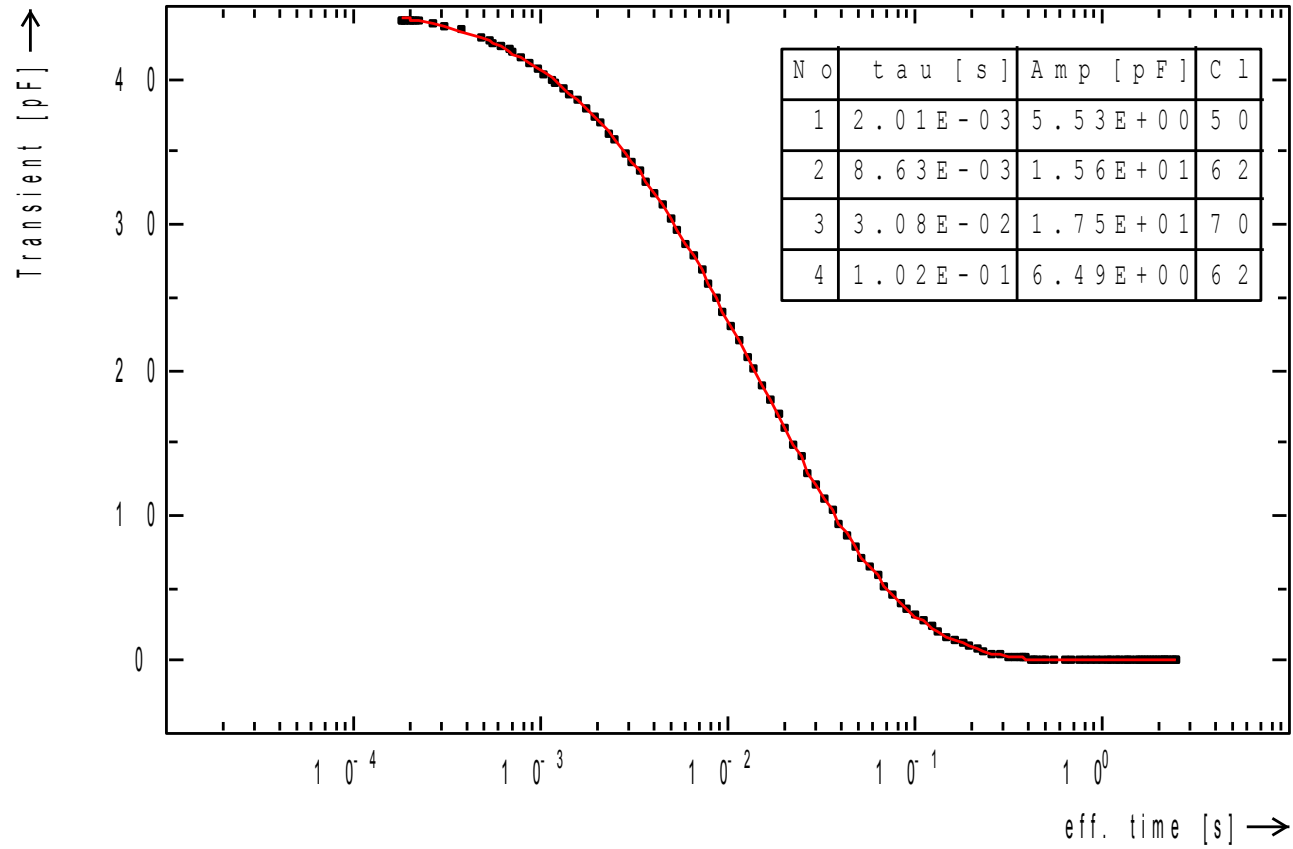
Arrhenius plot of the above measurement comparing the maximum analysis with the direct Laplace analysis.

Level1: maximum analysis, Level2: Laplace analysis

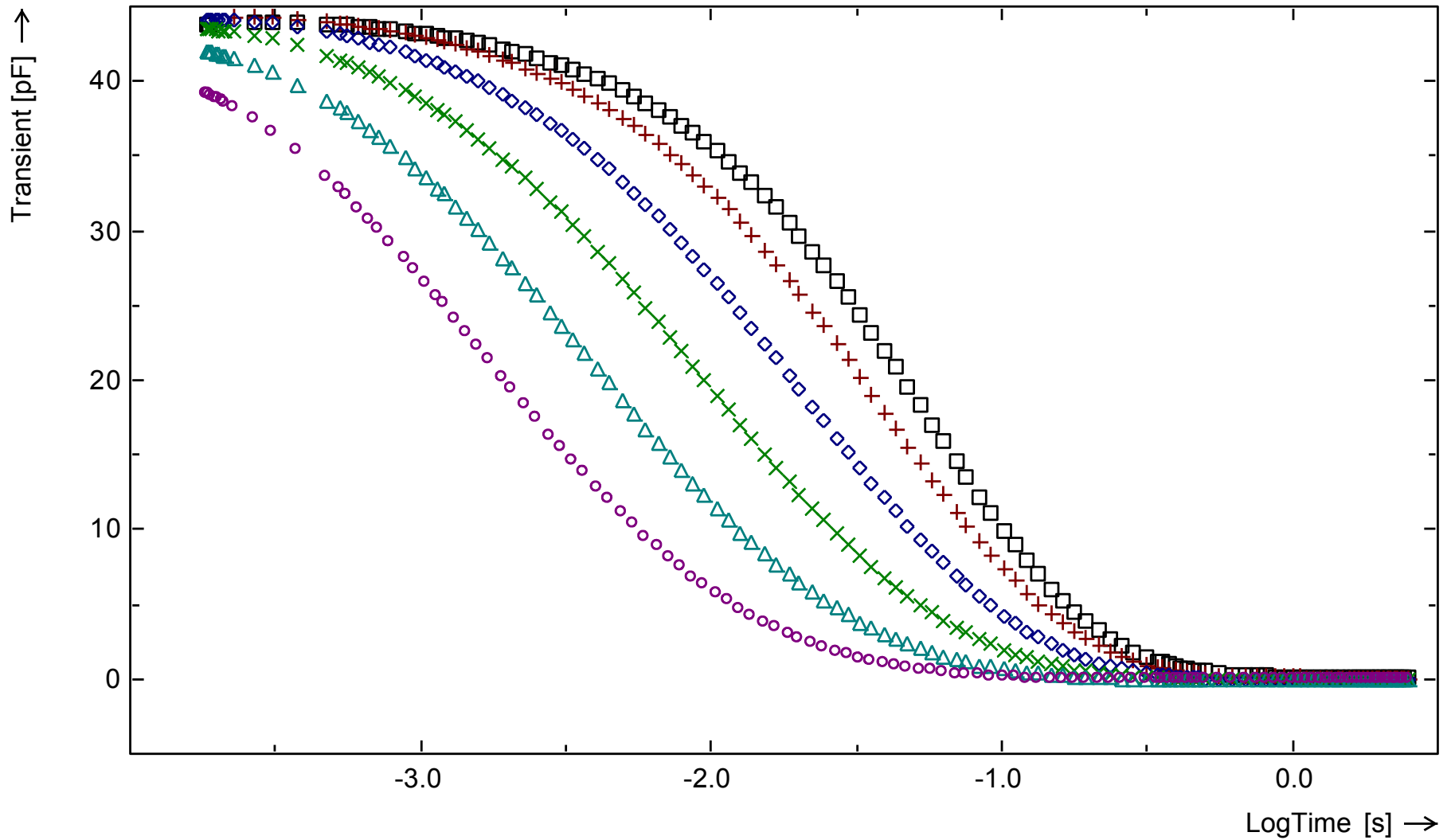




treated Si sample



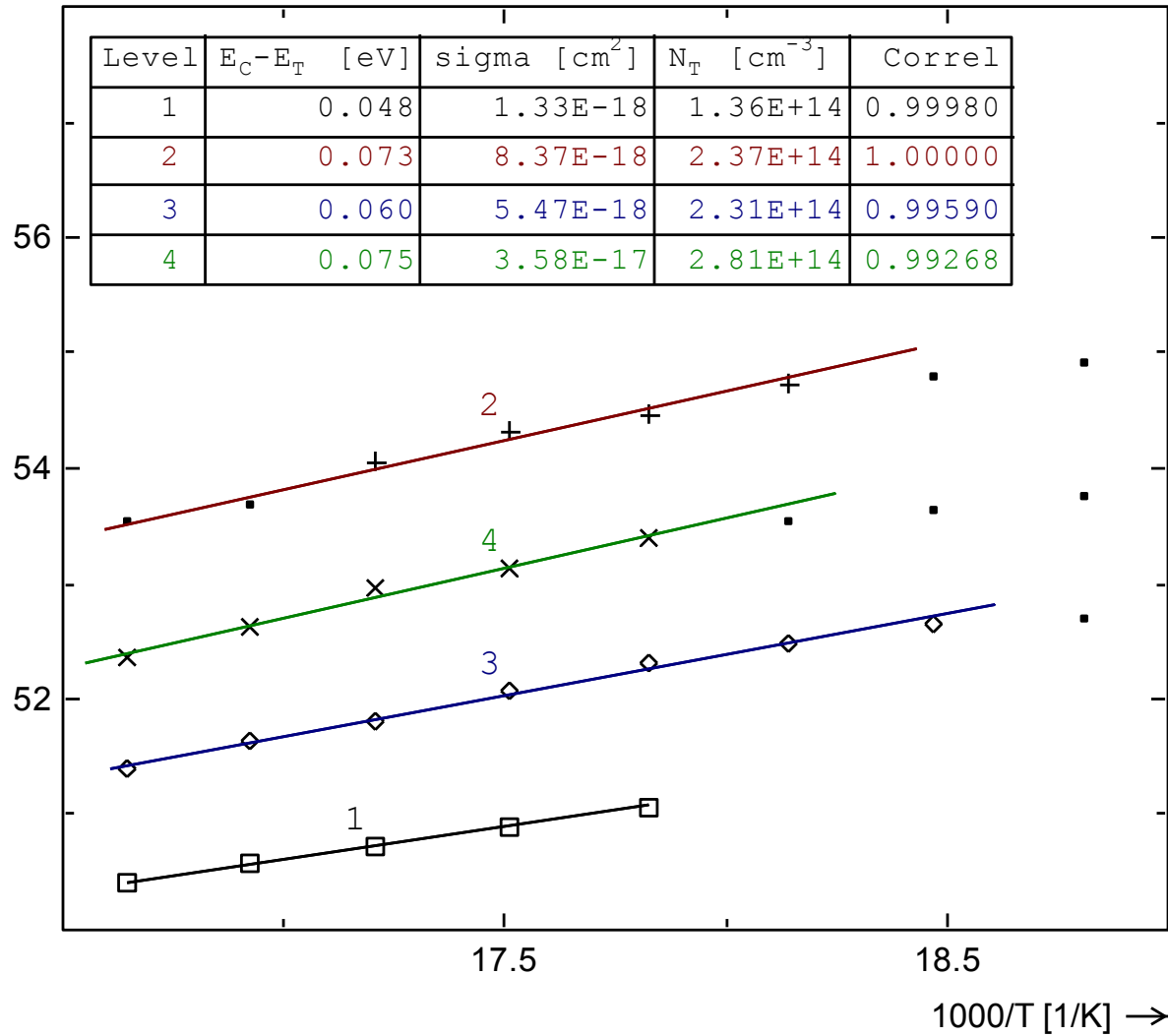
```
Name = @1_00T006.PWA
ID    = SH_250C130
rcID  = 2015*
Date  = 16.07.2015
Type  = n-Si
Area  = 4.00E-02 c m2
Ns    = 4.51E+15 c m-3
Temp  = 55.08 K
TempX = 0.11 K
tp    = 200.00 u s
UR    = -2.00 V
UP    = -0.10 V
CR    = 472.52 p F
IR    = -4.34 u A
Dif-T = 0.11 K
Class = 6 4
```



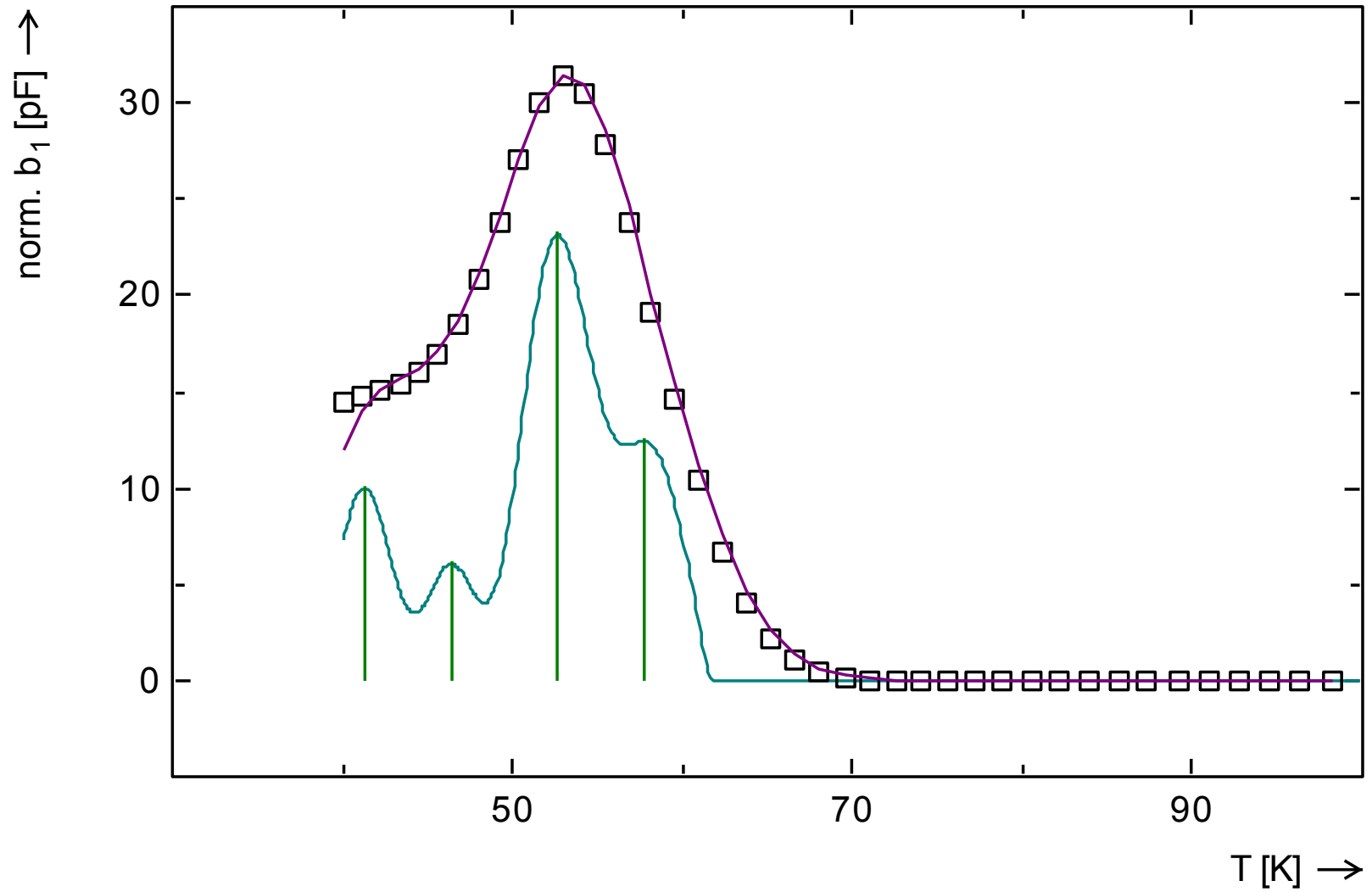
Log sampled transients measured from 50K to 65 K

3 measurements with linear sampling using 65000 data points each
and constructing a log sampled transient

$\ln(\tau_{th} \cdot v_{th} \cdot N_C) \rightarrow$



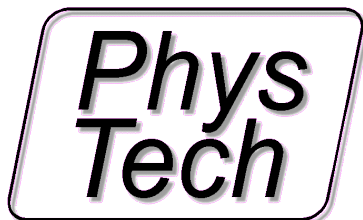
Name = @1_00T_cont.AWT
ID = SH_250C130
Date = 16.07.2015
Type = n-Si
Area = $4.00\text{E-}02 \text{ cm}^2$
 $N_S = 4.51\text{E+}15 \text{ cm}^{-3}$
 $t_P = 200.00 \text{ us}$
 $U_R = -2.00 \text{ V}$
 $U_P = -0.10 \text{ V}$

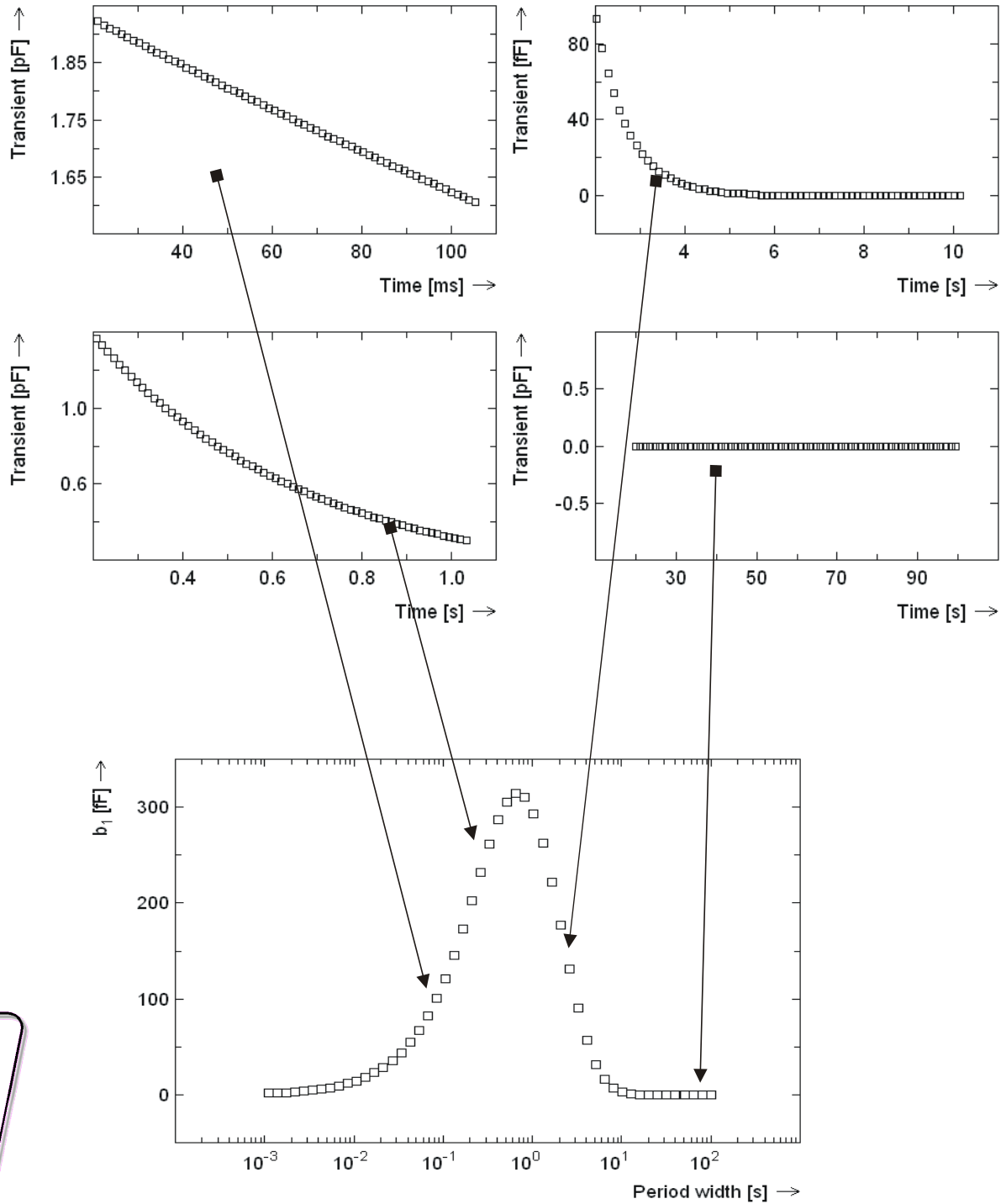
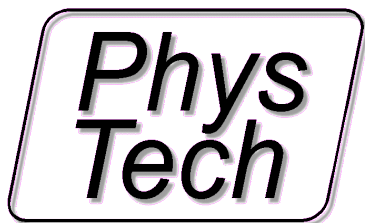


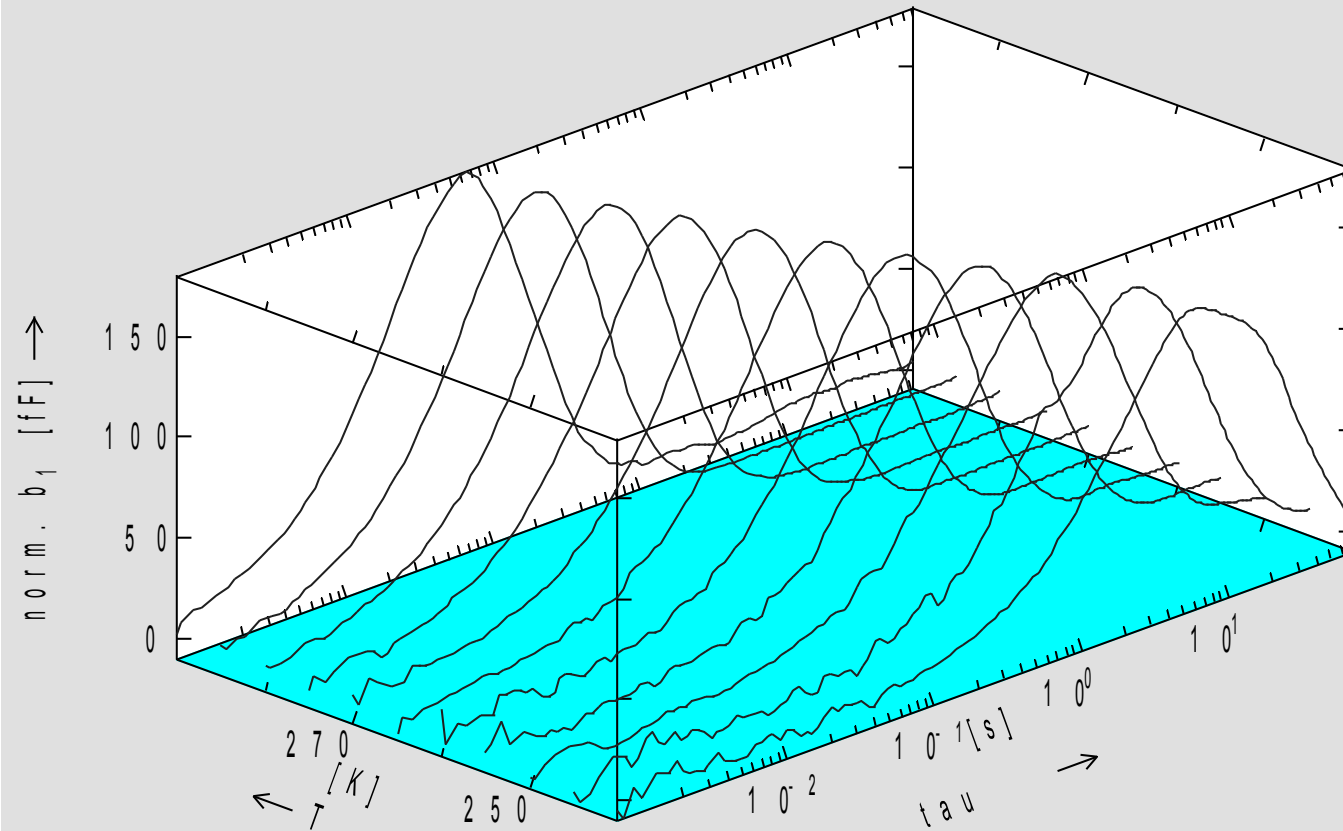
ITS, ICTS, Periodwidthscan

ITS : Isothermal Transient Spectroscopy

ICTS: Isothermal Current Transient Spectroscopy

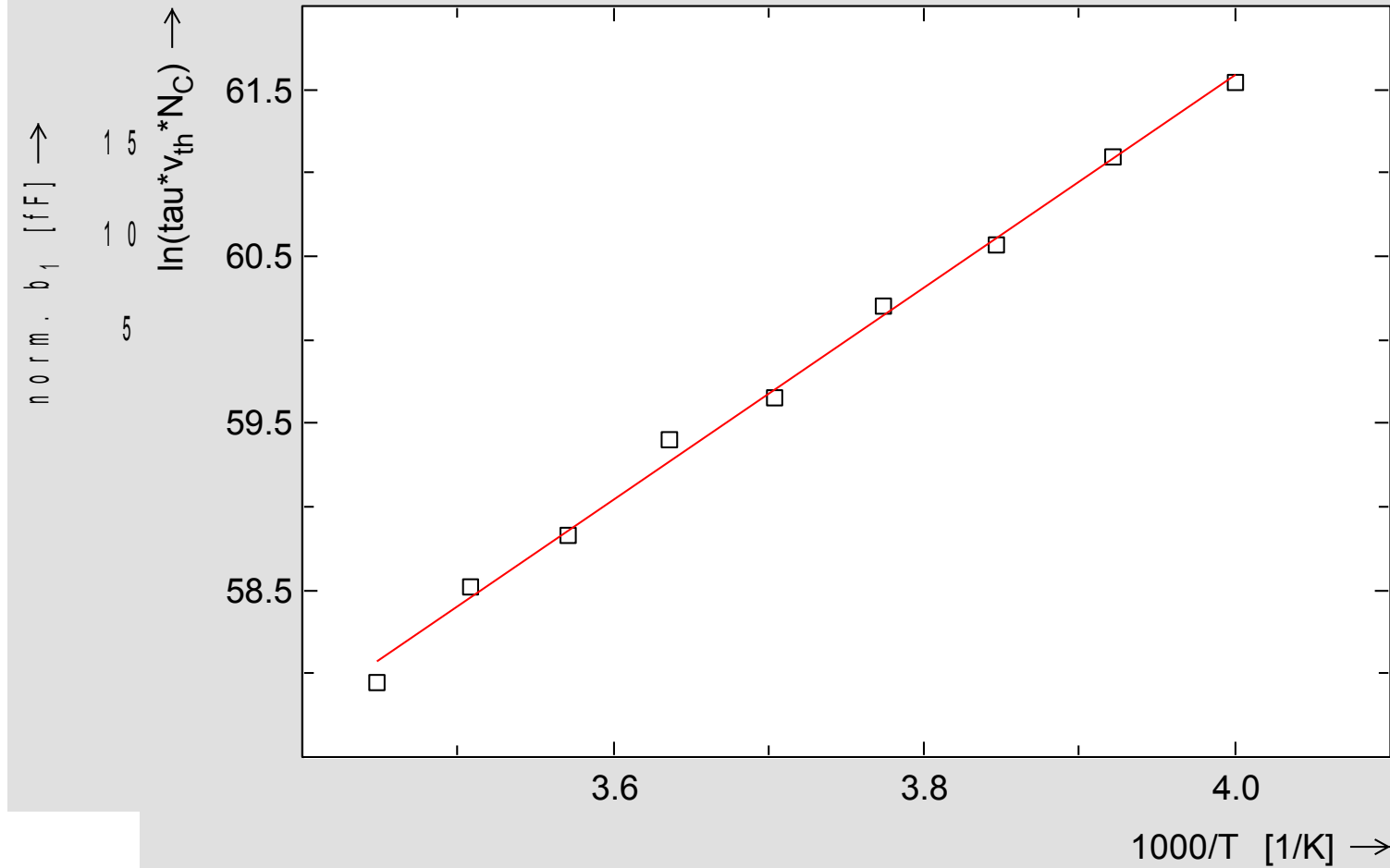




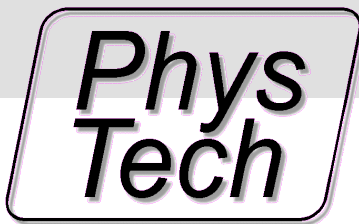
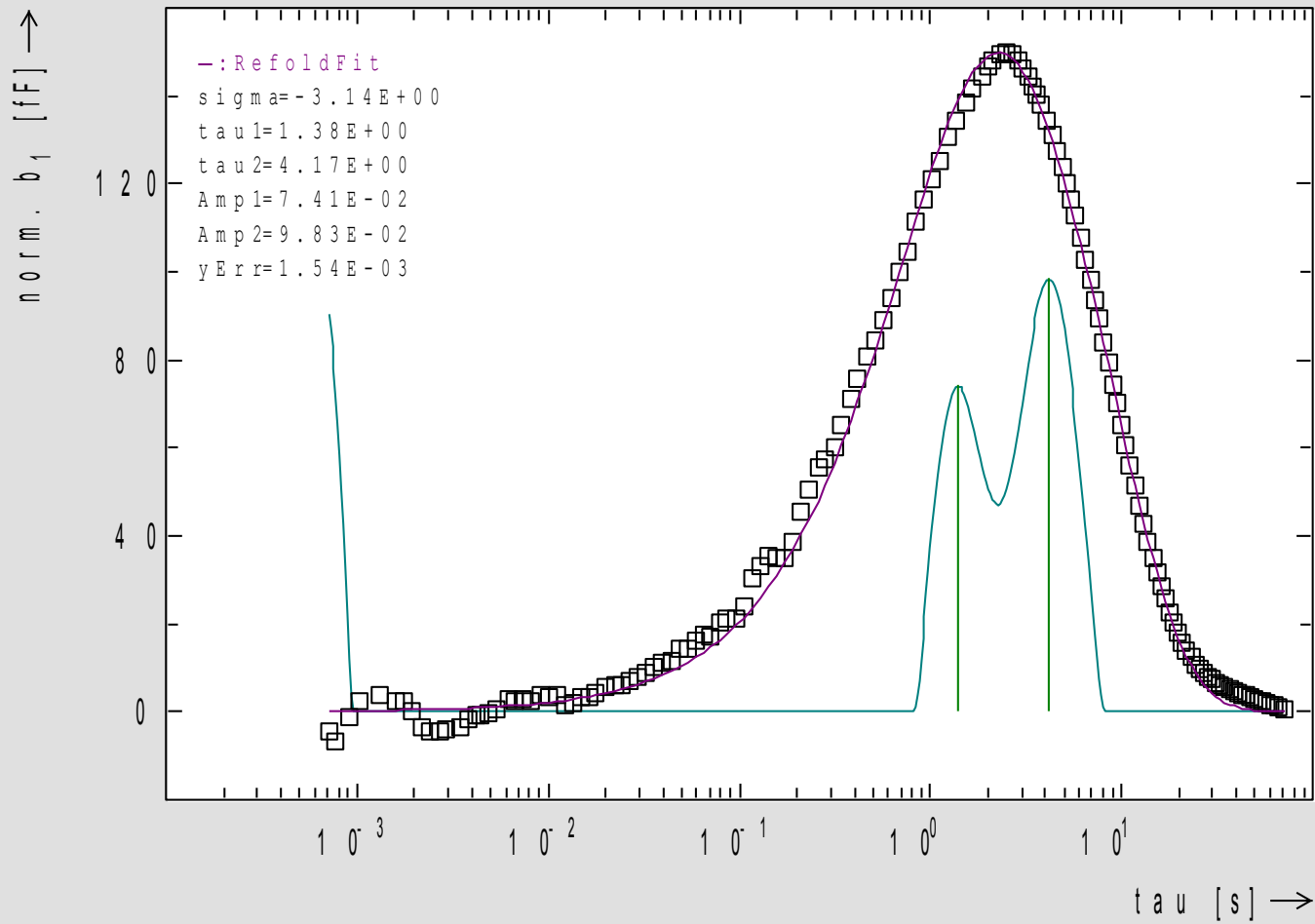


Name	=	_T001.PWA
Comm	=	J7
ID	=	GANA18
rcID	=	0000
Date	=	28.10.2004
Type	=	n-GaN*
Area	=	$3.14E-04 \text{ cm}^2$
N_s	=	$2.00E+17 \text{ cm}^{-3}$
t_p	=	100.00 μs
U_R	=	-3.00 V
U_P	=	0.00 V
C_R	=	18.44 pF
I_R	=	-1.17 nA

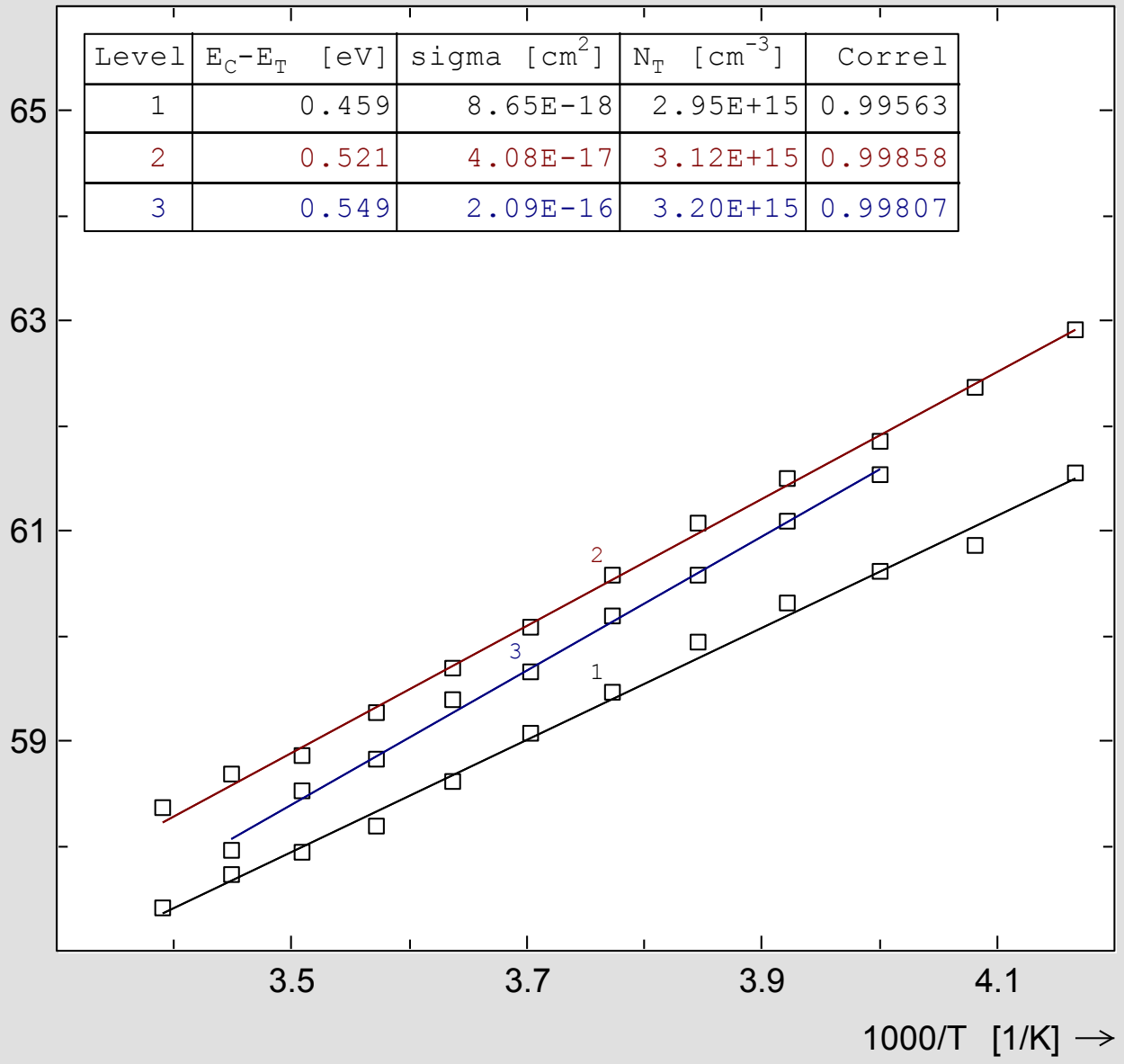




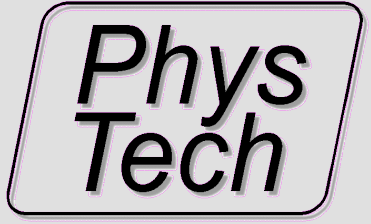
Name = _T1.AWA
 Comm = J7
 ID = GANA18
 rclD = 0000
 Date = 28.10.2004
 Type = n-GaN*
 Area = 3.14E-04 cm²
 N_S = 2.00E+17 cm⁻³
 t_p = 100.00 us
 U_R = -3.00 V
 U_P = 0.00 V
 Energy = 0.549 eV
 sigma = 2.09E-16 cm²
 N_T = 3.20E+15 cm⁻³
 Correl = 0.99807



$\ln(\tau_{th} \cdot v_{th} \cdot N_C) \uparrow$



Name = _T1.AWA
Comm = J7
ID = GANA18
rcID = 0000
Date = 28.10.2004
Type = n-GaN*
Area = $3.14\text{E-}04 \text{ cm}^2$
 $N_S = 2.00\text{E+}17 \text{ cm}^{-3}$
 $t_P = 100.00 \text{ us}$
 $U_R = -3.00 \text{ V}$
 $U_P = 0.00 \text{ V}$

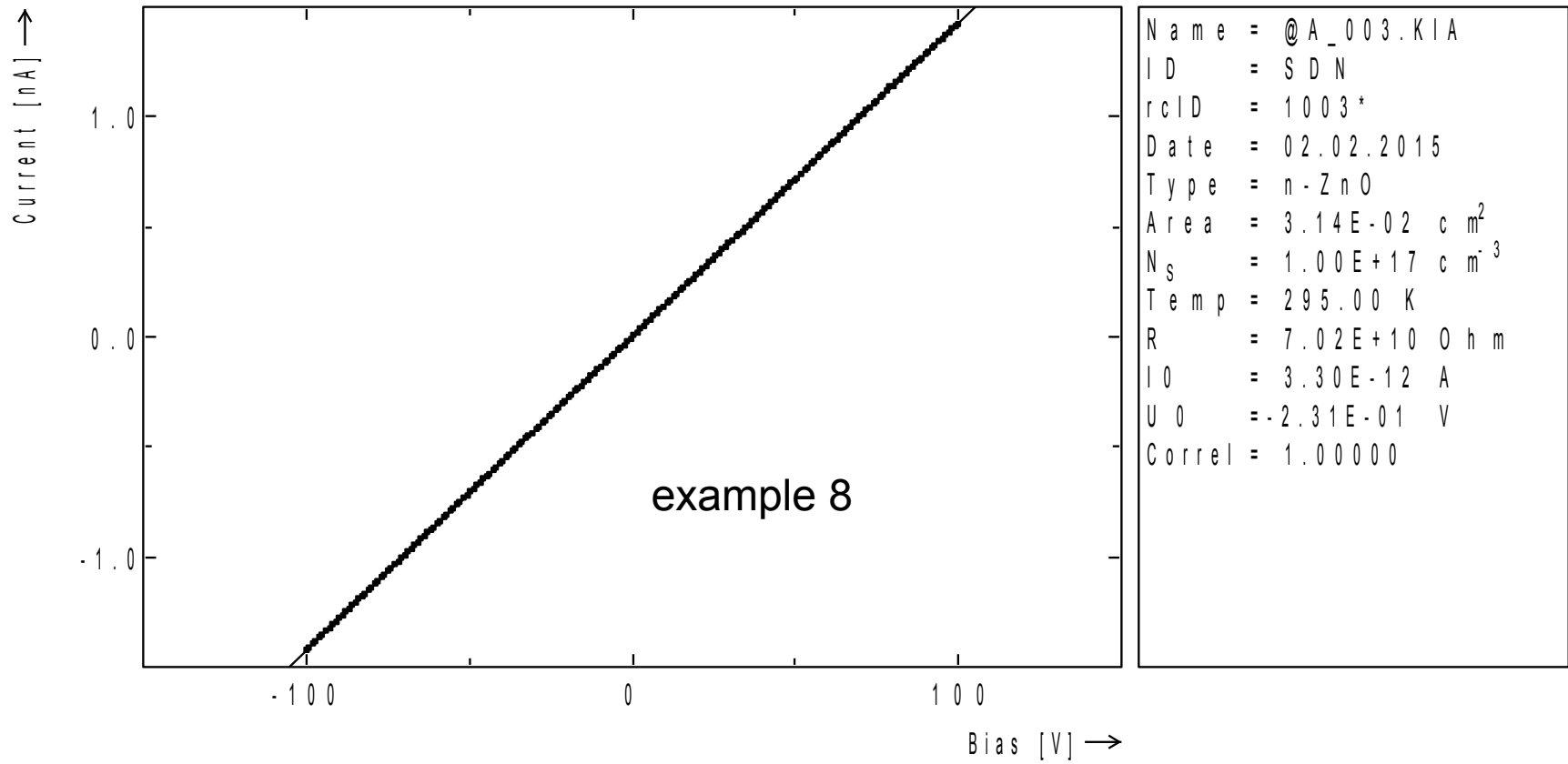


Current - DLTS

Resistivity sample

example 8

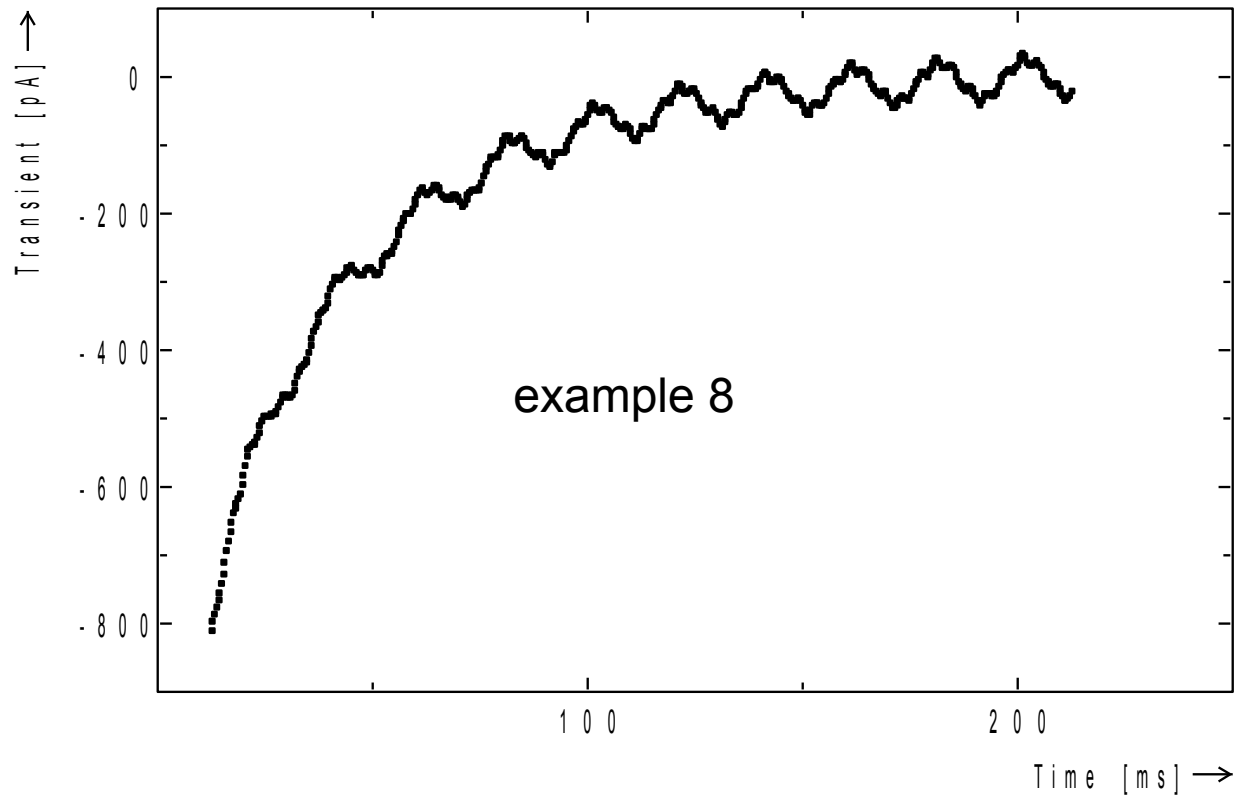
Deconvolution DLTS example



```

tau(a1,b1) = 38.079 ms    Amplitude = -966.235 pA, -36.793 pAs
tau(a2,b2) = 34.466 ms    NT      = 3.09E+08 cm-3
tau(b1,b2) = 31.868 ms    NTs     = 0.00E+00 cm-3
tau(a1,a2) = 38.029 ms    Energy  = 0.615 eV
tau(Tw/4)  = 27.997 ms    tau,ts/Tw = 0.19,1.47
tau(Tw'/2) = 37.583 ms    ExpClass = 0.91
tau(a0,b1) = 48.355 ms    TauClass = 55

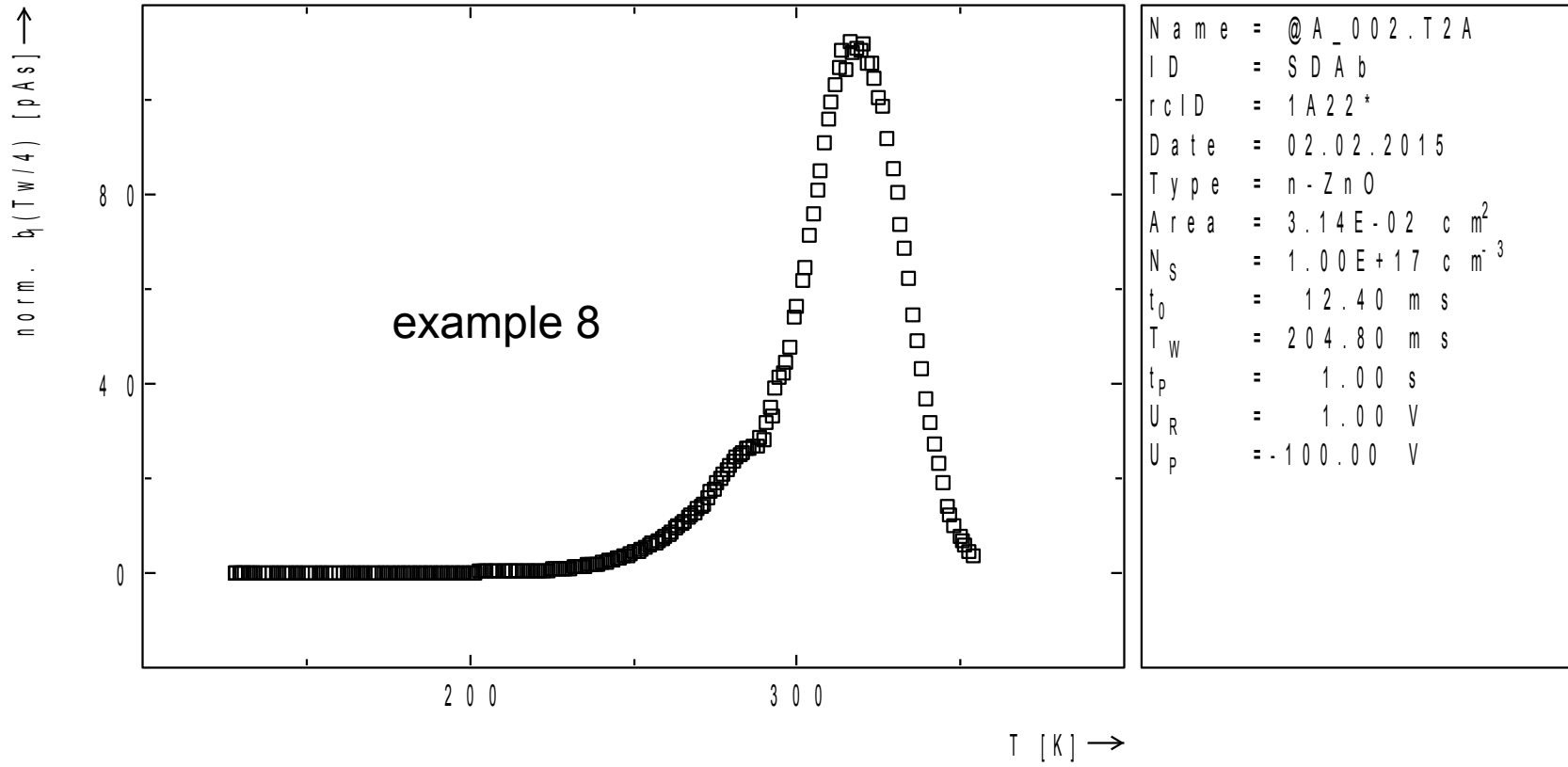
```

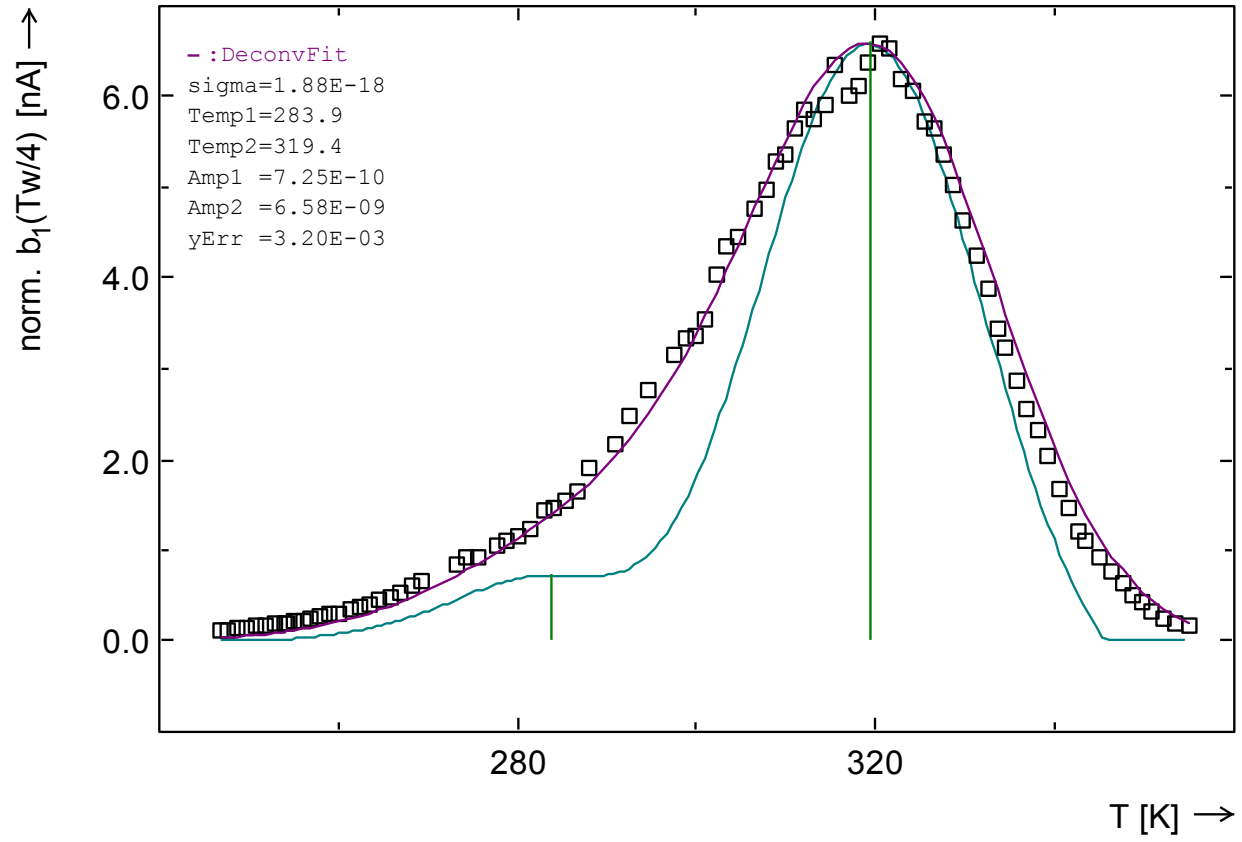


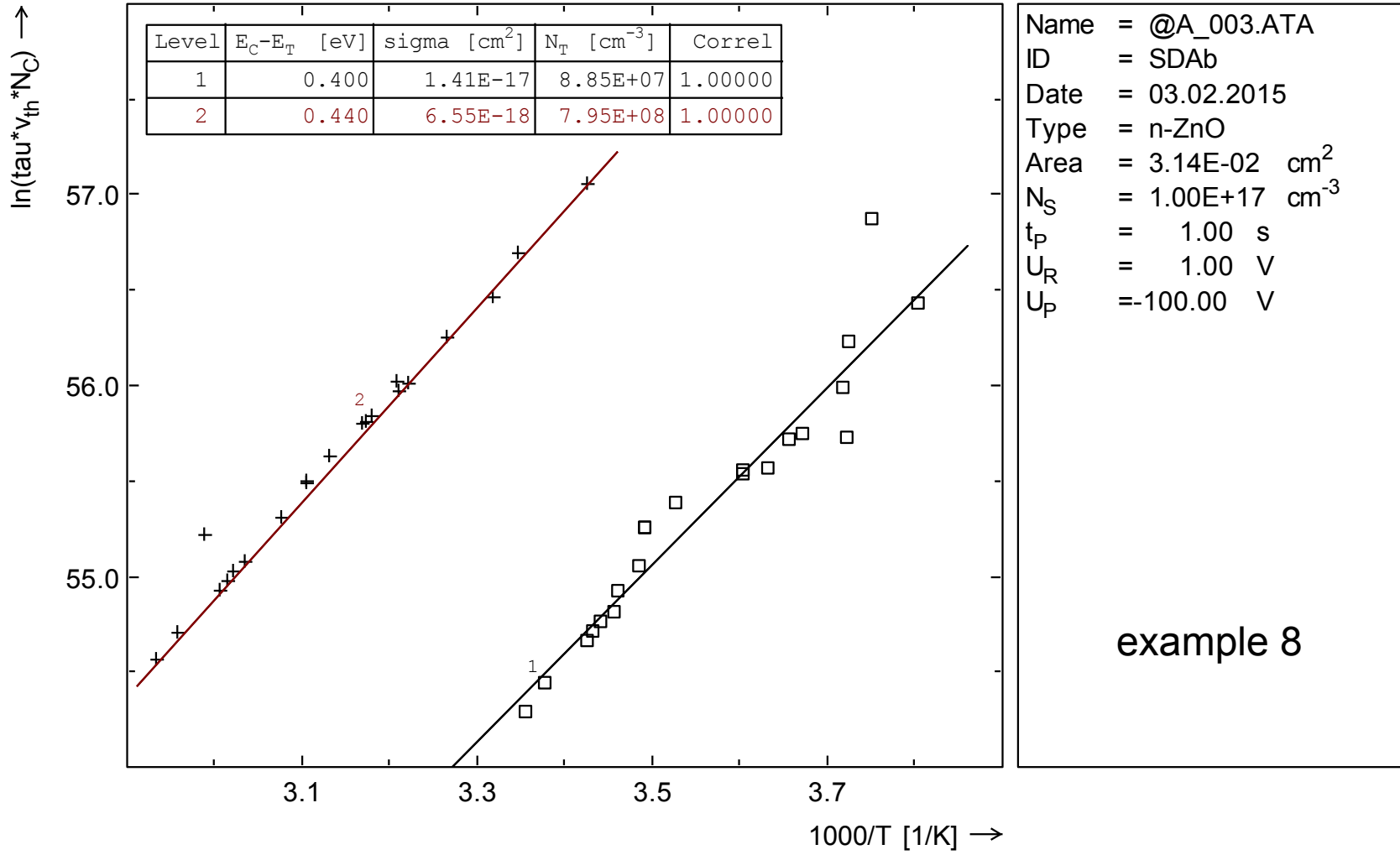
```

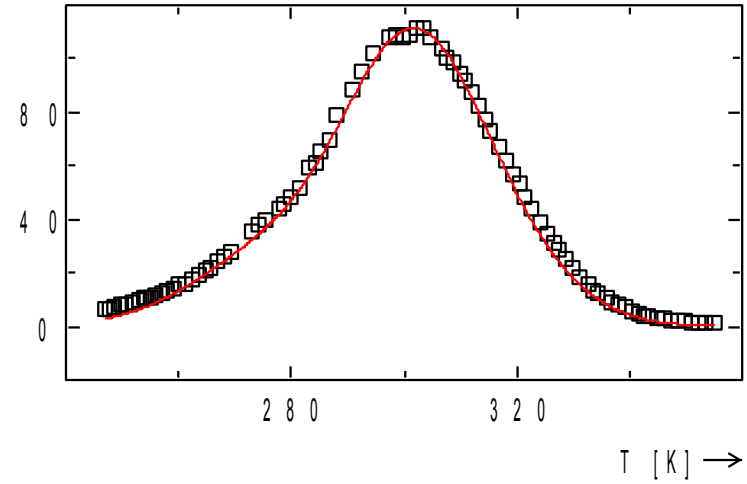
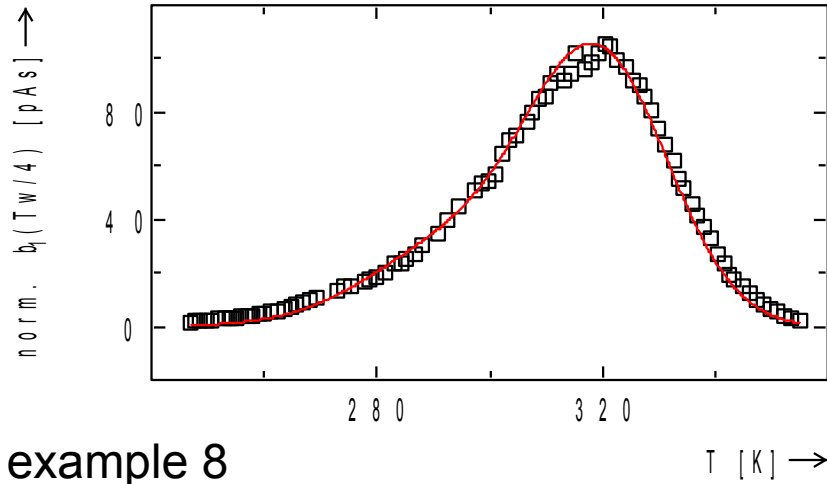
Name = @A_003.YCA
ID   = SDN
rcID = 1015*
Date = 02.02.2015
Type = n-ZnO
Area = 3.14E-02 cm2
Ns   = 1.00E+17 cm-3
Temp = 295.90 K
Tw   = 199.94 ms
tp   = 1.00 s
UR   = 1.00 V
UP   = -100.00 V
IR   = 3.62 pA

```

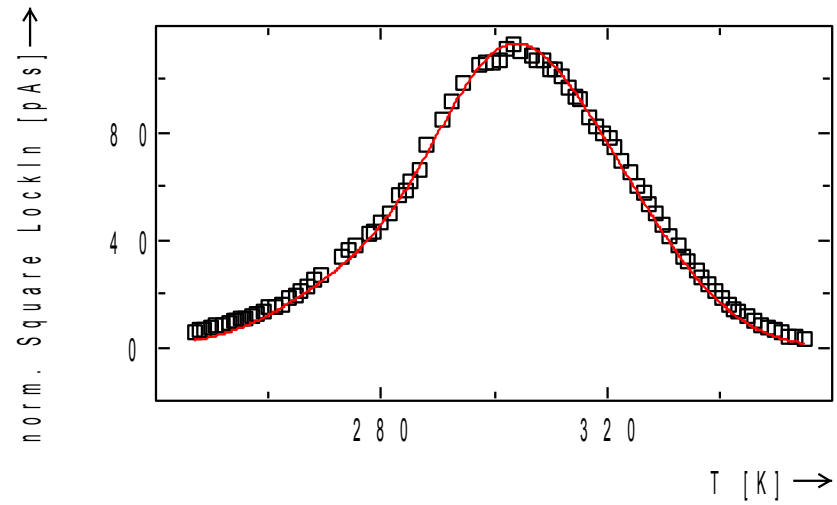
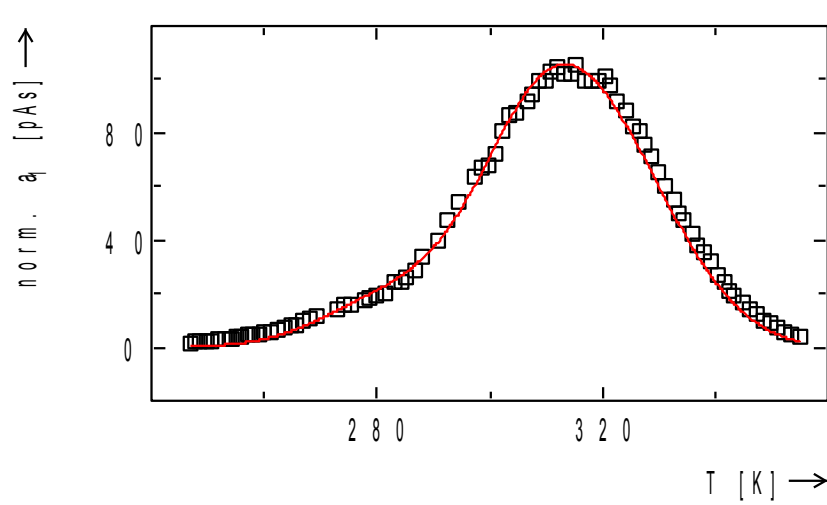







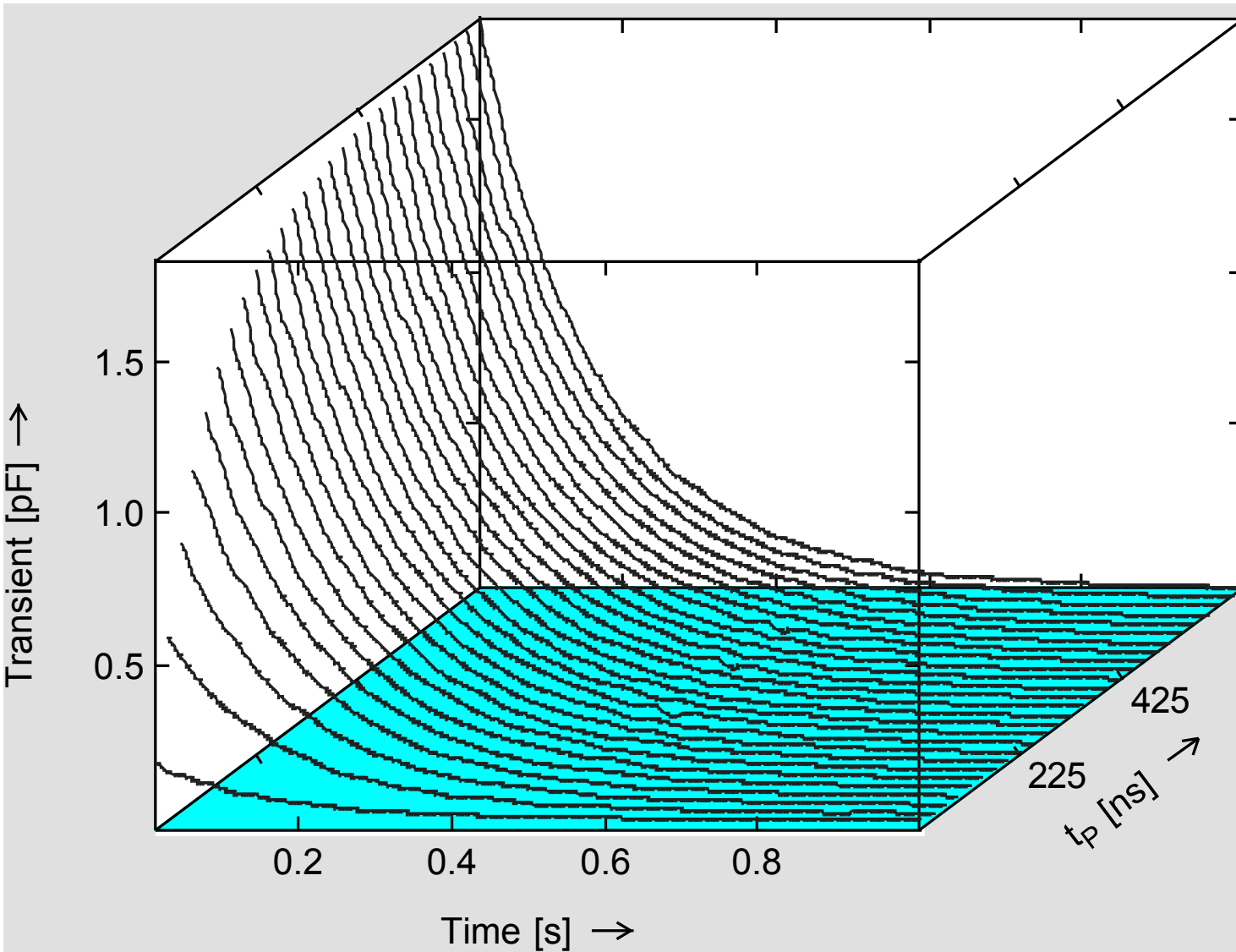


example 8

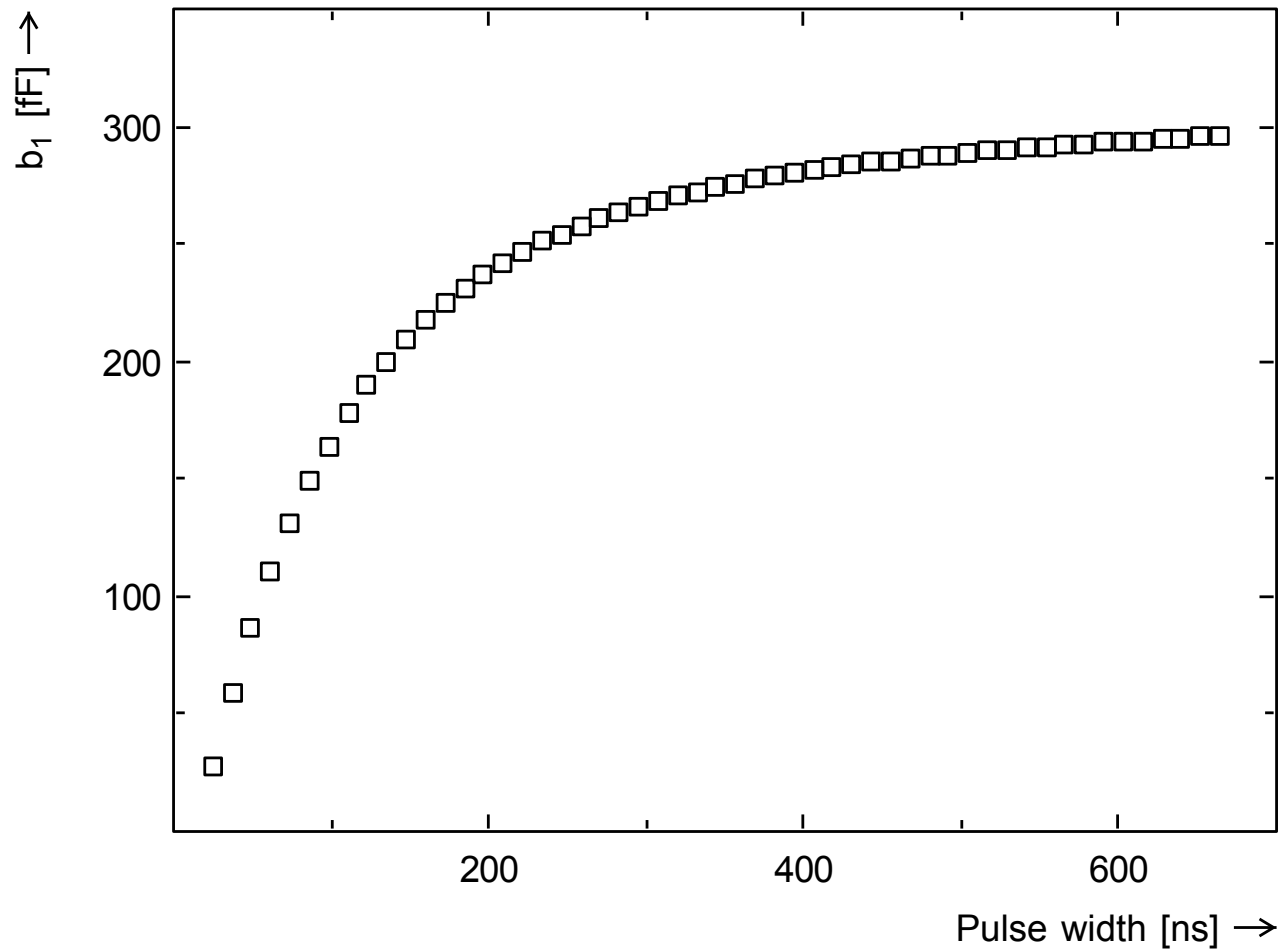


Capture Cross Section Measurements

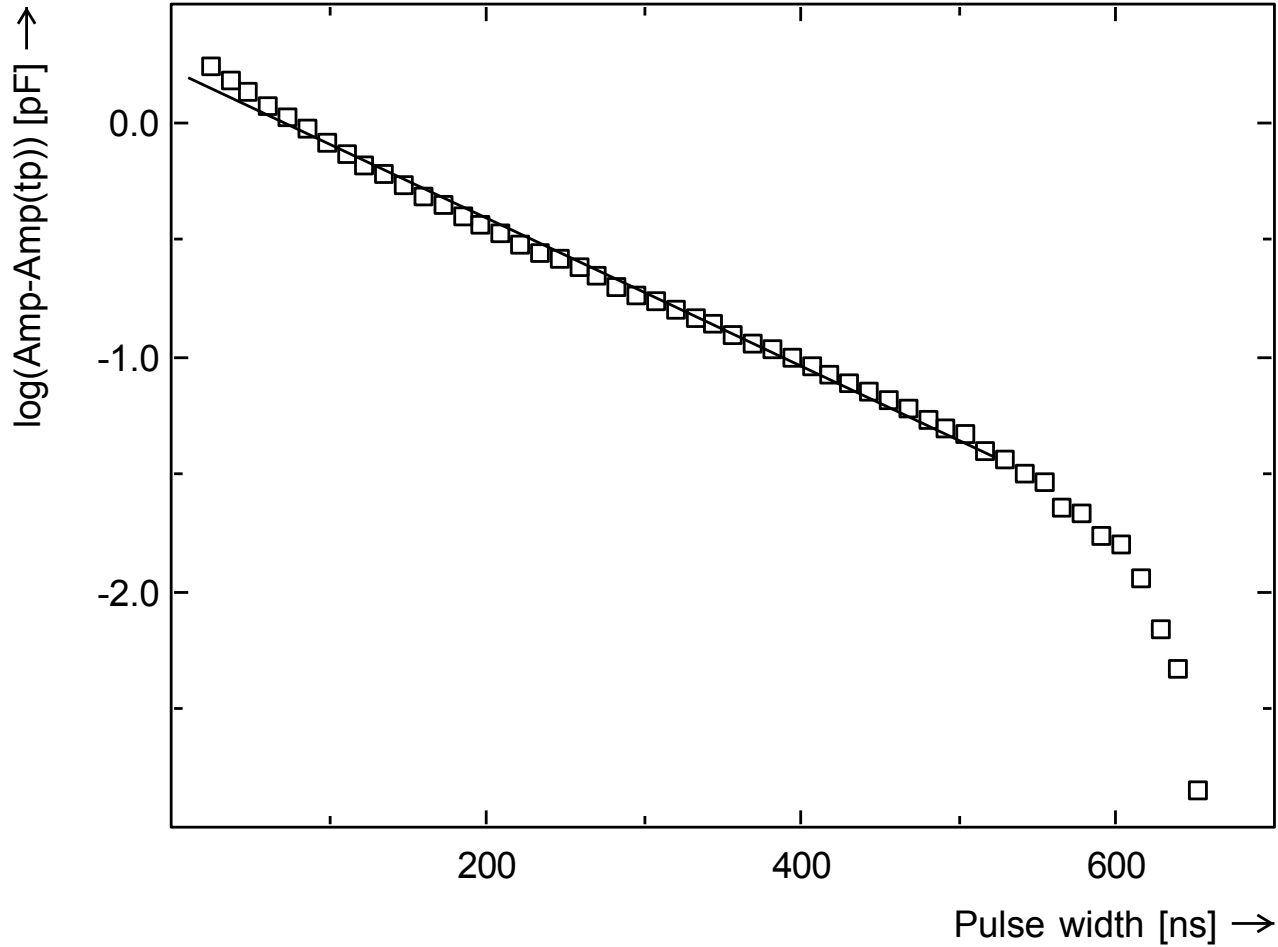




Name	= @A_004.PFA
ID	= PT_SiC_ref
rcID	= 1041*
Date	= 27.03.2015
Type	= n-4H-SiC
Area	= 8.00E-03 cm ²
N _S	= 1.31E+16 cm ⁻³
T _W	= 1.00 s
t _P	= 664.20 ns
U _R	= -5.00 V
U _P	= -0.20 V
C _R	= 96.75 pF
I _R	= -833.47 pA

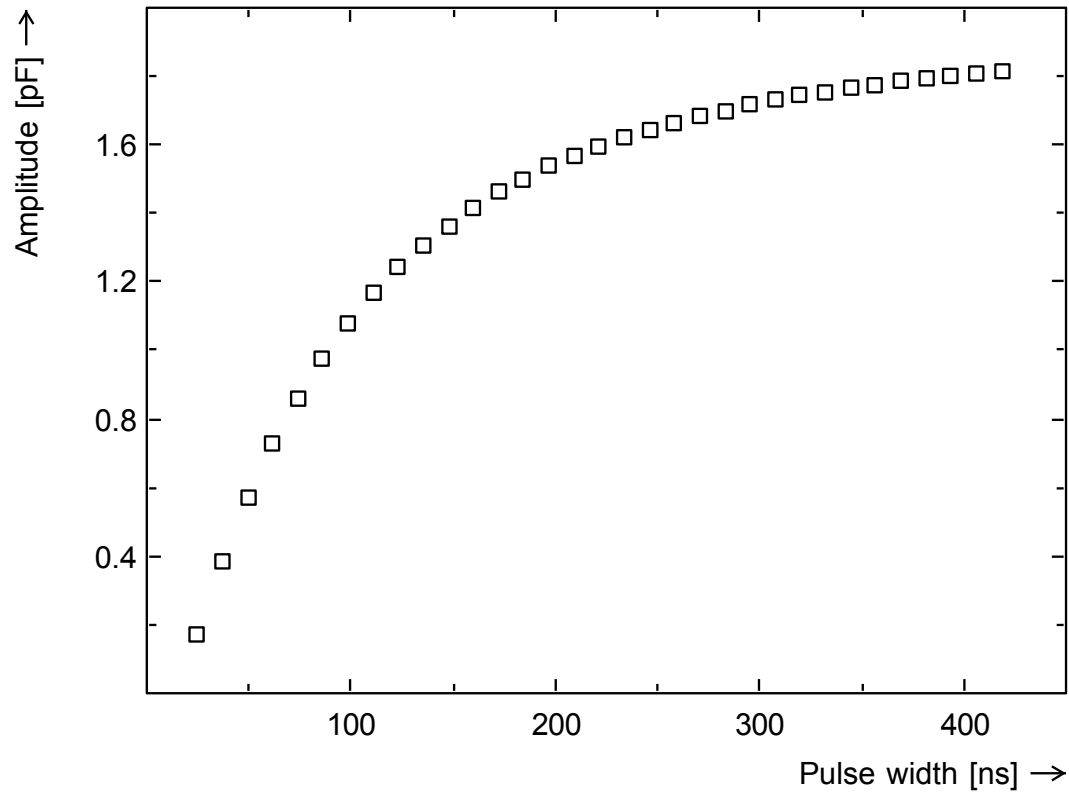


Name = @A_004.PFA
ID = PT_SiC_ref
rclD = 1041*
Date = 27.03.2015
Type = n-4H-SiC
Area = 8.00E-03 cm²
N_S = 1.31E+16 cm⁻³
Temp = 288.74 K
TempX = 0.01 K
T_W = 1.00 s
U_R = -5.00 V
U_P = -0.20 V
C_R = 96.75 pF
I_R = -833.47 pA

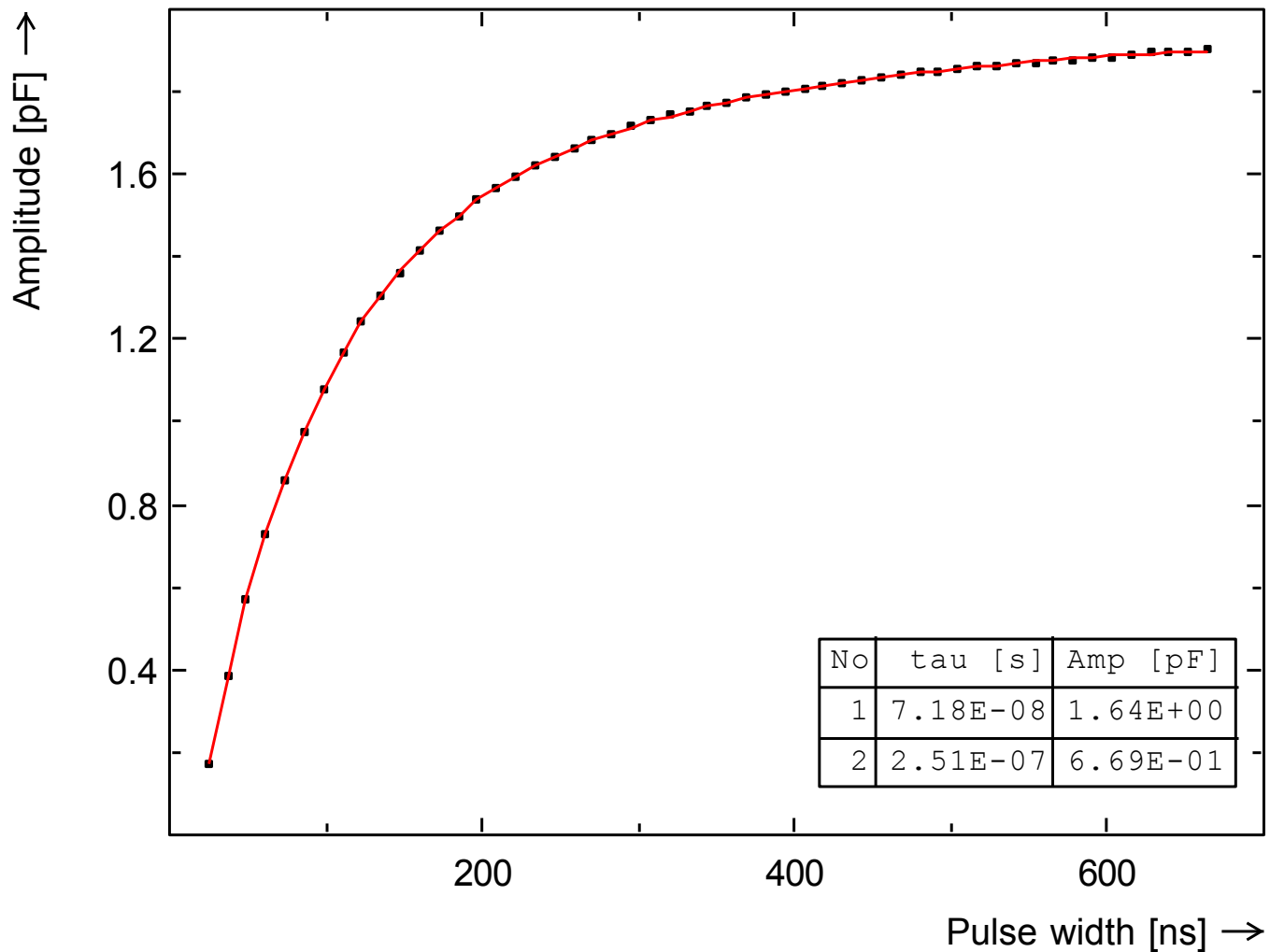


Name = @A_004.PFA
ID = PT_SiC_ref
rcID = 1041*
Date = 27.03.2015
Type = n-4H-SiC
Area = 8.00E-03 cm²
N_S = 1.31E+16 cm⁻³
Temp = 288.74 K
TempX = 0.01 K
U_R = -5.00 V
U_P = -0.20 V
I_R = -833.47 pA
tau_c = 138.21 ns
Amp = -1.66 pF
N_T = 4.51E+14 cm⁻³
sigma_c = 3.05E-17 cm²
Correl = 0.99744

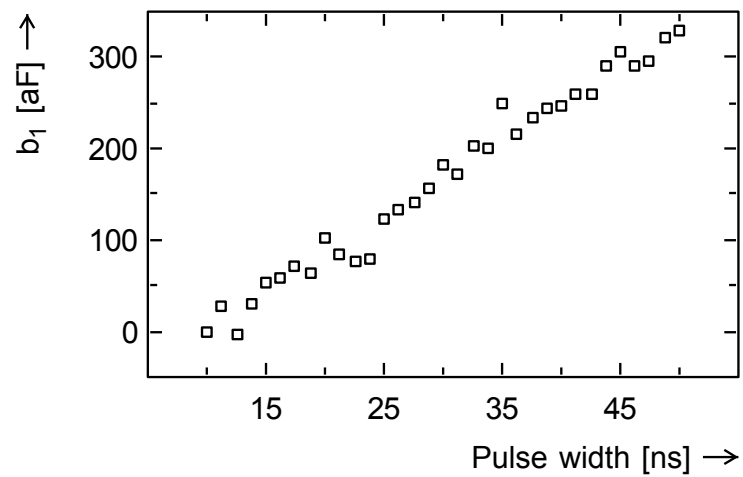
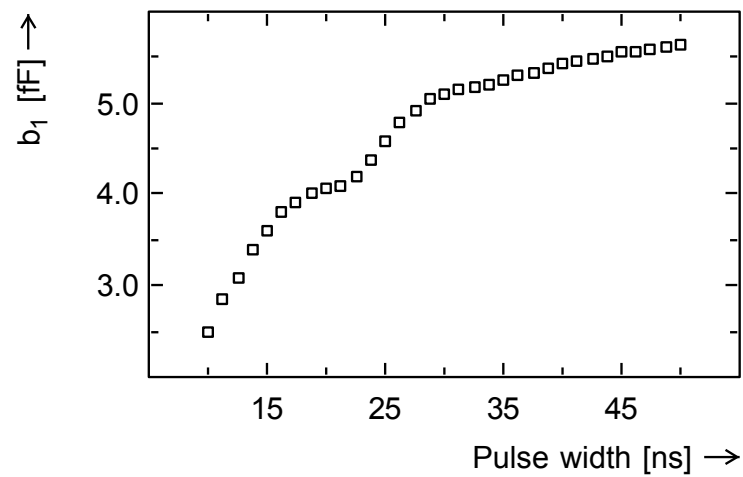
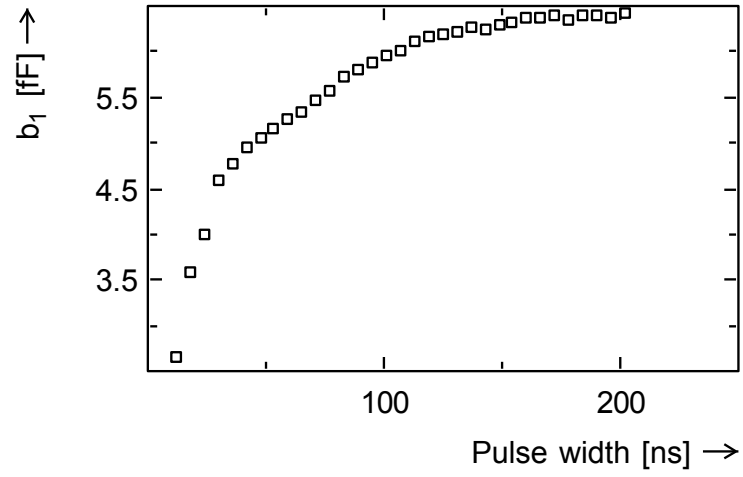
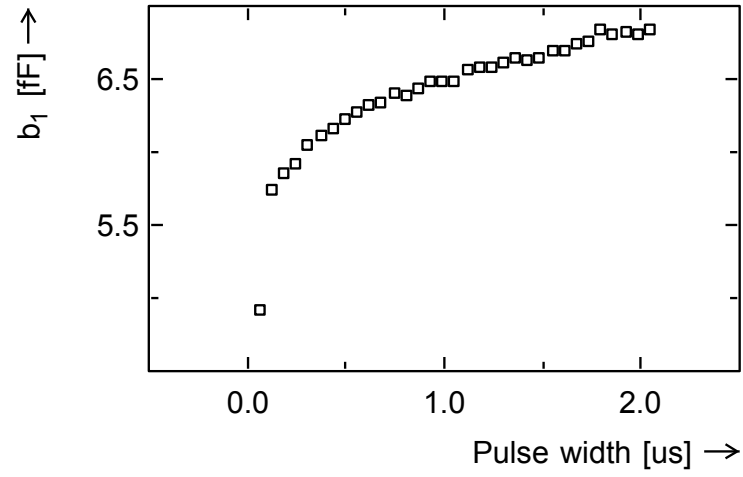
Name = PT_SiC_ref@A_004.PFA

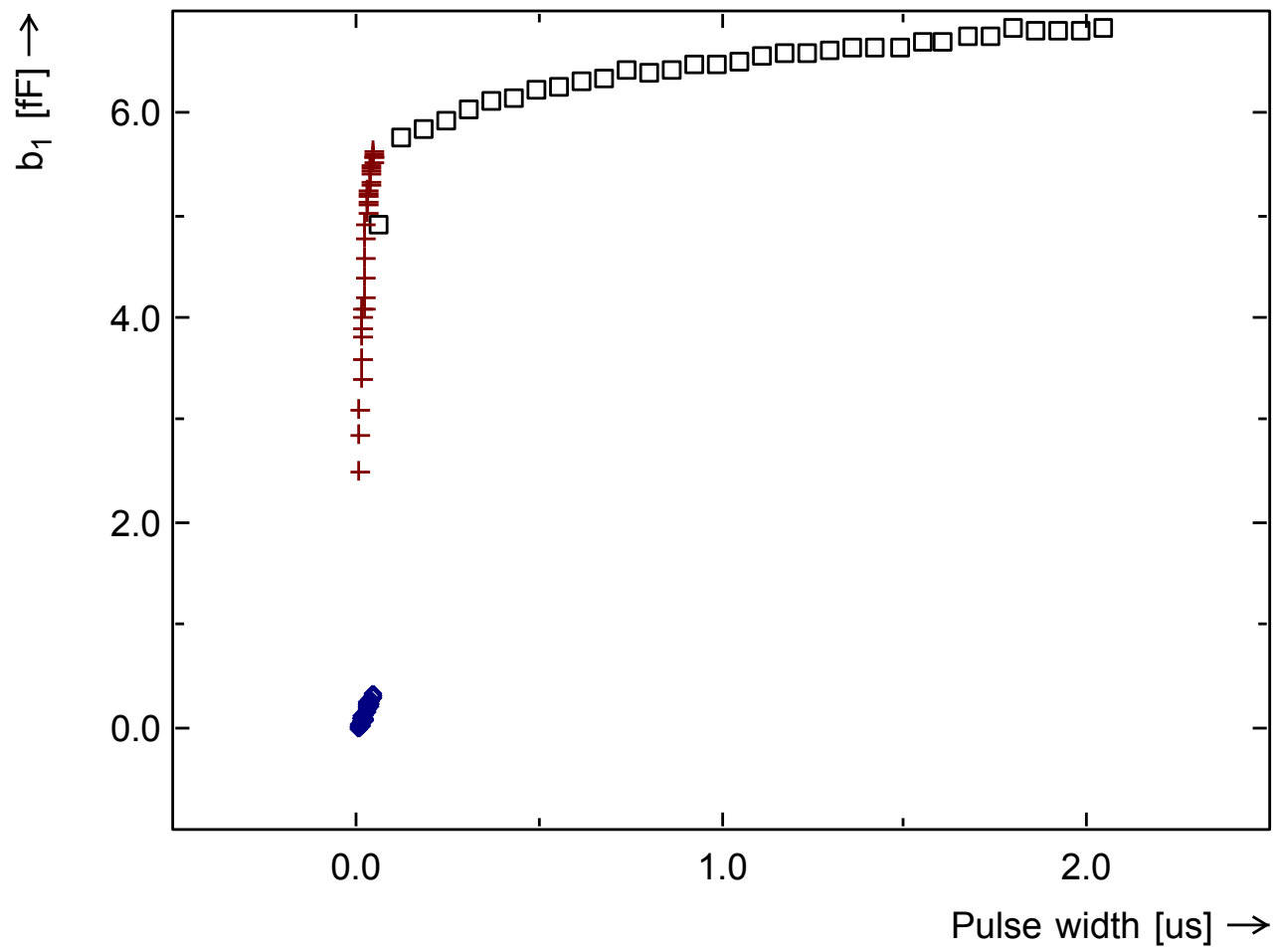


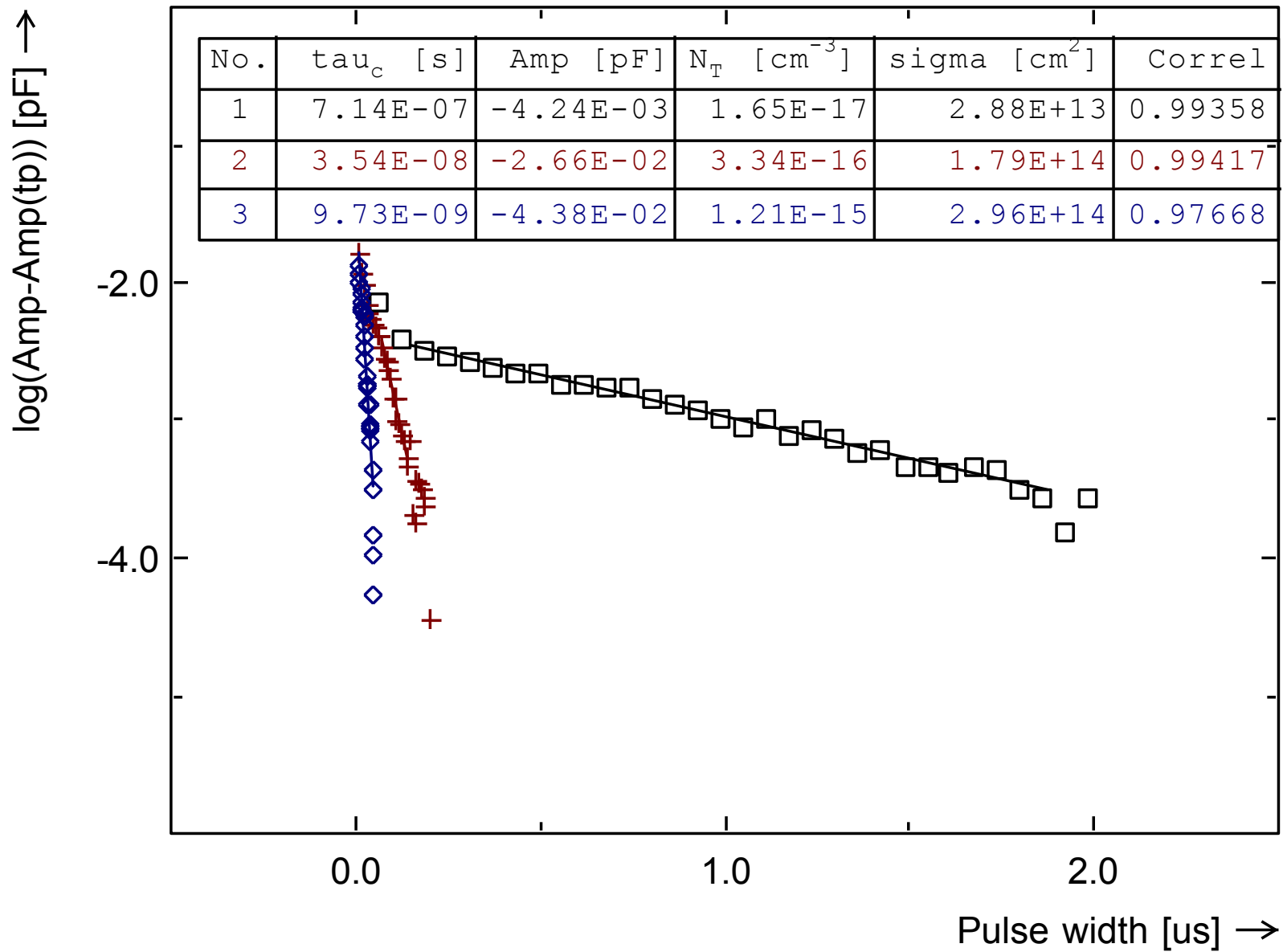
ID = PT_SiC_ref
rcID = 1041*
Date = 27.03.2015
Type = n-4H-SiC
Area = 8.00E-03 cm²
N_S = 1.31E+16 cm⁻³
Temp = 288.74 K
TempX = 0.01 K
U_R = -5.00 V
U_P = -0.20 V
I_R = -833.47 pA
tau_c = 100.38 ns
Amp = -2.01 pF
N_T = 5.44E+14 cm⁻³
sigma_c = 4.20E-17 cm²
Class = 55

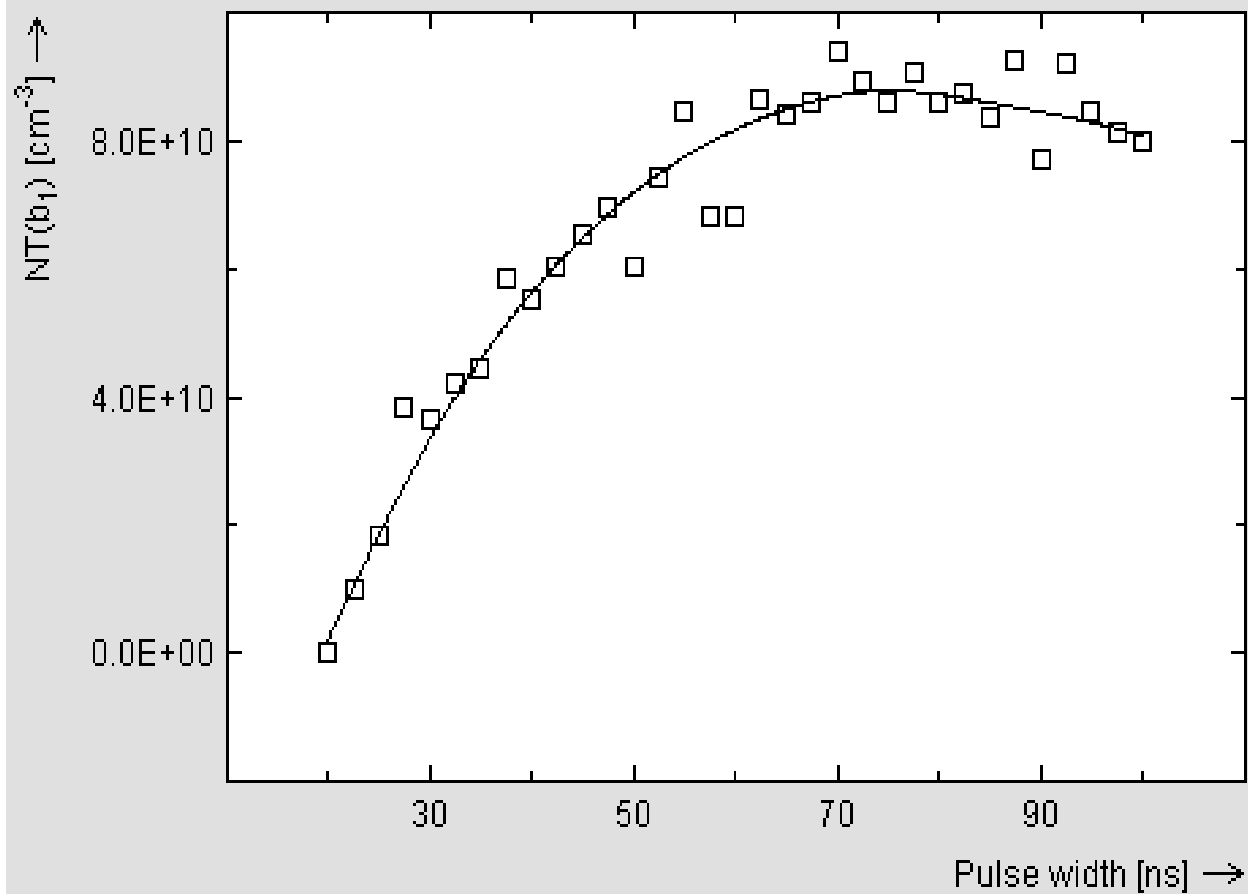


Name = @A_004.PFA
 ID = PT_SiC_ref
 rcID = 1041*
 Date = 27.03.2015
 Type = n-4H-SiC
 Area = 8.00E-03 cm²
 N_S = 1.31E+16 cm⁻³
 Temp = 288.74 K
 TempX = 0.01 K
 T_W = 1.00 s
 U_R = -5.00 V
 U_P = -0.20 V
 C_R = 96.75 pF
 I_R = -833.47 pA

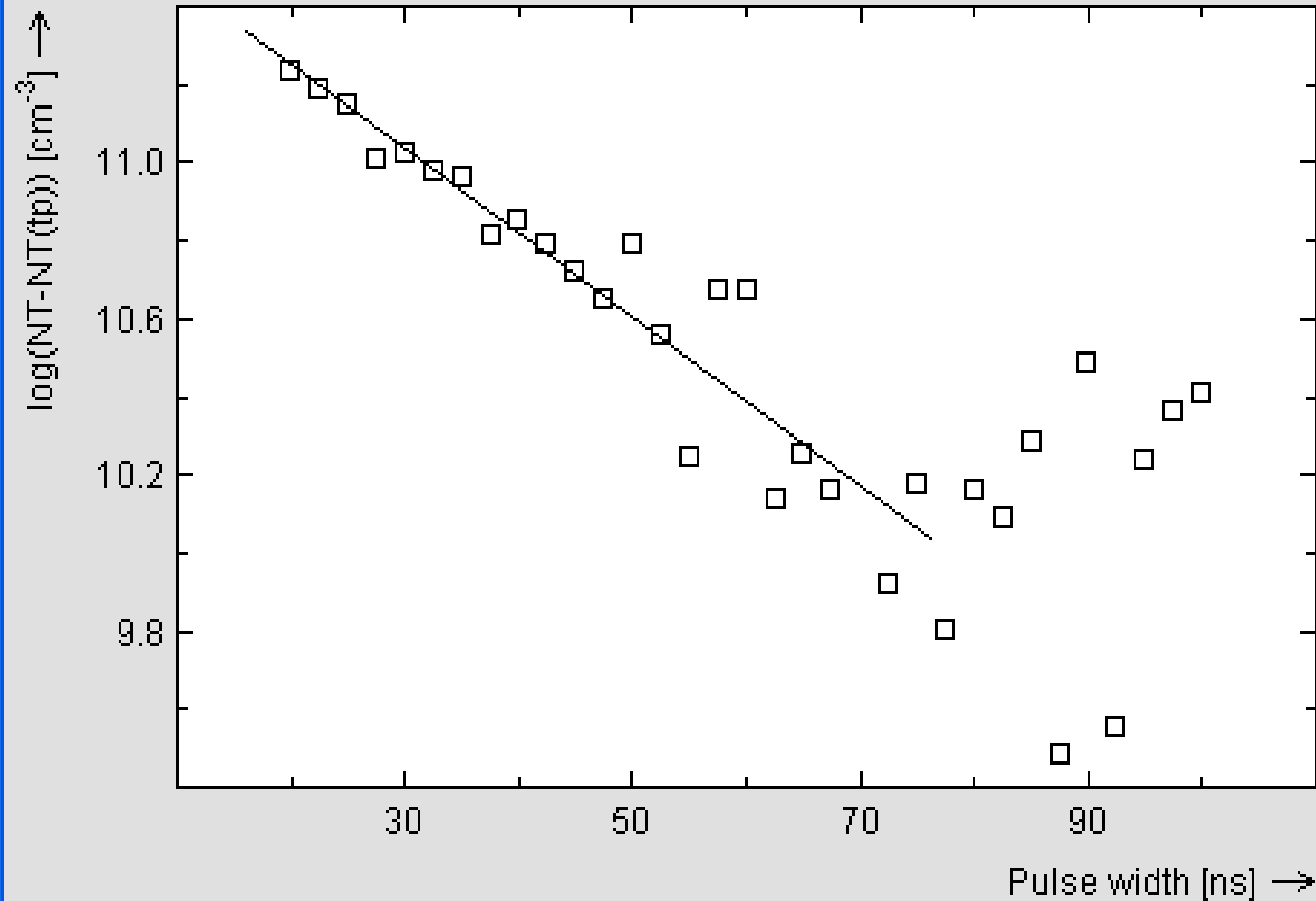








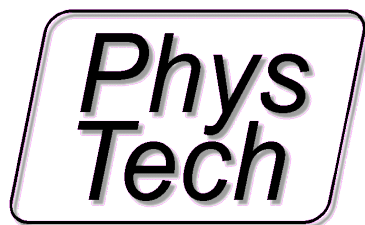
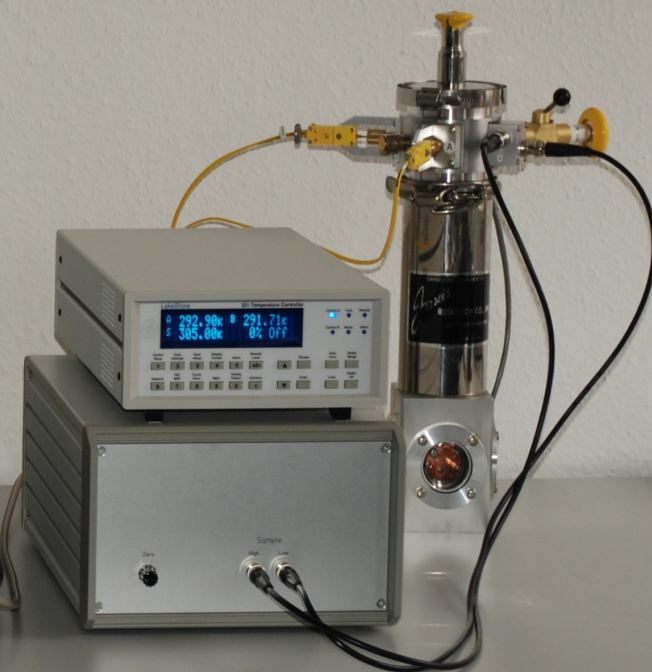
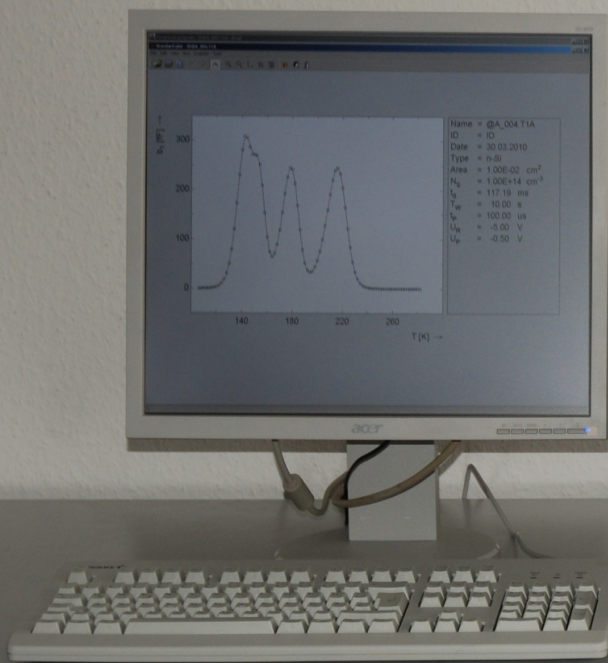
Name = @C_002.PFA
 ID = 0918-1
 rcID = 1014*
 Date = 18.09.2014
 Type = p-Si
 Area = 7.85E-03 cm²
 N_S = 2.28E+15 cm⁻³
 Temp = 52.90 K
 TempX = 0.02 K
 T_{iw} = 20.48 ms
 U_R = 5.00 V
 U_P = 1.00 V
 C_R = 44.92 pF
 I_R = 540.14 pA



Name = @C_002.PFA
 ID = 0918-1
 rclD = 1014*
 Date = 18.09.2014
 Type = p-Si
 Area = 7.85E-03 cm²
 N_s = 2.28E+15 cm⁻³
 Temp = 52.90 K
 TempX = 0.02 K
 U_R = 5.00 V
 U_P = 1.00 V
 I_R = 540.14 pA
 tau_c = 20.15 ns
 N_T = 4.81E+11 cm⁻³
 sigma_c = 3.31E-15 cm²
 Correl = 0.94163

HERA FT1230 DLTS specifications





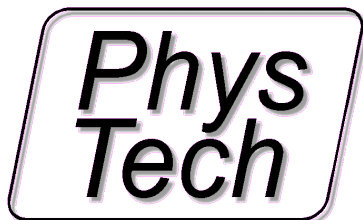
Dr. Ludwig Cohausz
Phystech GmbH
Moosburg
Germany

Specifications:

Bias-/Pulsvoltagesource

voltage range ((due to be changed)	: -/+ 20V (optional +/- 100V)
voltage setting resolution option)	: 0.3 mV (1.5mV with 100V option)
internal shortest Pulswidth s)	: 10 micro second (1V/micro s)
external fast pulse generator	: 20 ns (+/- 10V)
longest Pulswidth	: > 100h

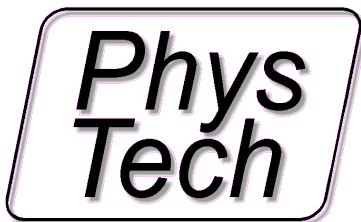
optical pulse trigger available at the option port for TTL modulation inputs of Laser power supplies



Specifications:

Digital transient recorder **with variable oversampling technic**

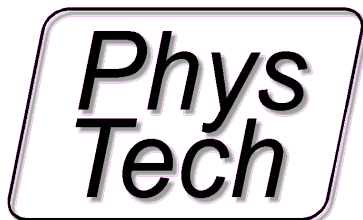
max. samplings per transient : **2E6 (buffered), 2E9 (streaming)**



Specifications:

Digital transient recorder **with variable oversampling technic**

max. samplings per transient : **2E6 (buffered), 2E9 (streaming)**
fastest sampling intervall : **850 nano seconds**
shortest period width : **27 micro seconds**
longest periodwidth : **110 h**



Specifications:

Phystech Capacitancemeter

with automatic reverse bias capacitance compensation and automatic range setting

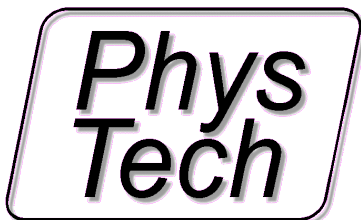
Compensation range : **1 pF - 3300 pF**
HF - frequency : 1 MHz
HF signal : **15mV, 100mV**
ranges : **5 pF - 5000 pF (4) (100mV)**

Current measurement amplifier with automatic range setting

max. measurement current : 15 mA

current resolution : **<1 pA**

This amplifier can be used for I/V measurements as well



FT 1230 HERA DLTS features

- C/V , I/V
- C-DLTS / Capacitance - DLTS
- I-DLTS / Current - DLTS
- CC-DLTS / Constant Cap. DLTS
- Laplace DLTS
- ITS (ICTS)
- MIS Analysis / Zerbst DLTS

